



SMR.998d - 31

Research Workshop on Condensed Matter Physics
30 June - 22 August 1997
**MINIWORKSHOP ON
QUANTUM WELLS, DOTS, WIRES
AND SELF-ORGANIZING NANOSTRUCTURES
11 - 22 AUGUST 1997**

**"Self-ordering of quantum wells, wires and dots
by growth on a nonplanar substrate"
PART I**

and

**"Electronic properties of low dimensional nanostructures
grown on nonplanar substrates"
PART II**

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These are preliminary lecture notes, intended only for distribution to participants.



part I:

Self Ordering of Quantum Wells, Wires and Dots by Growth on a Nonplanar Substrate

part II:

Electronic Properties of Low Dimensional Nanostructures Grown on Nonplanar Substrates

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*Mini workshop on Quantum Wells, Dots, Wires and Self-Organizing Nanostructures
International Center for Theoretical Physics, Trieste, Italy
August 11-22, 1997*

Self Ordering of Quantum Wells, Wires and Dots by Growth on a Nonplanar Substrate

outline:

- **Modified step flow growth on nonplanar substrates**
- **Nanofacet self ordering**
- **“Vertical” quantum wells**
- **V-groove quantum wires**
- **Dot-like potential landscape in V-groove wires**
- **Inverted-pyramidal quantum dots**

**Self Ordering of Quantum Wells, Wires and Dots
by Growth on a Nonplanar Substrate**

Collaborators:

F. Reinhardt, G. Binasch, A. Rudra

B. Dwir, A. Hartmann, L. Loubies, Y. Dumeau

A. Gustafsson, K. Leifer

Morphology

GaAs(100) nominally $\pm 0.037^\circ$ off

T = 680 °C



step height: 0.285 ± 0.005 nm
average terrace size: 280 nm
-> miscut 0.058° off



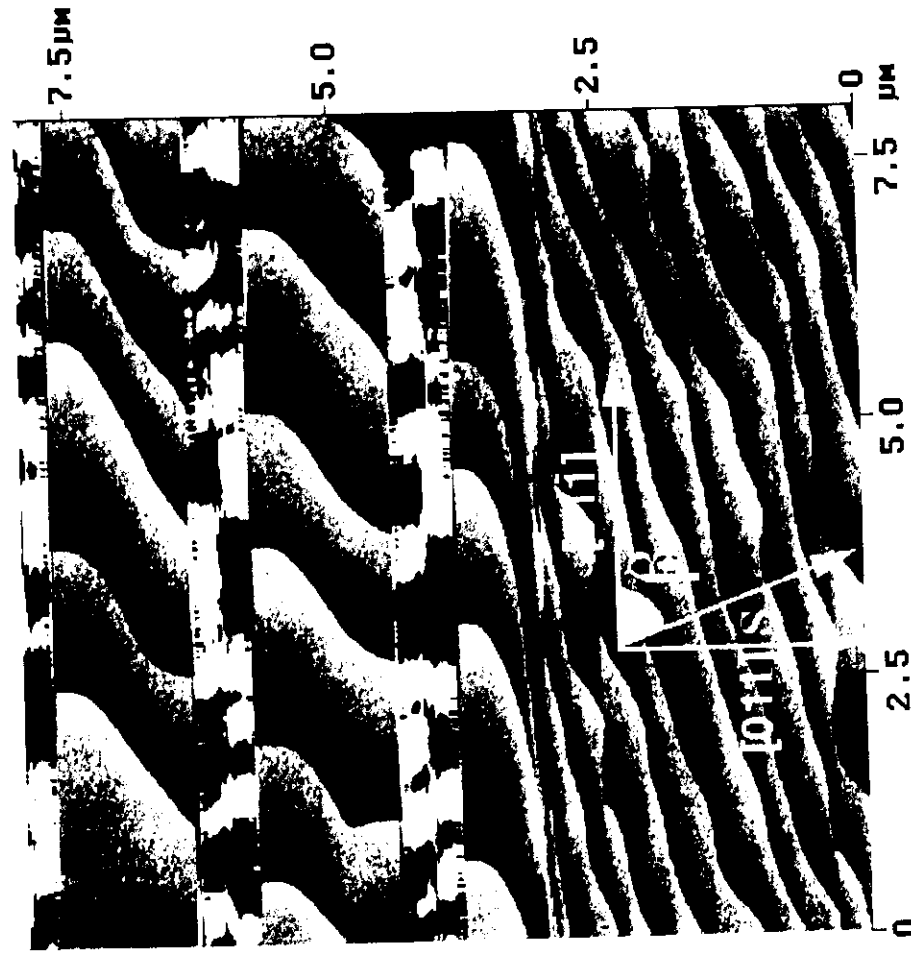
step height: 0.295 ± 0.005 nm
average terrace size: 430 nm
-> miscut 0.037° off

Step ordering on the (100) surface between V-grooves

EPFL

ÉCOLE POLYTECHNIQUE
FÉDÉRALE DE LAUSANNE

1.5 nm
0.75 nm
0.0 nm



175 nm GaAs
175 nm Al_{0.2}Ga_{0.8}As

300 nm deep V-grooves
in GaAs(100), spaced by
different pitch p

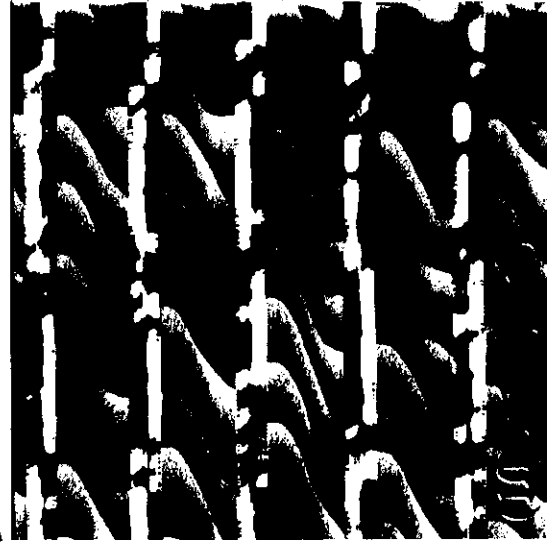


Step ordering on the (100) face

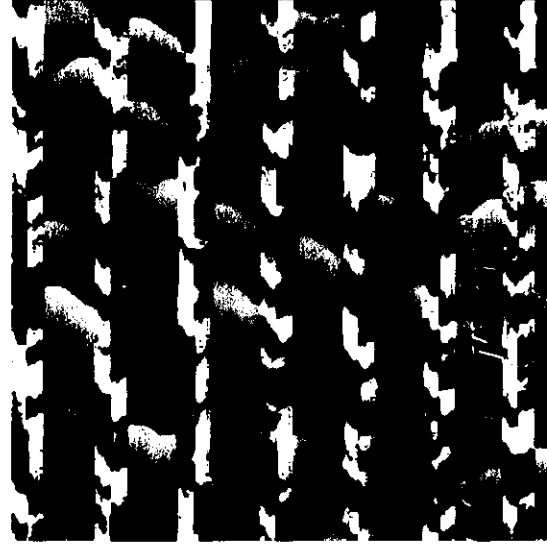


ÉCOLE POLYTECHNIQUE
FÉDÉRALE DE LAUSANNE

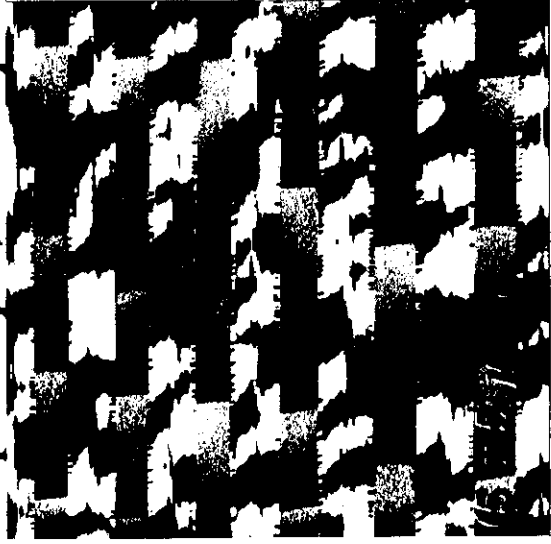
$p = 2.0 \mu\text{m}$, $w \approx 1.4 \mu\text{m}$



$p = 1.5 \mu\text{m}$, $w \approx 0.9 \mu\text{m}$



$p = 1.0 \mu\text{m}$, $w \approx 0.3 \mu\text{m}$

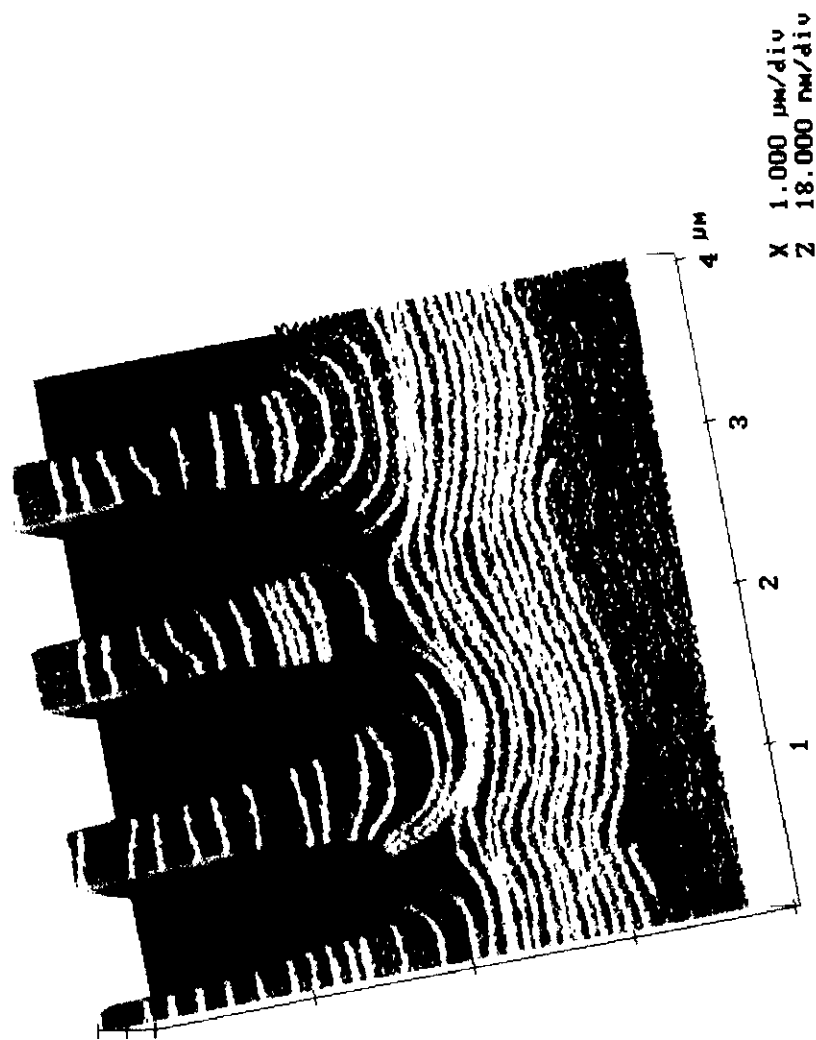
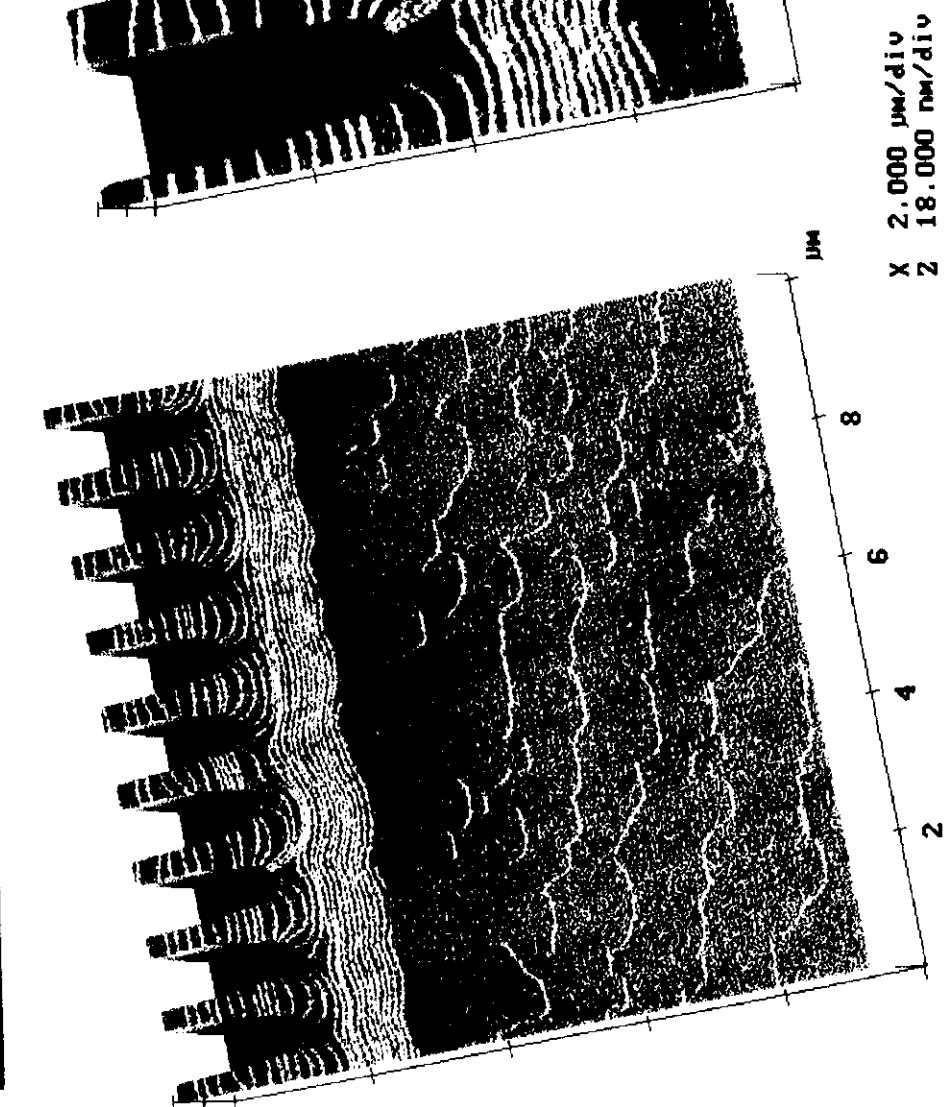


$p = 0.5 \mu\text{m}$, $w \approx 0.1 \mu\text{m}$

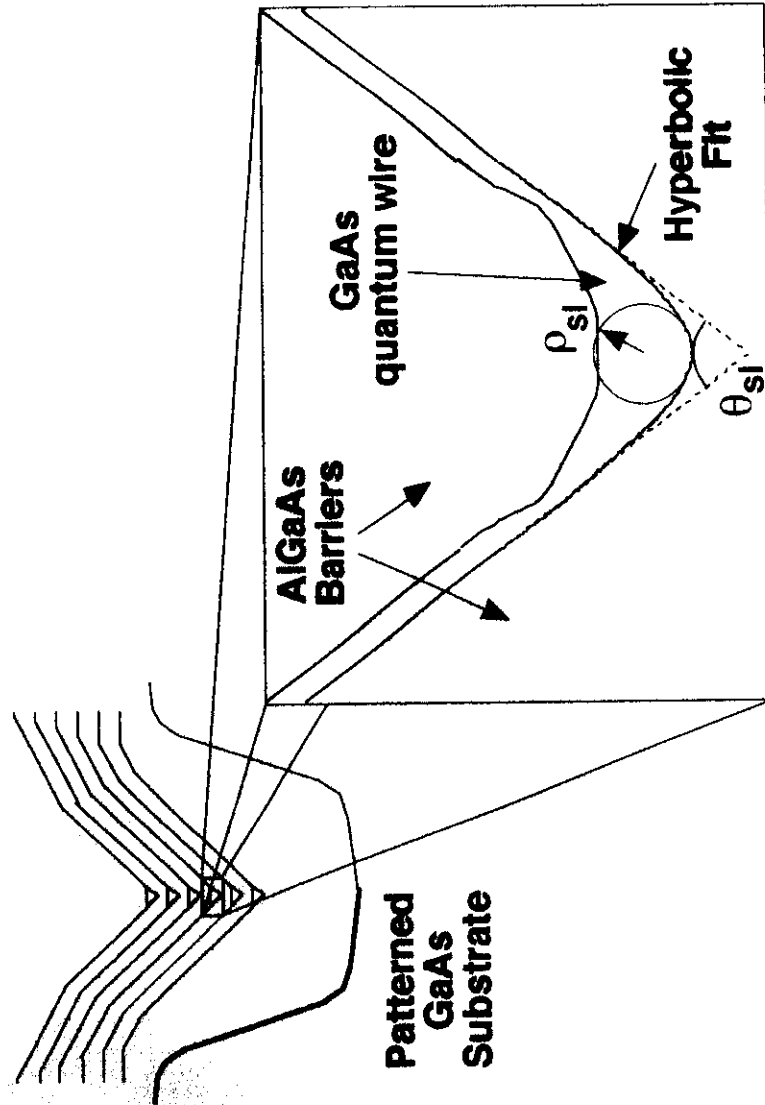
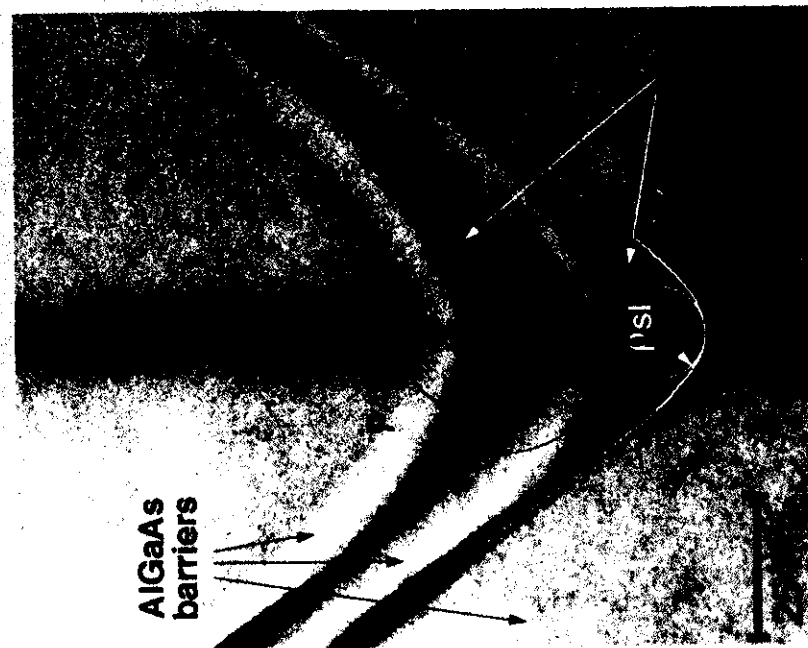


Step ordering on the (100) face
in GaAs(100), spaced by
different pitch p

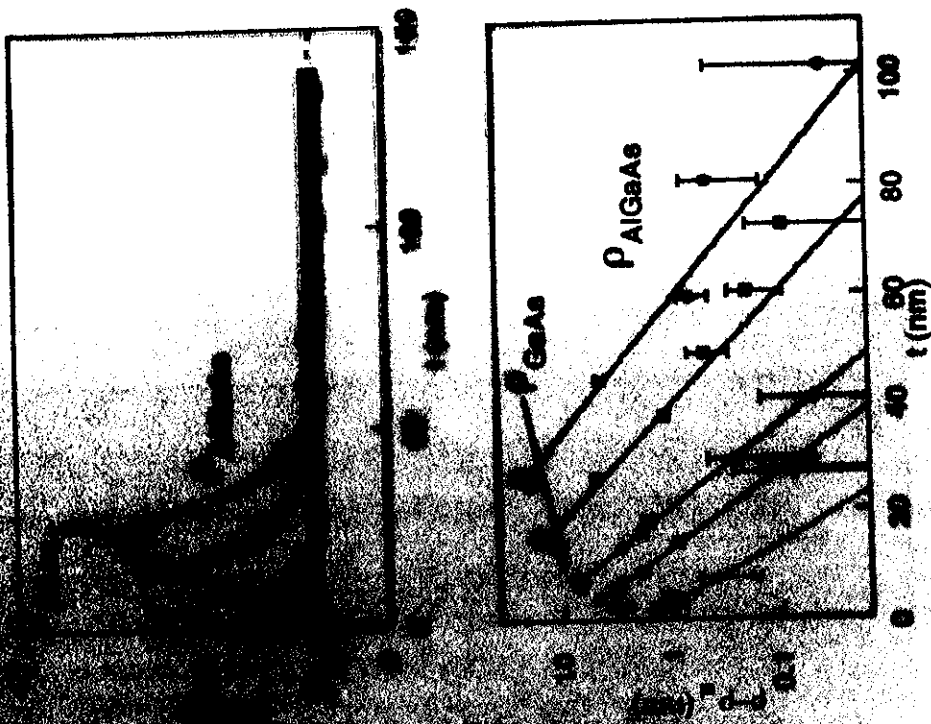
Monolayer Step Alignment on a Nonplanar Substrate



Formation of QWRs in a Self-Ordered V-Groove

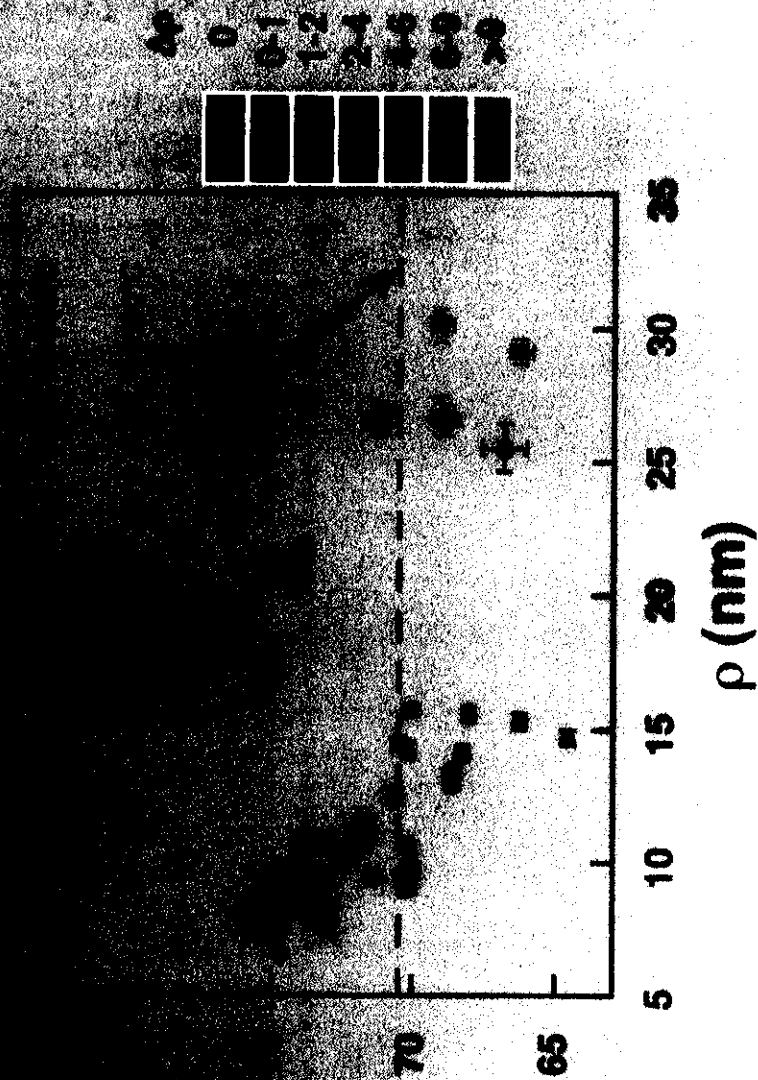


Low Temperature QWRS



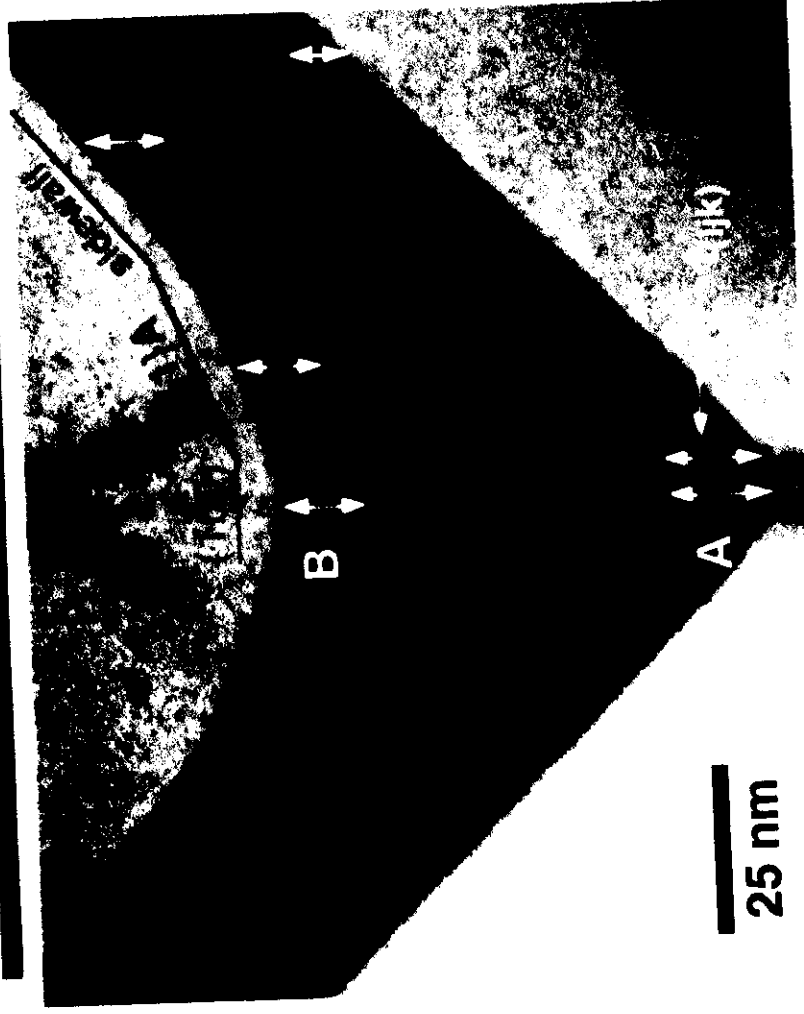
$$\rho(t_{GaAs}) = \rho_{SI} + \alpha \cdot t_{GaAs}$$

$$\rho(t_{GaAs}) = \rho_{SI} + (\rho_{GaAs} - \rho_{SI}) \exp(-t/t_0)$$



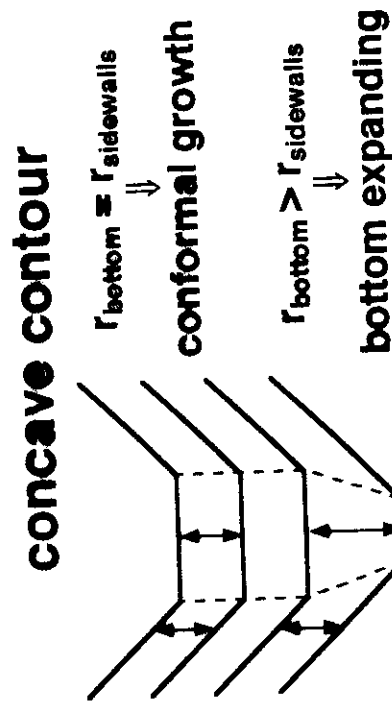
$$\rho(t) = \rho_{sl} + \Delta\rho; \quad \Delta\rho = \alpha t_{GaAs} \cdot e^{(-t_{AlGaAs} / \tau)}$$

Evolution to a Self-Limiting GaAs Groove Profile



$T = 650^{\circ}\text{C}$

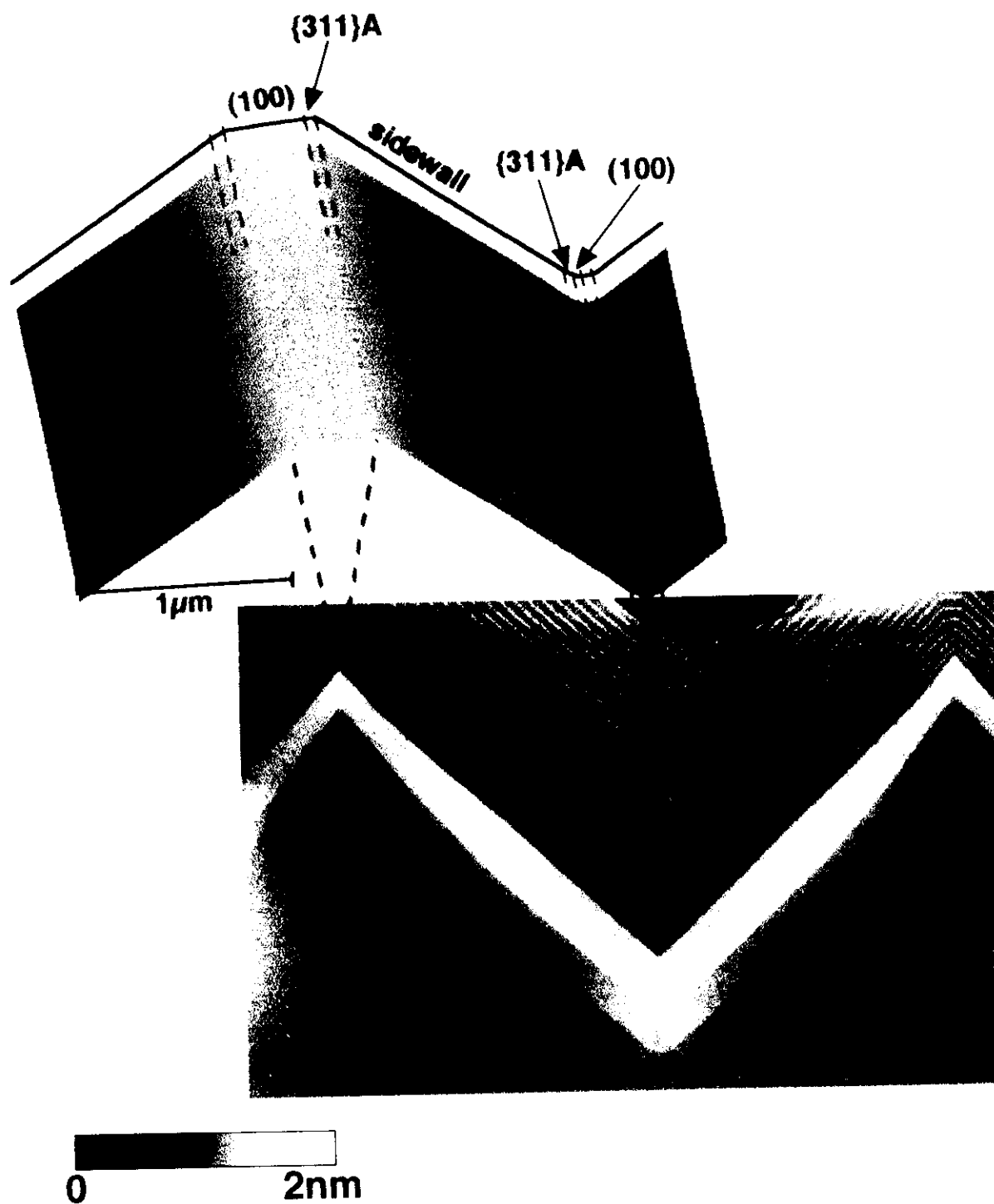
$X_{\text{barrier}} = 0.45$



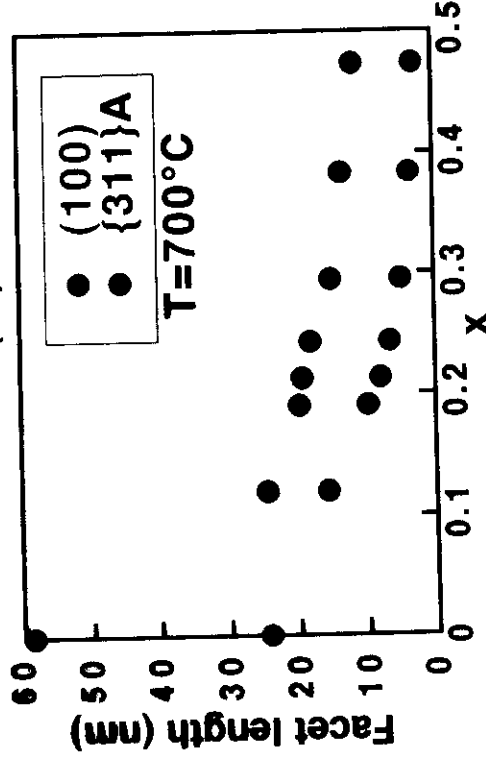
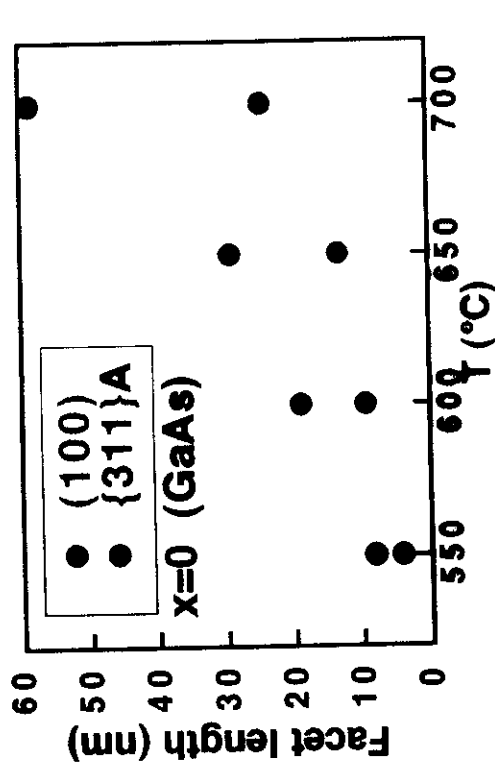
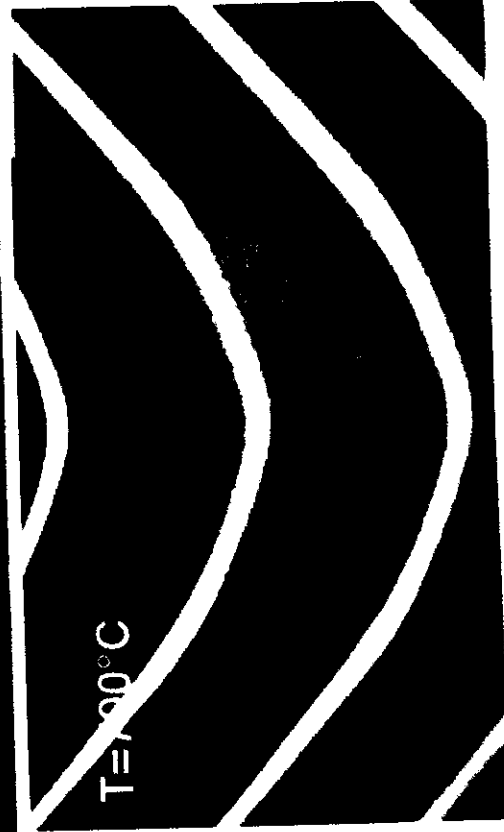
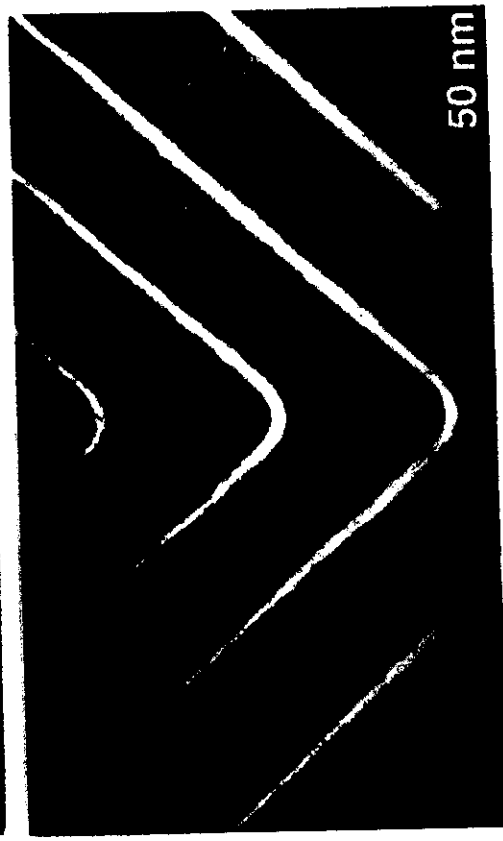
layer A: $t_{(100)} > t_{\{311\}A} > t_{\text{sidewall}} \Rightarrow$ expansion of (100) and $\{311\}A$ facets

layer B: $t_{(100)} = t_{\{311\}A} = t_{\text{sidewall}} \Rightarrow$ stable facets, self-limiting growth

Surface of a Self-Limiting GaAs V-Groove



Self-Limiting Growth of GaAs on V-Grooves



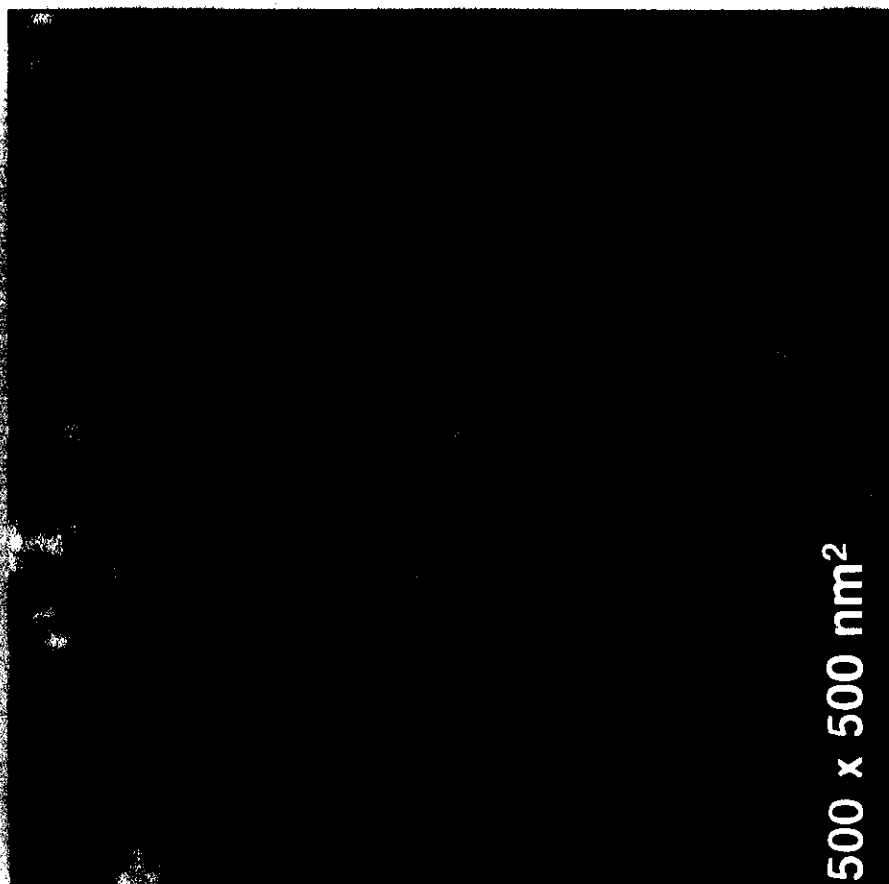
Self-limiting GaAs + AlGaAs markers

Comparison of the Initial shape of the groove

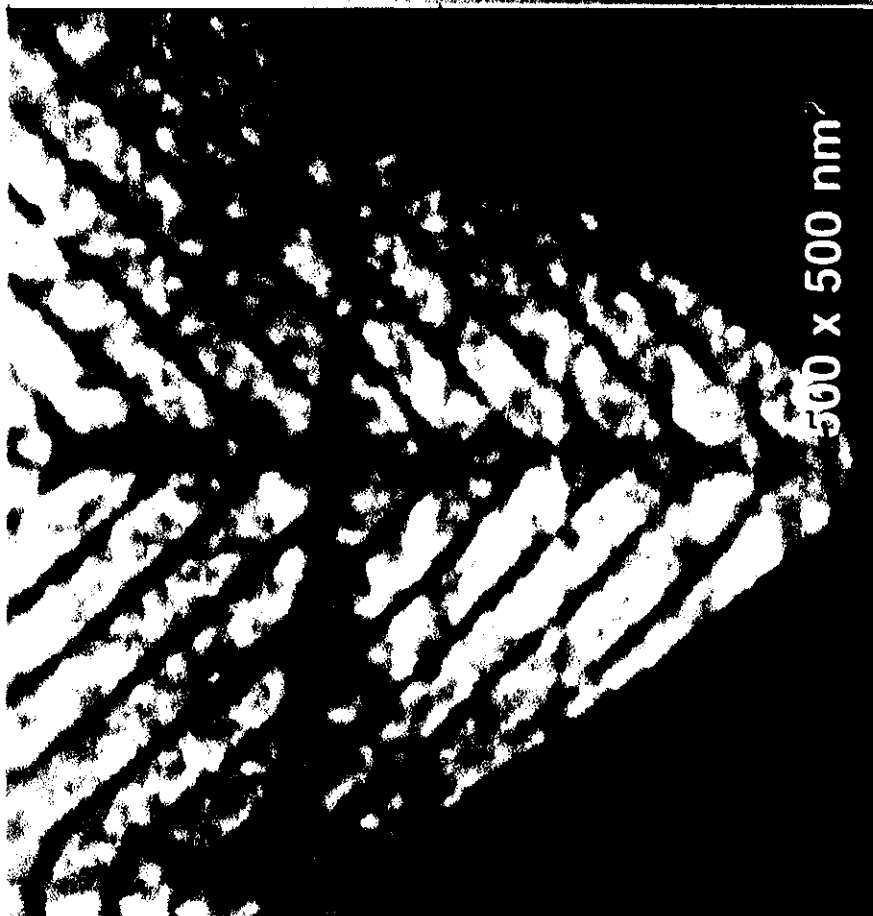


square-shaped groove

V-groove



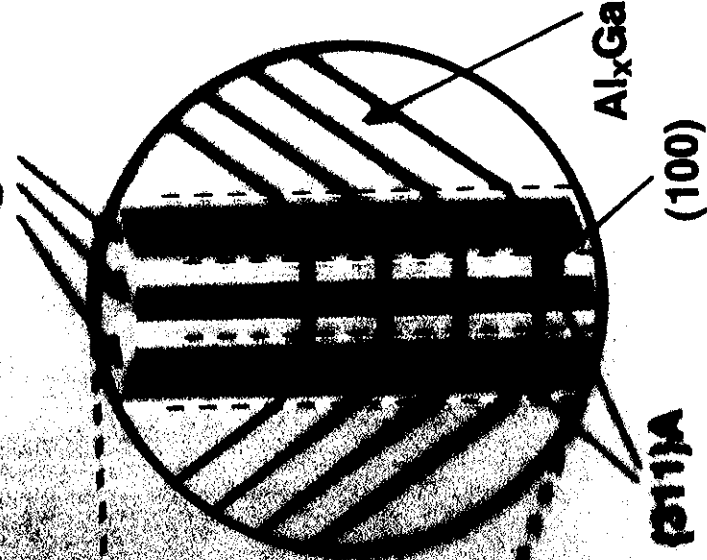
500 x 500 nm²



500 x 500 nm²

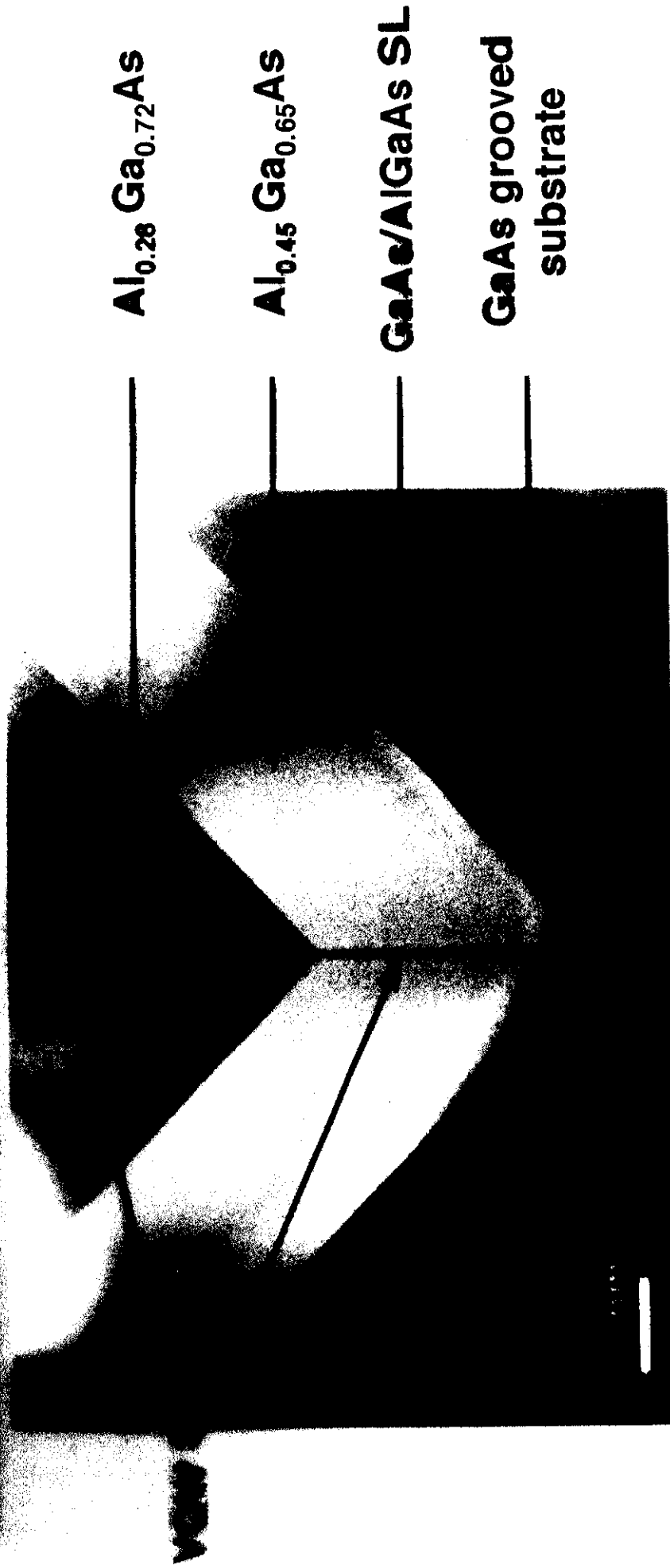
Aluminum-Gallium Arsenide Heterostructure

Aluminum-Gallium Arsenide
($y < x$)



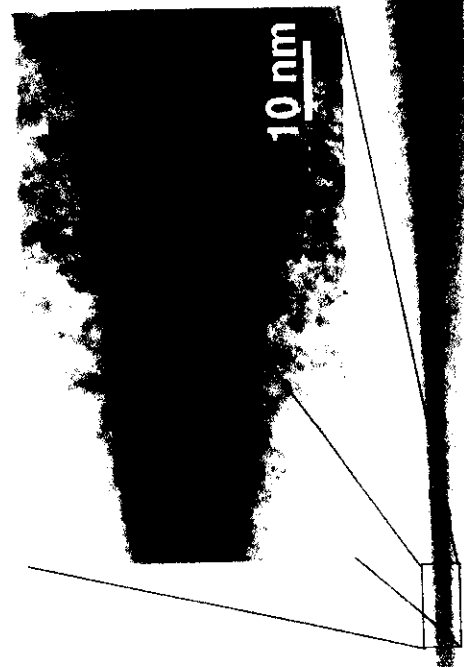
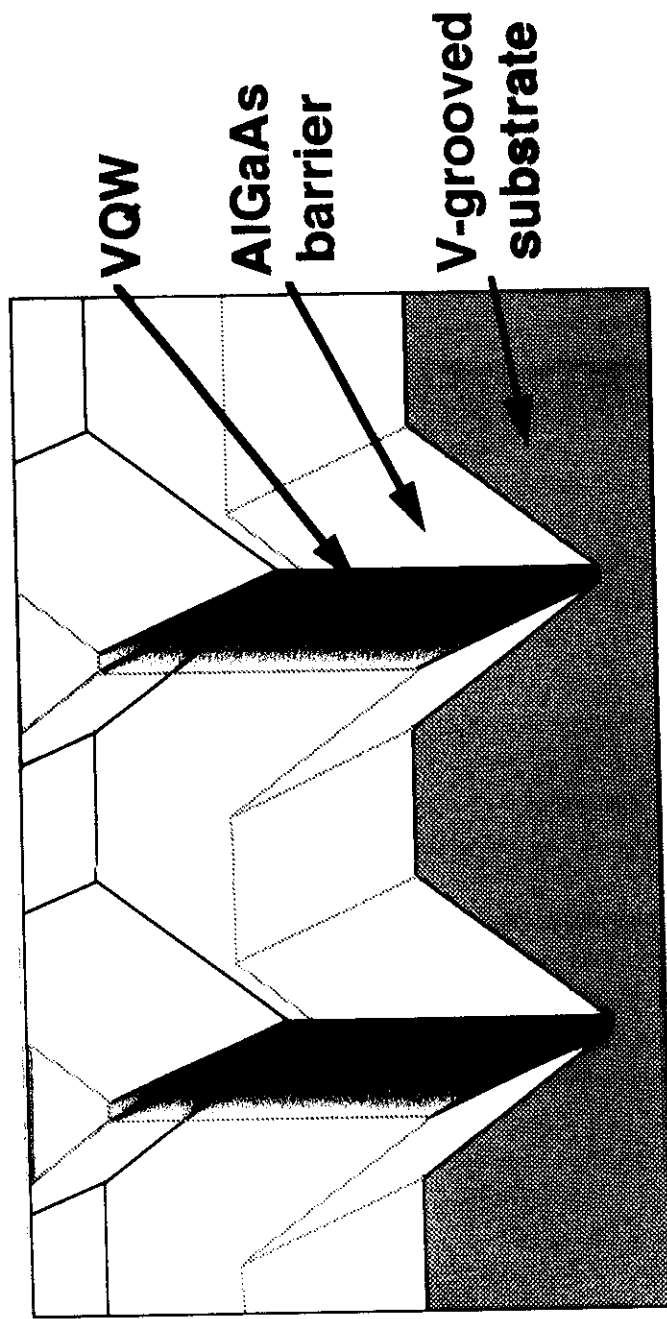
Initial
groove

LP OMVCD growth of VQWS



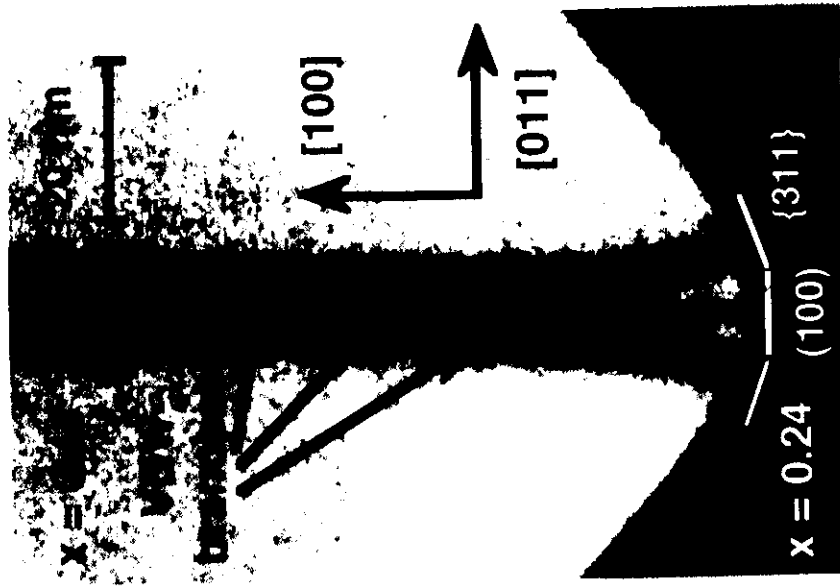
- V-groove pitch $\Lambda = 3 \mu\text{m}$ (by optical photolithography and wet chemical etching)
- Horizontal reactor; pressure = 20 mbar
- Growth temperature = 600 - 765 °C
- Al mole fraction = 0.13-0.75
- Growth rates = 0.28 - 0.45 nm/sec
- V/III ratios @ 160-200

Self-Ordered AlGaAs VQW Heterostructure



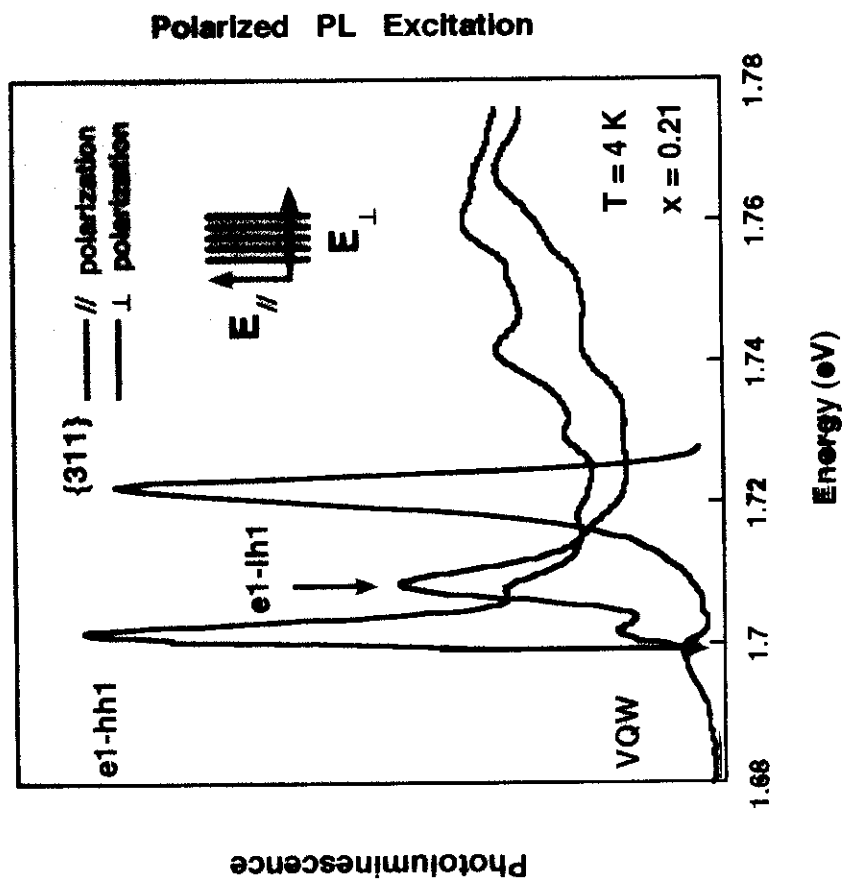
top view

cross section

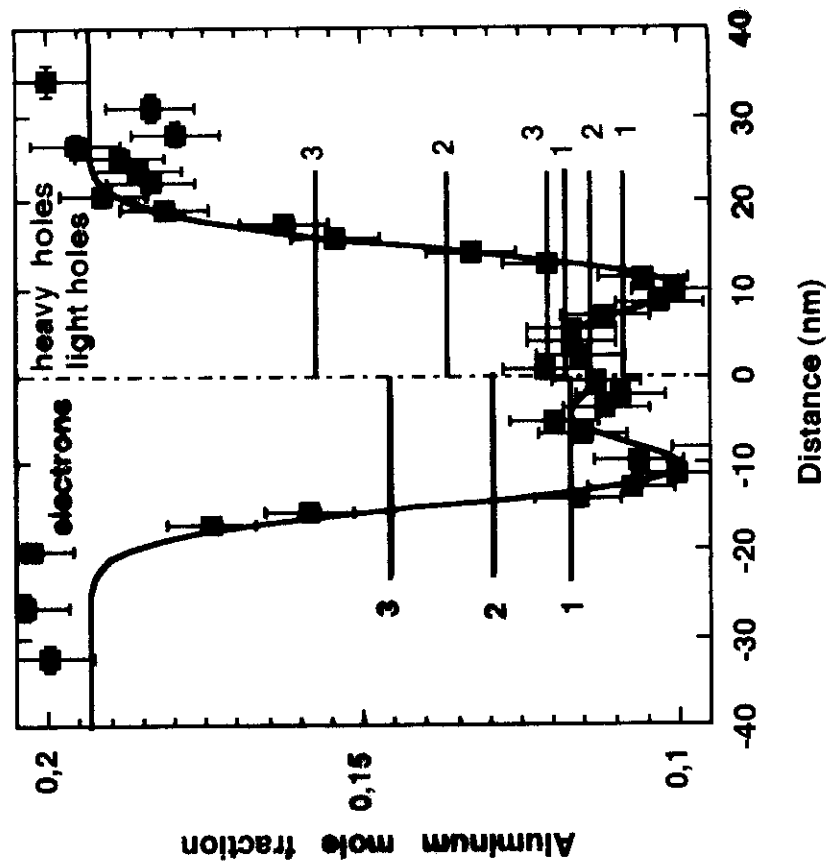


Quantum Confinement in V-Groove QWs

PL/PLE spectra

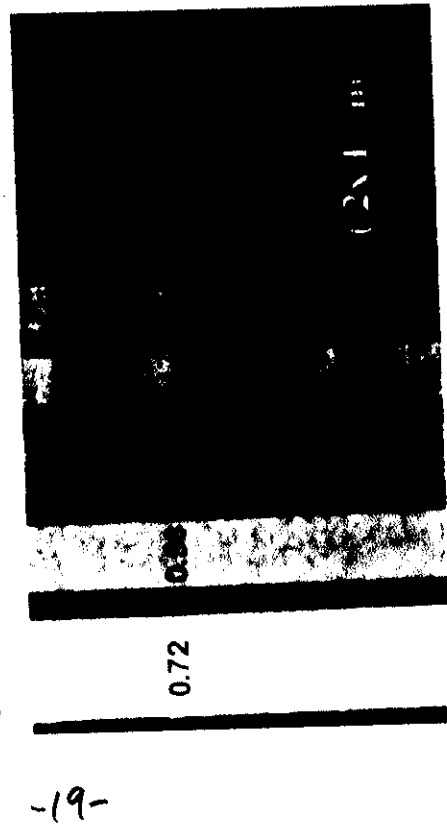
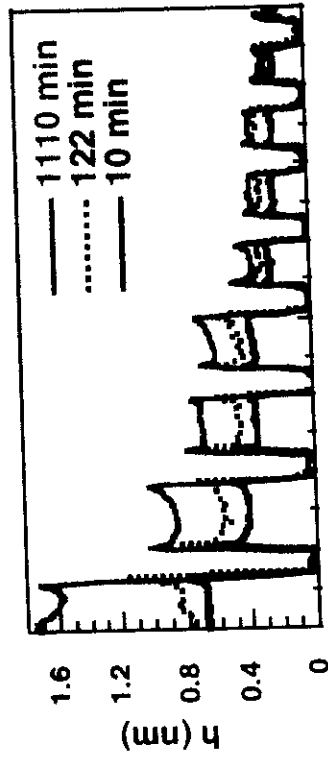


potential profile

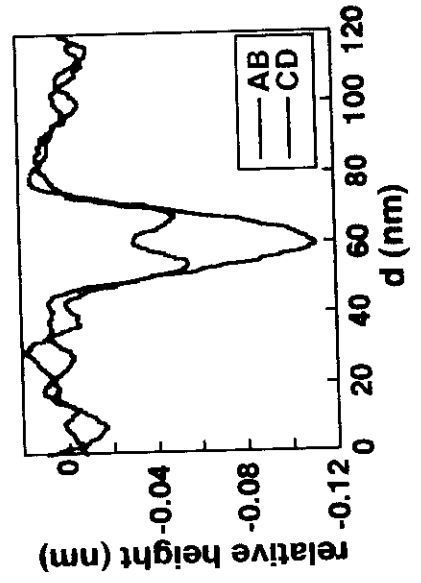
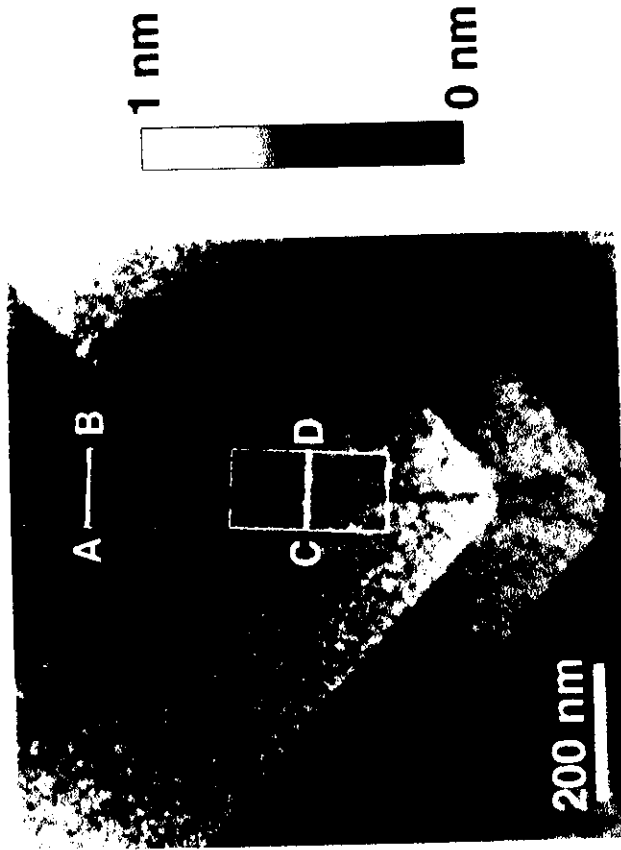


Cross-Sectional AFM Imaging of VQWs

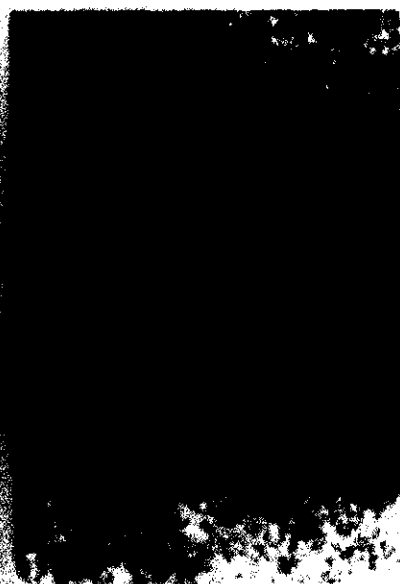
Method



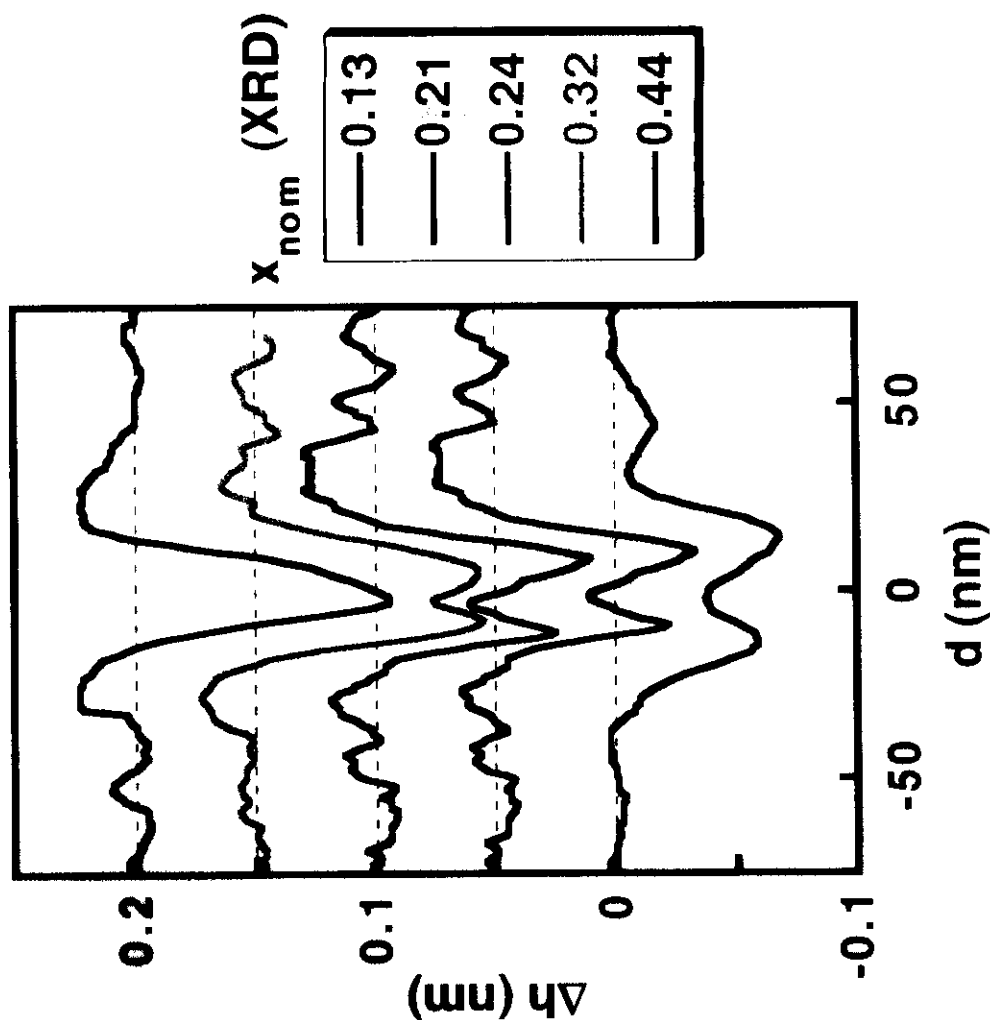
Application



VQW profile in $\text{Al}_x\text{Ga}_{1-x}\text{As}$ layers

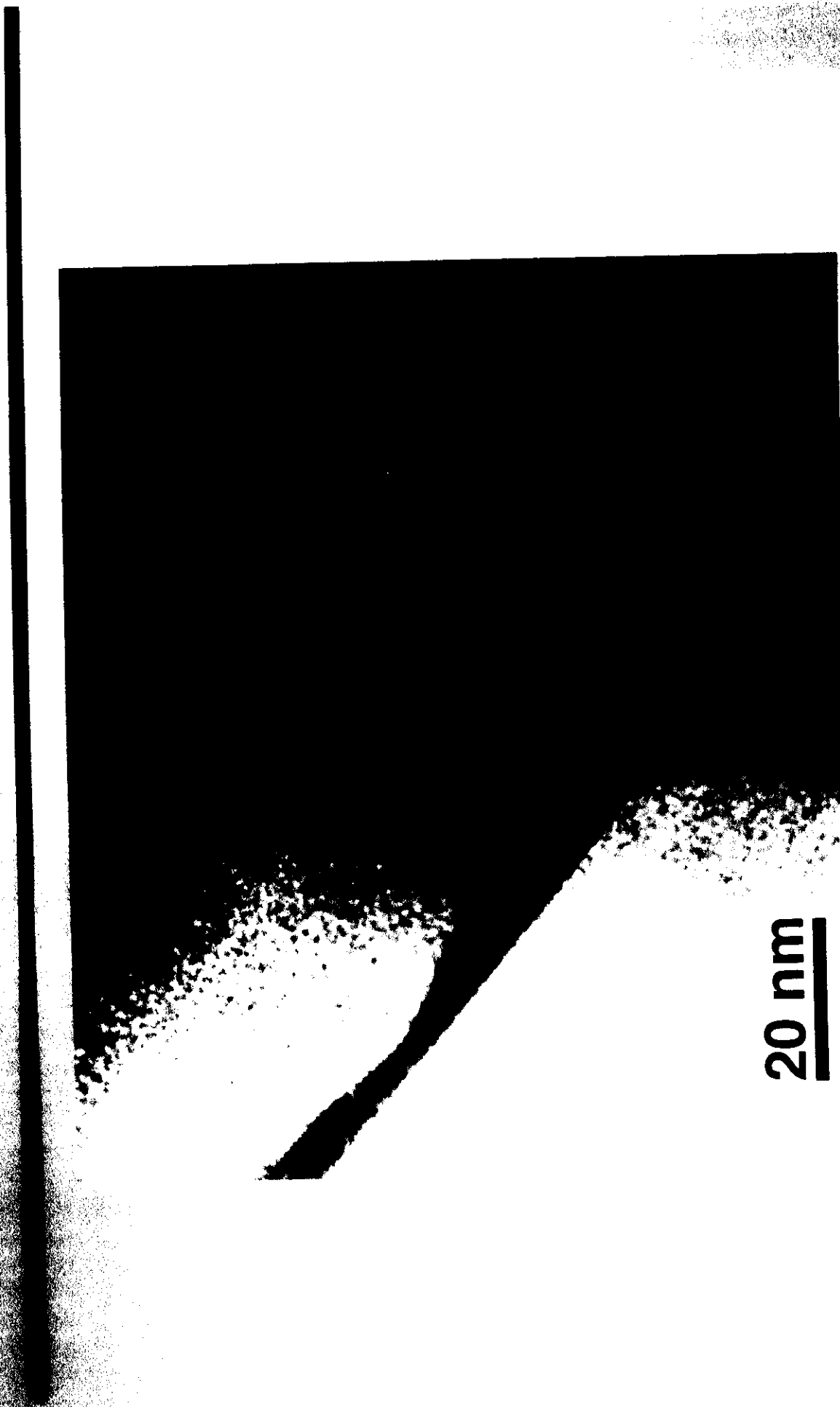


$x=0.45$



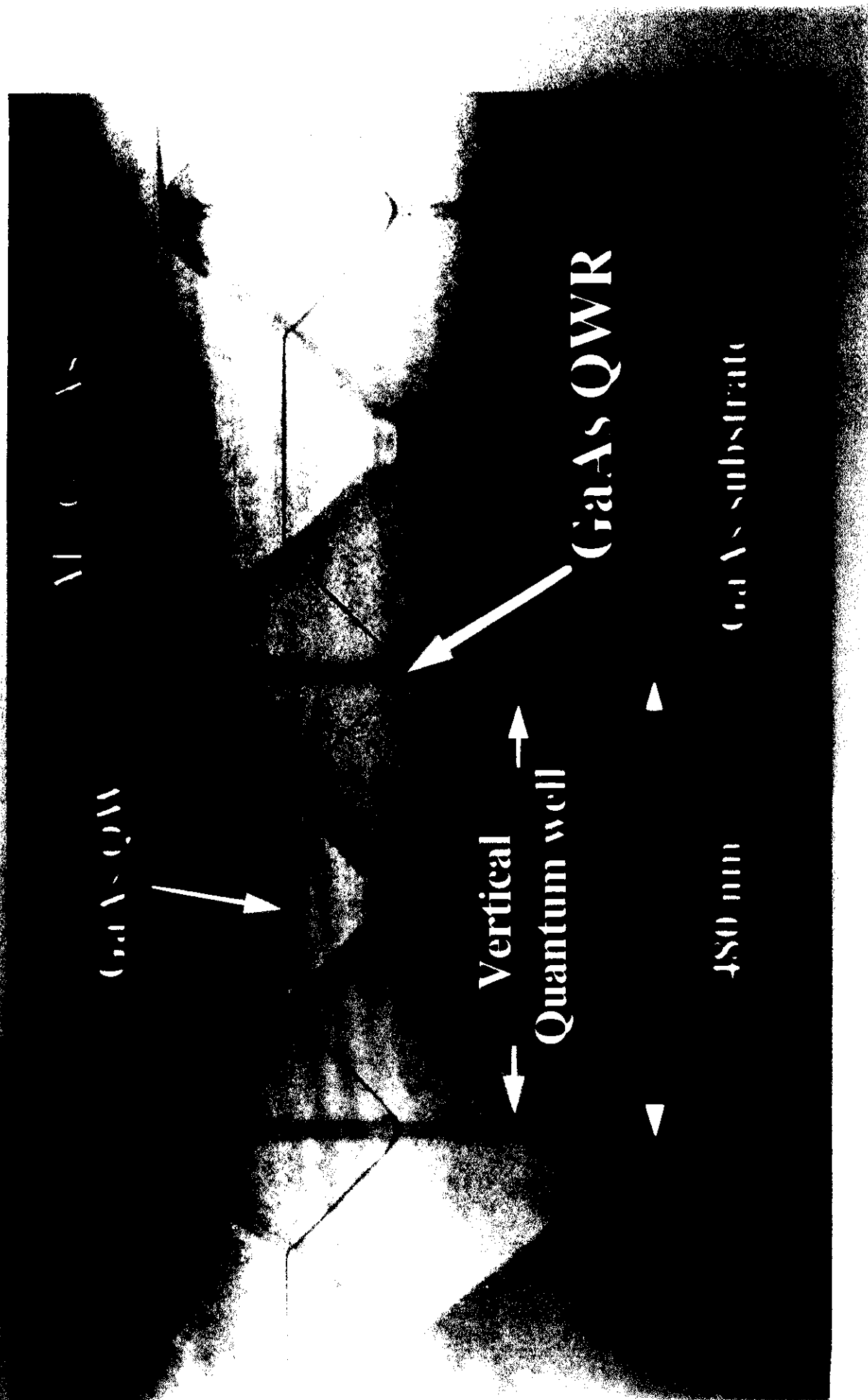
Atomic Force Microscopy: VQW x-section

V-Groove Quantum Wire



20 nm

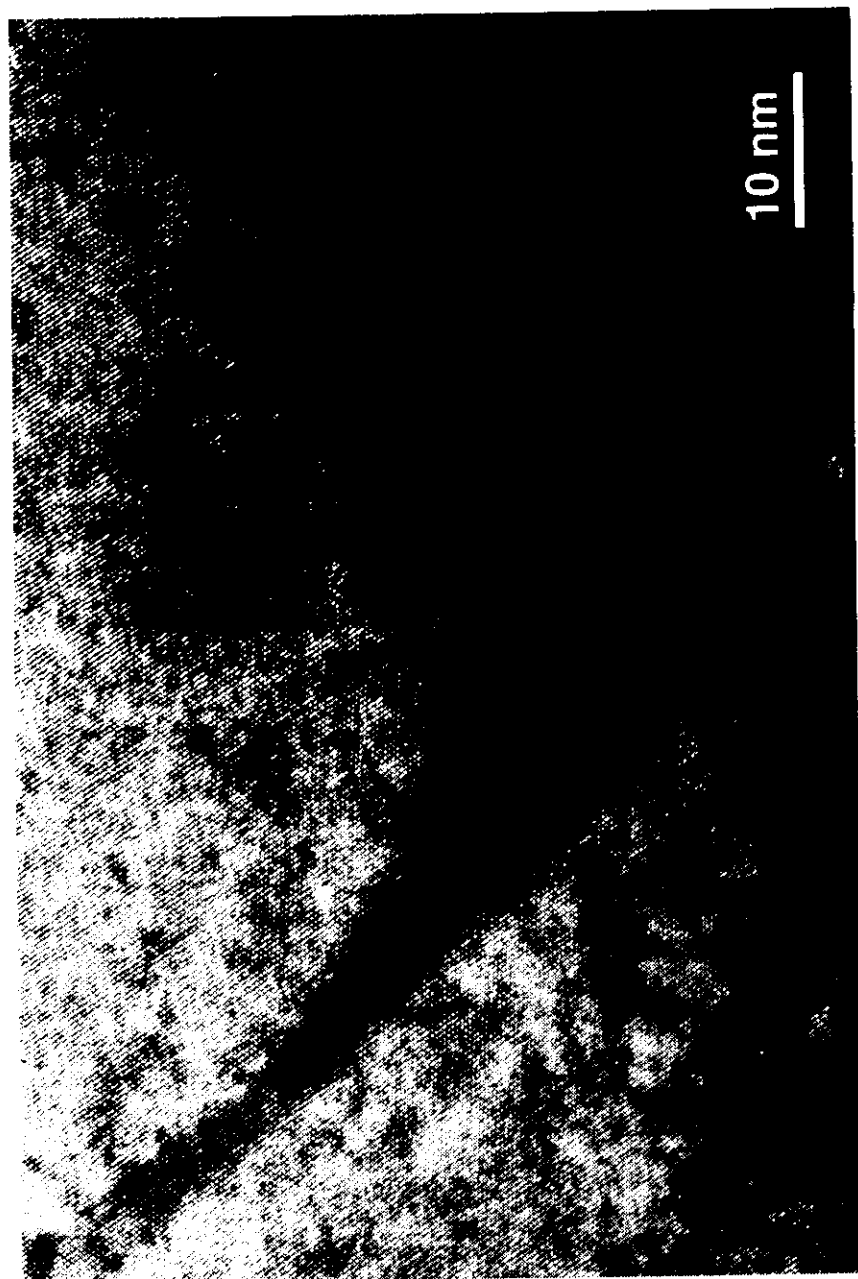
Vertical Array of V-Groove QWRs



GaAs/AlGaAs QWRs Grown by Low-Pressure OMPCVD

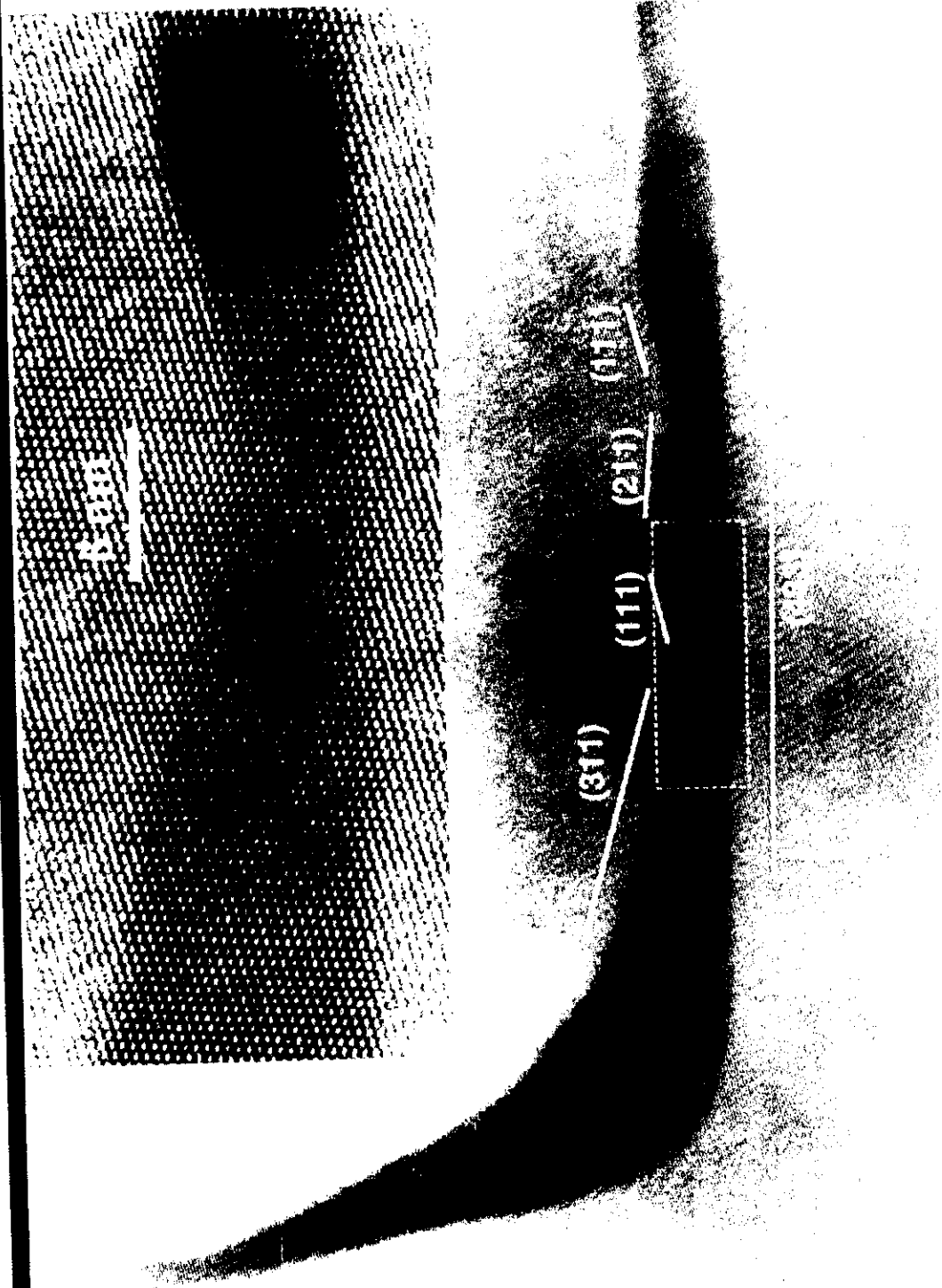


Dark field



High resolution

Quantum Crescent: high resolution TEM



Sections of a QWR Growth Study

40 nm-Al_{0.42}Ga_{0.58}As/3.5 nm-GaAs heterostructure

4 x 0.5 μm^2

GaAs-substrate

1 nm —

0 nm

(1 x 0.6 μm^2)

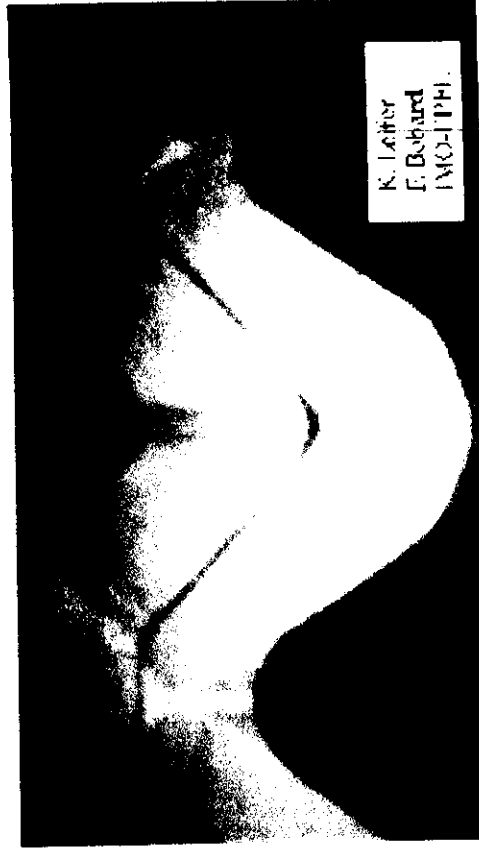
(0.2 x 0.2 μm^2)

GaAs/AlGaAs V-Groove QWRs

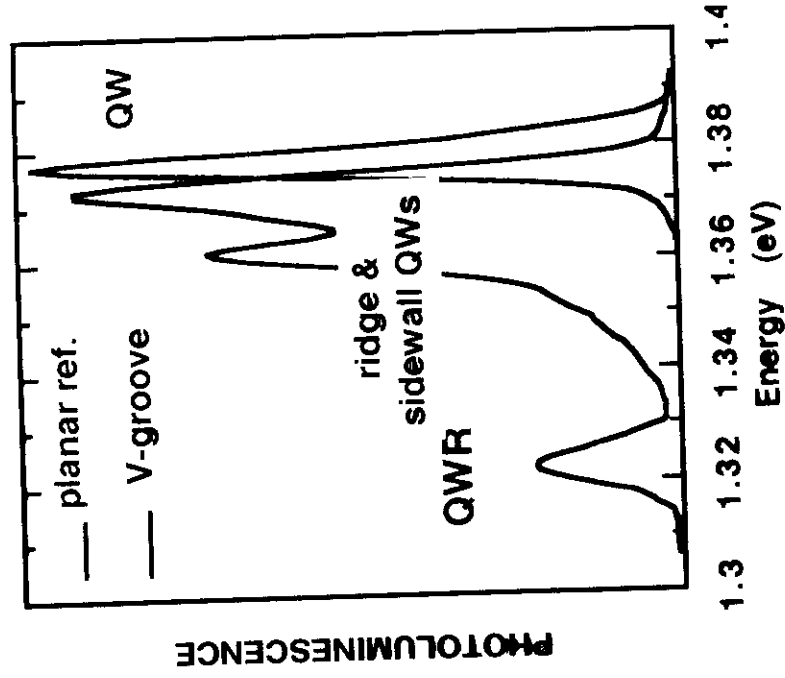
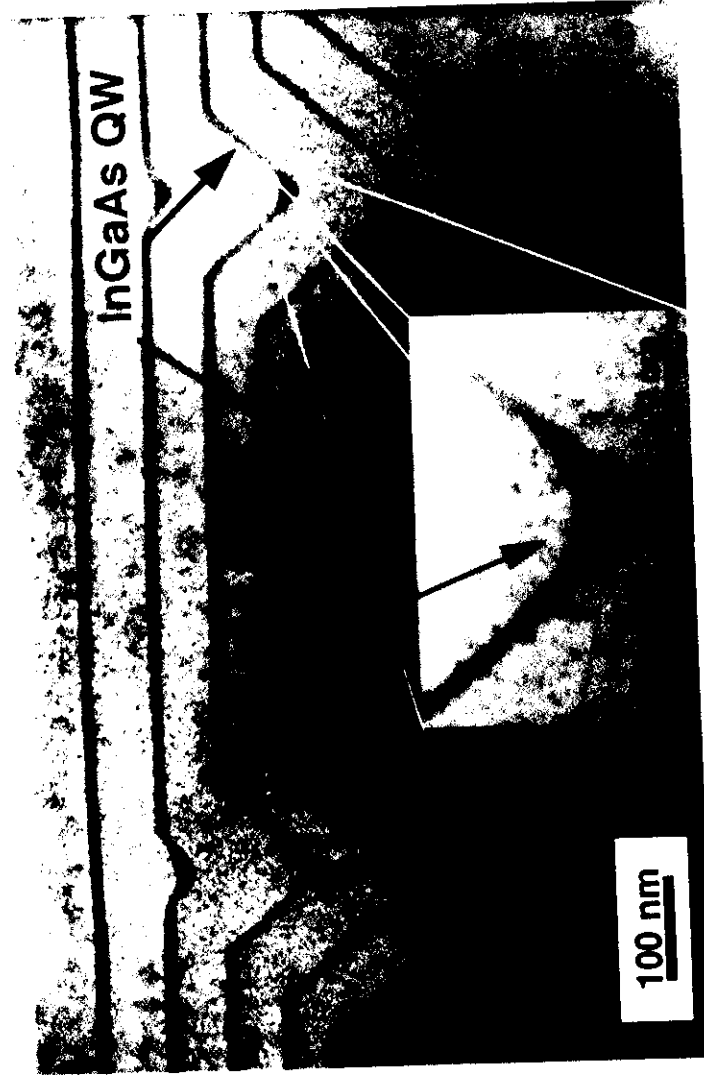
0.25 μm -pitch



-26-



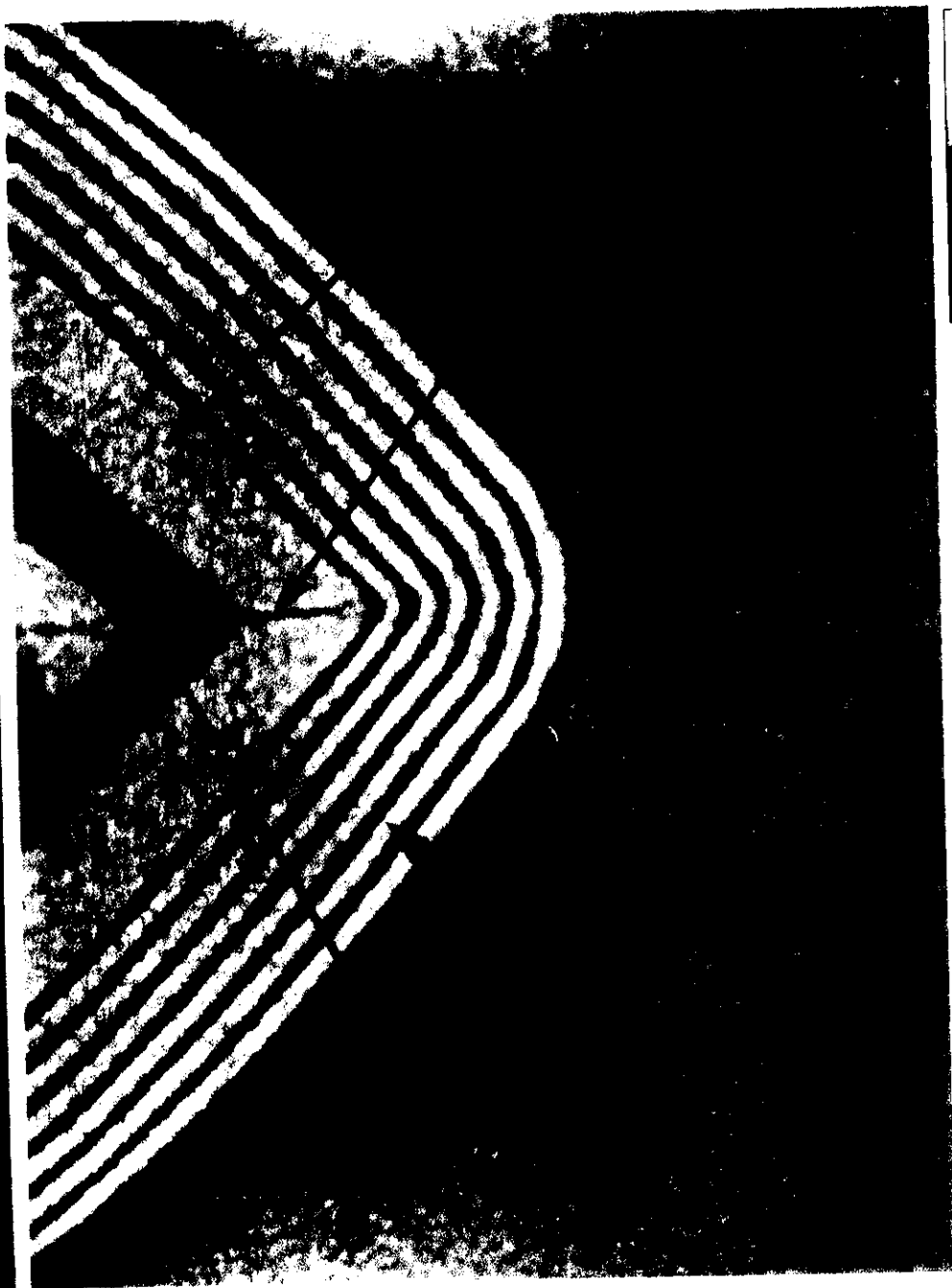
InGaAs/GaAs Strained QWRs on 0.5 μ m-pitch Grating



- uniform sub-10nm QWR size
- Self-limiting GaAs profile recovery < 25nm

- narrow linewidth (10meV)
- efficient carrier capture

Self-Ordering of a V-Groove Surface



0 1.5nm

From Multiple QWRs to QWR SLs

$t_w=4.5\text{nm}; t_b=60\text{nm}$



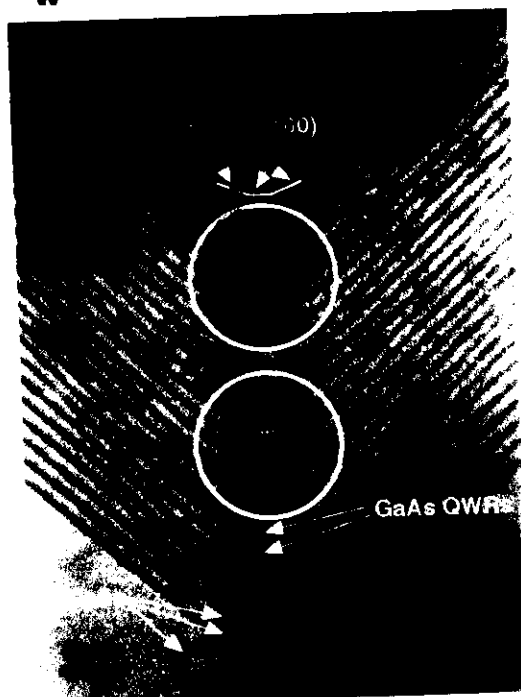
$t_w=4.5\text{nm}; t_b=9.3\text{nm}$



$t_w=3.9\text{nm}; t_b=5.3\text{nm}$

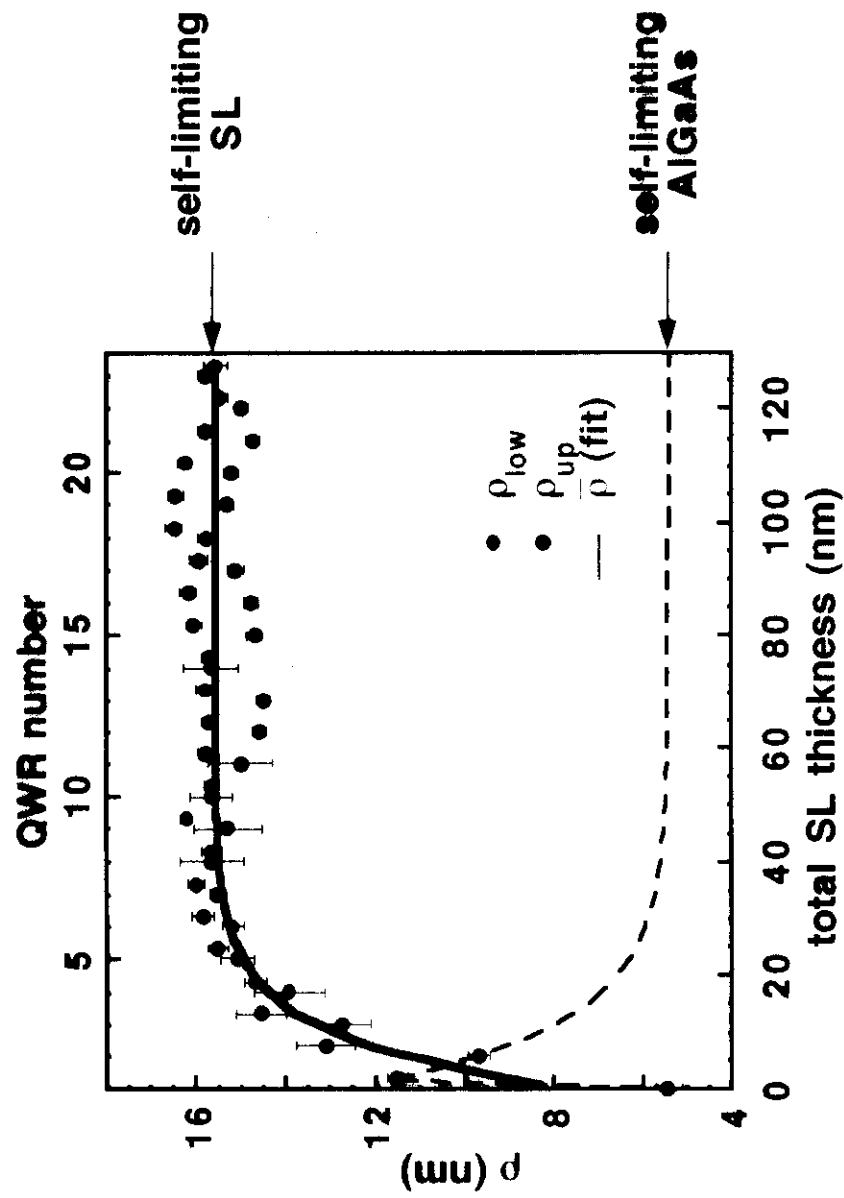


$t_w=2.3\text{nm}; t_b=1.8\text{nm}$

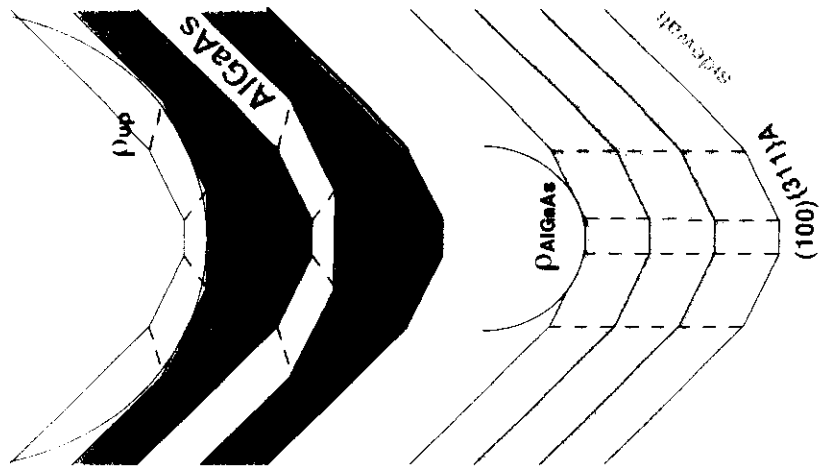


GaAs/ $\text{Al}_{0.45}\text{Ga}_{0.55}\text{As}$; $T_{\text{sub}}=650^\circ\text{C}$

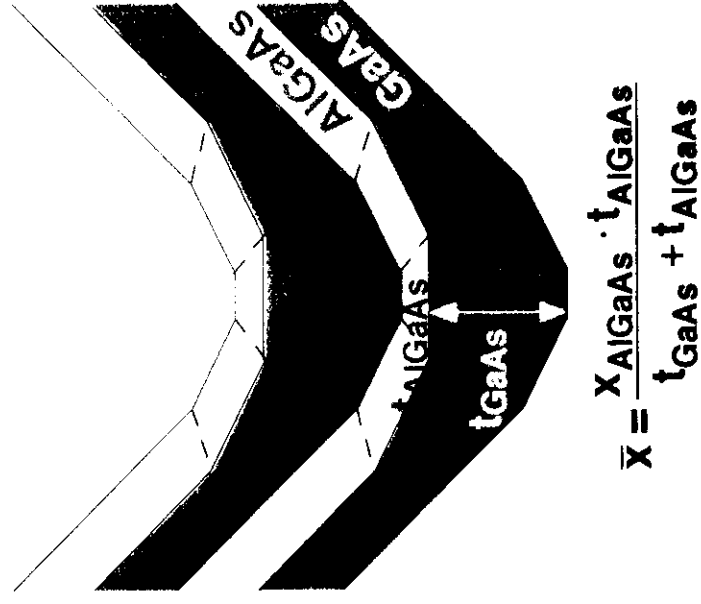
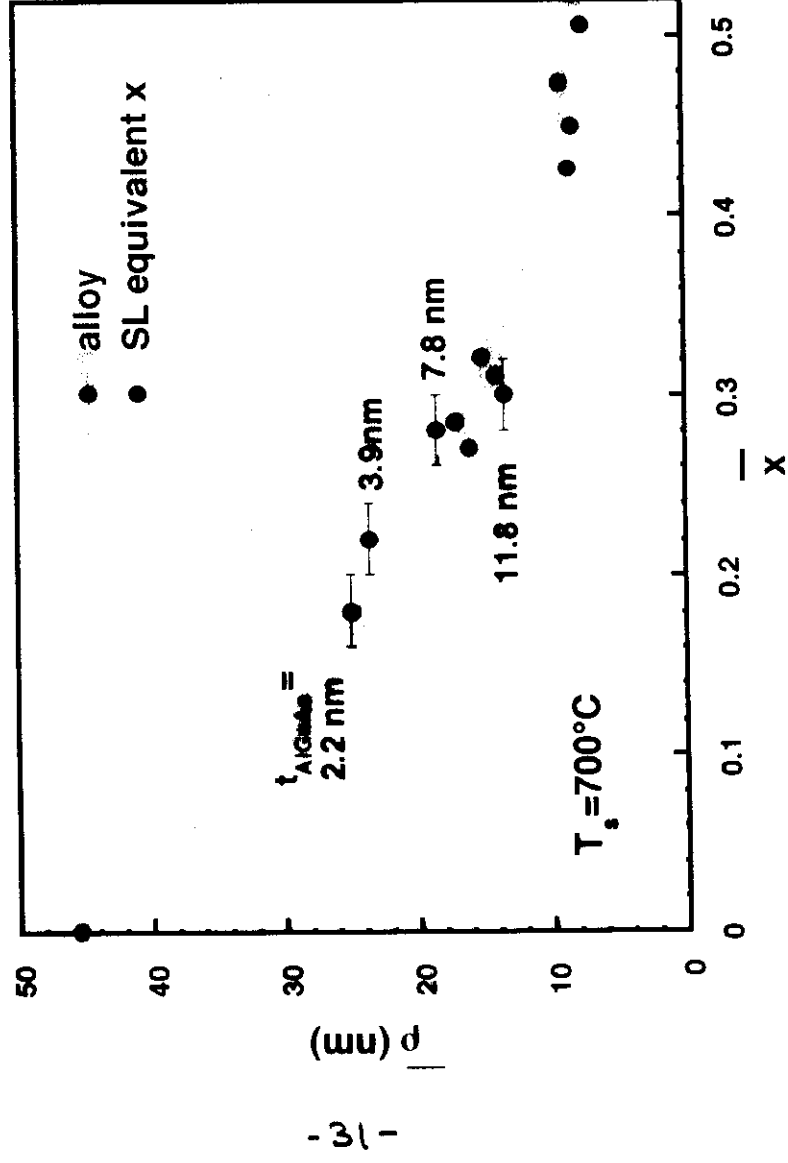
Self Ordering of a V-Groove QWR-SL



$t_w=1.8\text{nm}$; $t_b=3.9\text{nm}$; $T_{\text{sub}}=650^\circ\text{C}$



Comparison of Alloy and SL V-Groove Ordering



Quasi (100) Surface After Growth

- Monolayer steps on the (100) surface
- Step bunching on the (311)A surface

0.5 μm pitch

2 μm pitch

(100)

{311}A

(100)

{311}A

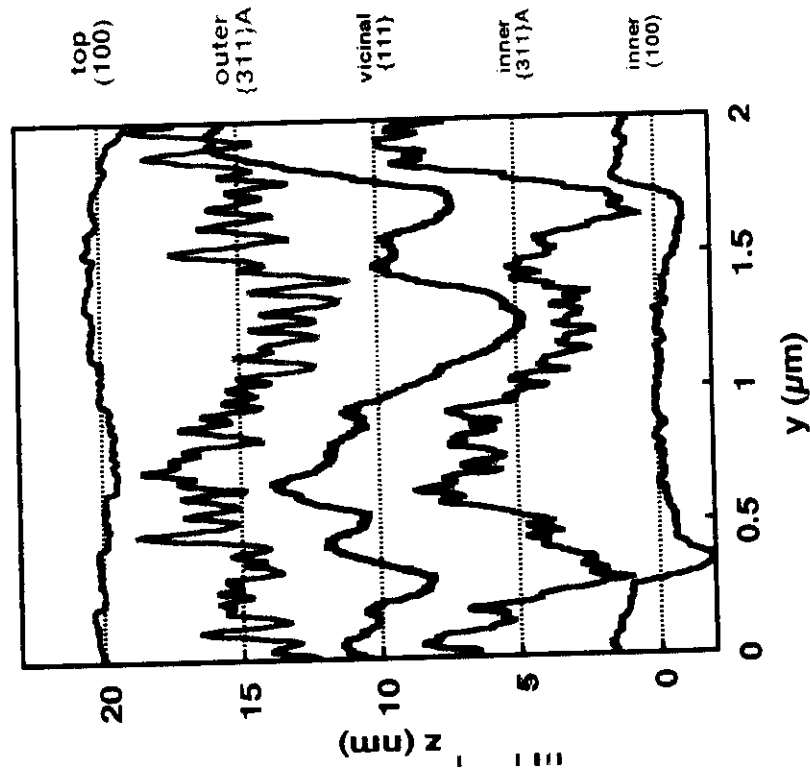
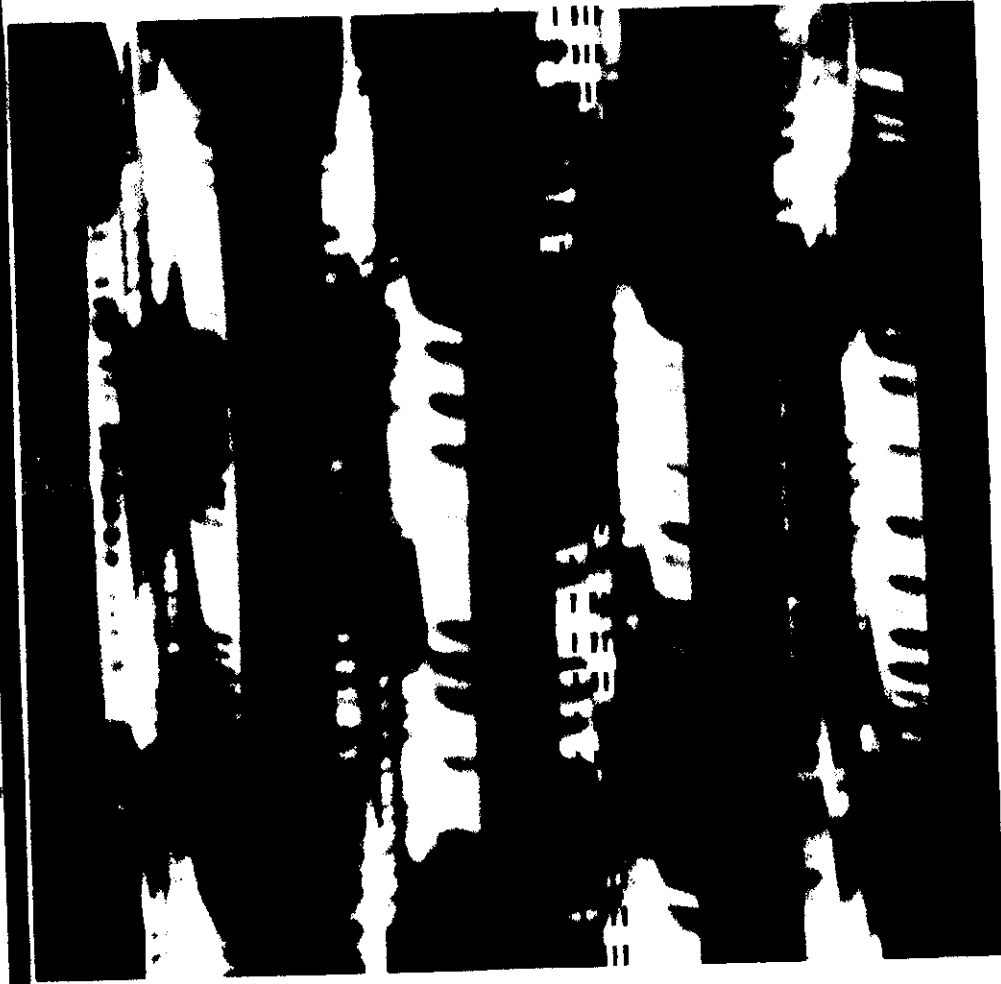
quasi {111}A

quasi {111}A

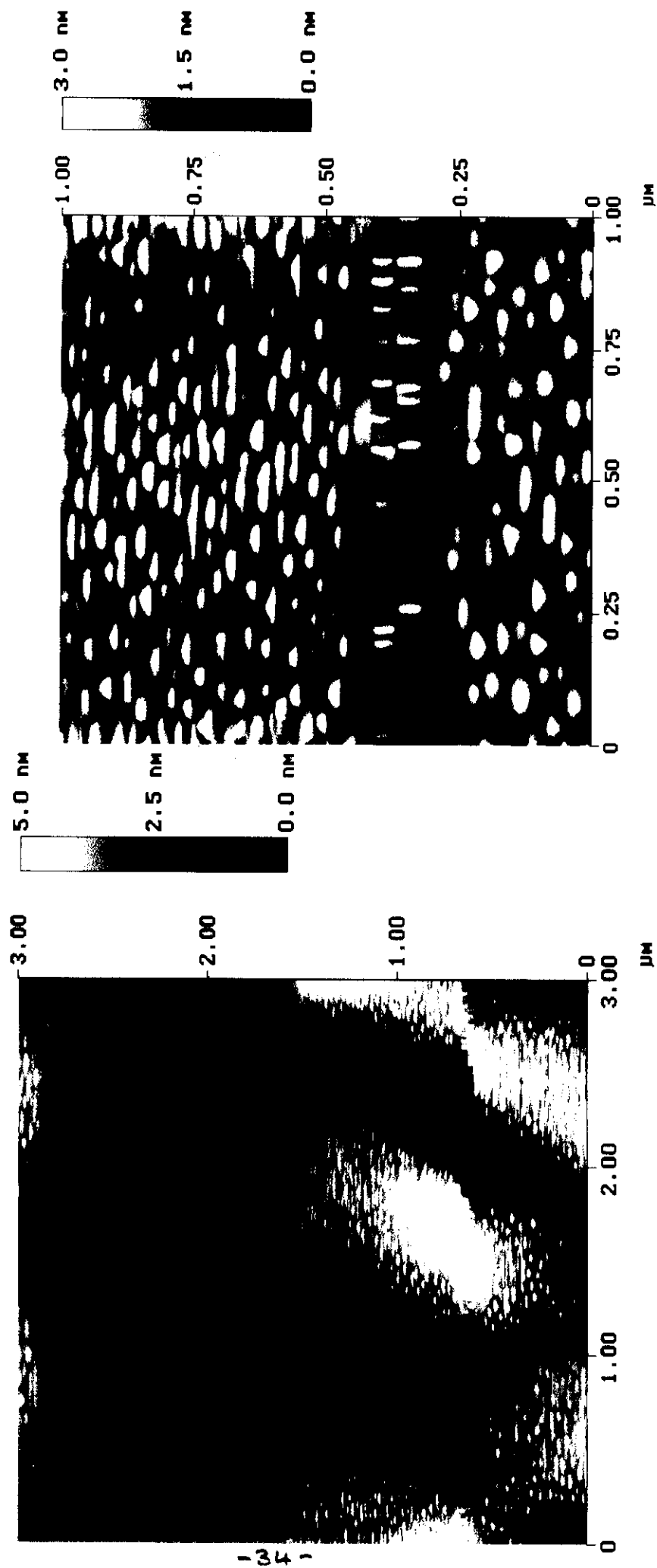
100

200.00 nm

Topography of a V-Groove Surface-QWR

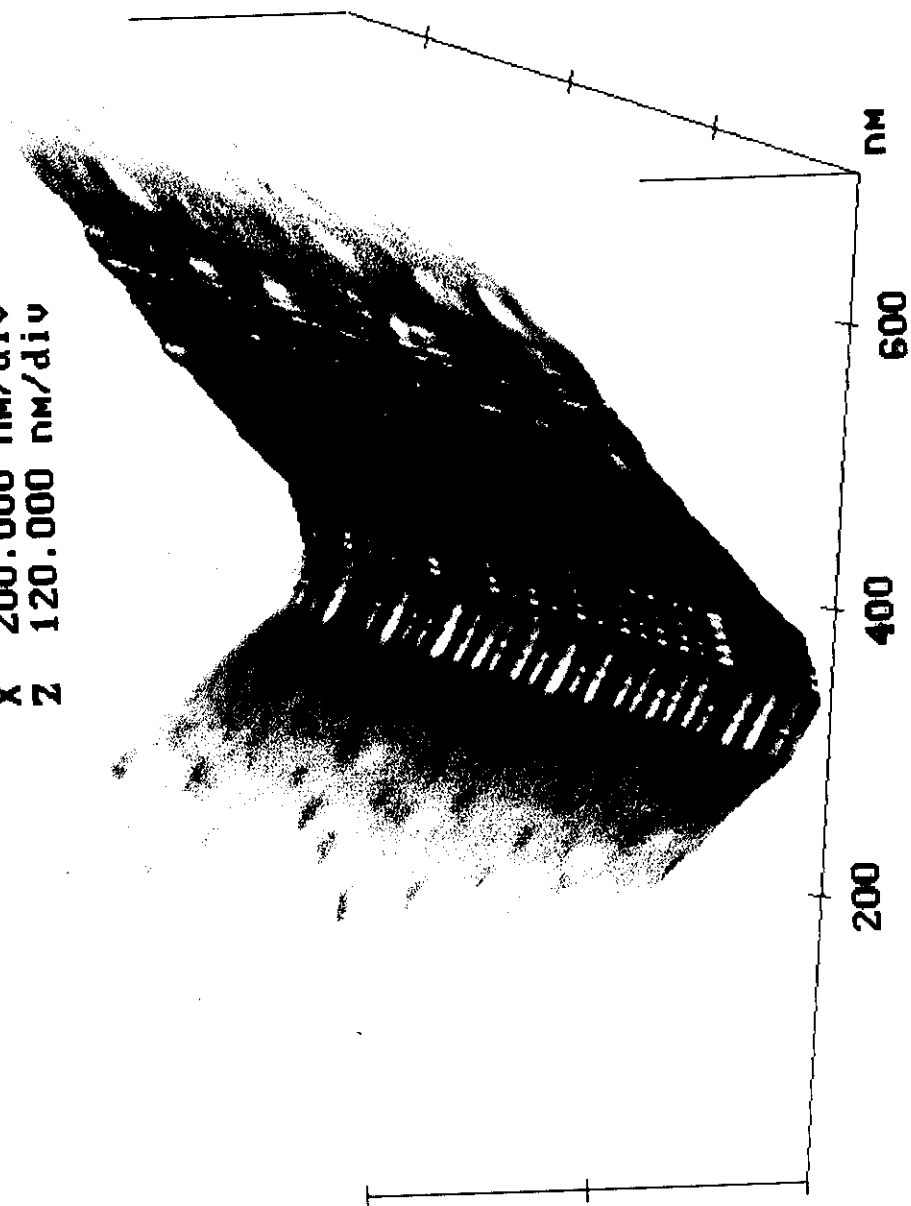


InGaAs/AlGaAs V-groove Surface



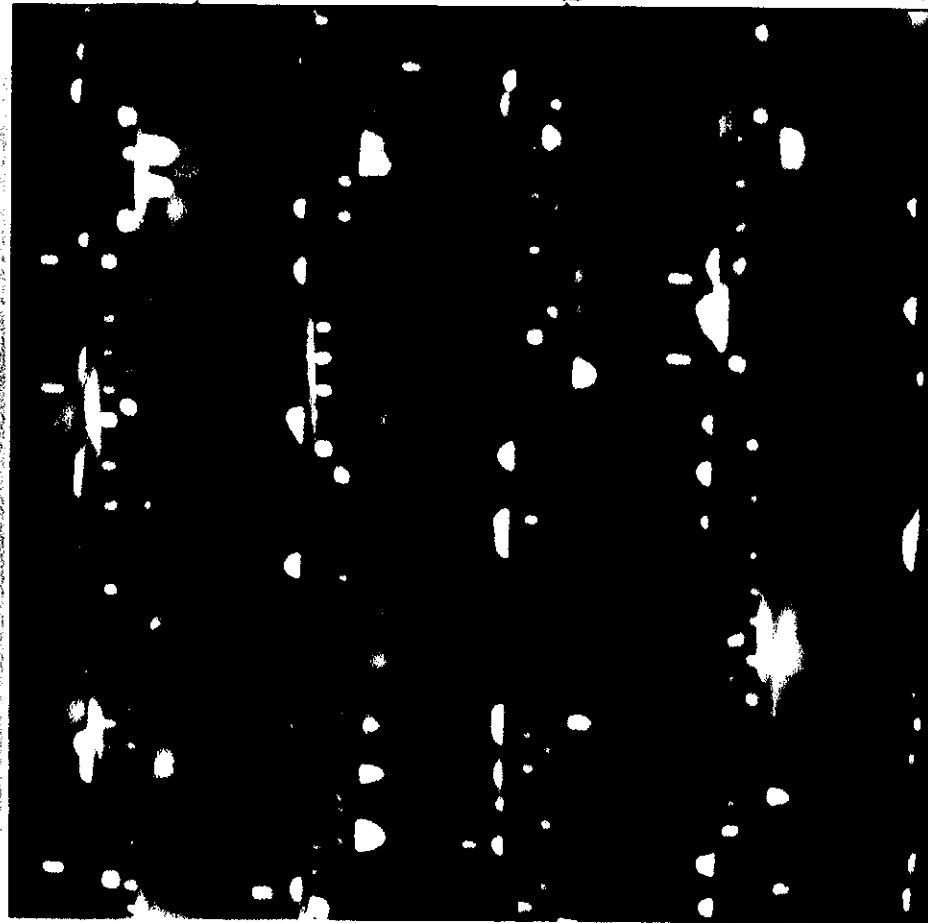
Surface of InGaAs/AlGaAs V-Groove

X 200.000 nm/div
Z 120.000 nm/div

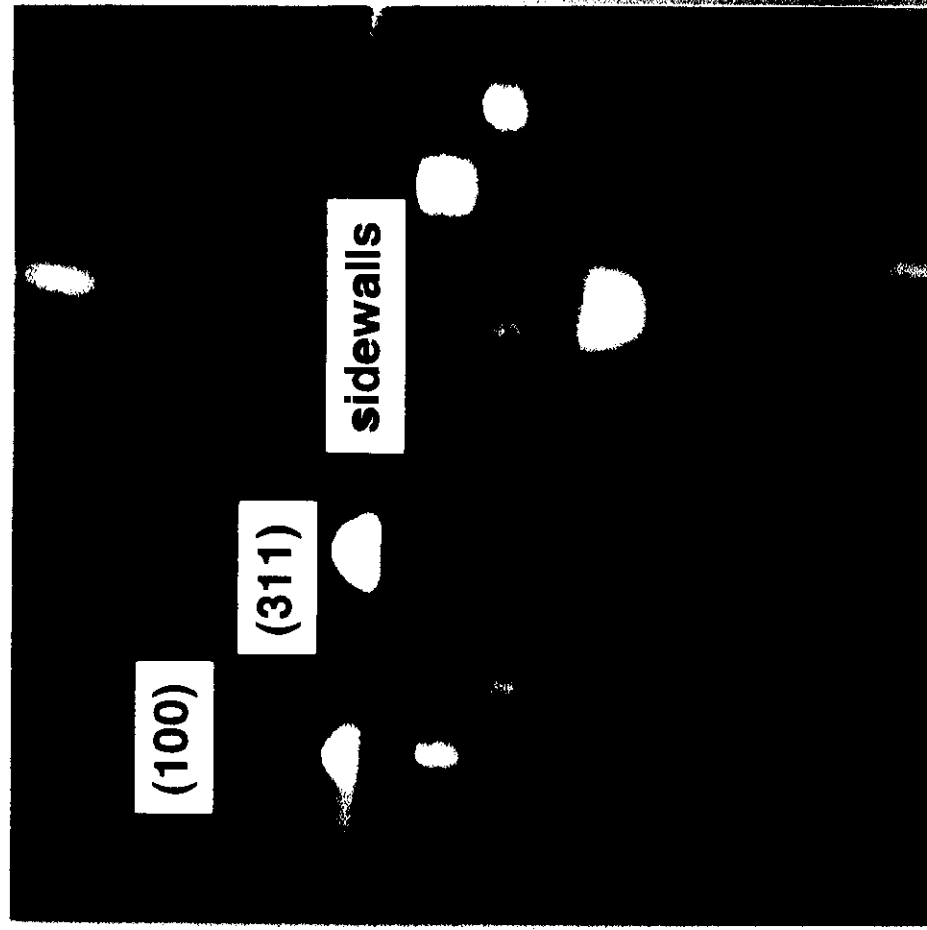


As Surface Quantum Wire ($p=0.5\text{ }\mu\text{m}$)

($2.5 \times 2.5\text{ }\mu\text{m}^2$)



($0.7 \times 0.7\text{ }\mu\text{m}^2$)



Growth of QDs in Inverted Tetrahedral Pyramids

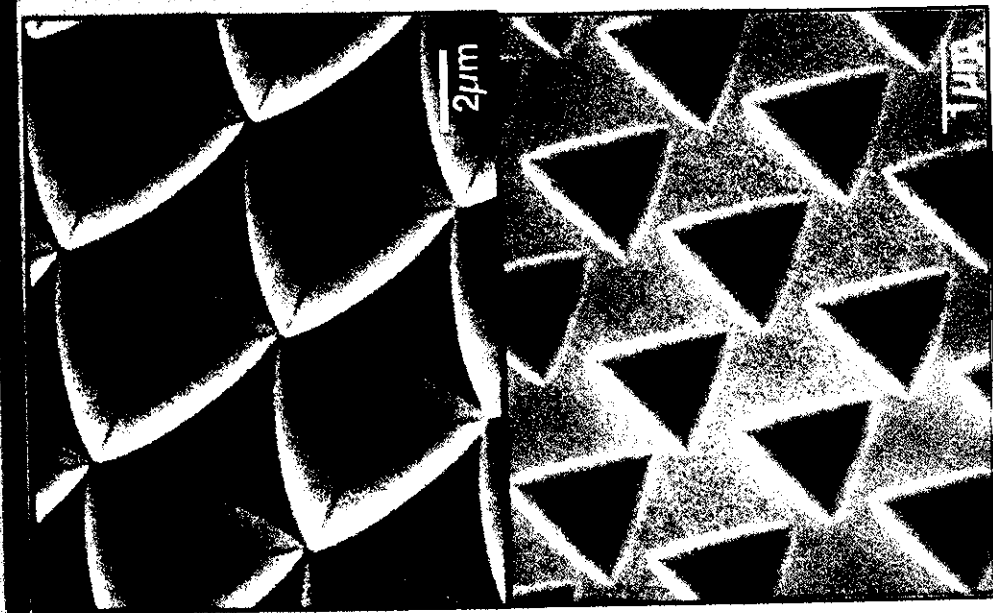


Figure 1. SEM image of inverted tetrahedral pyramids.

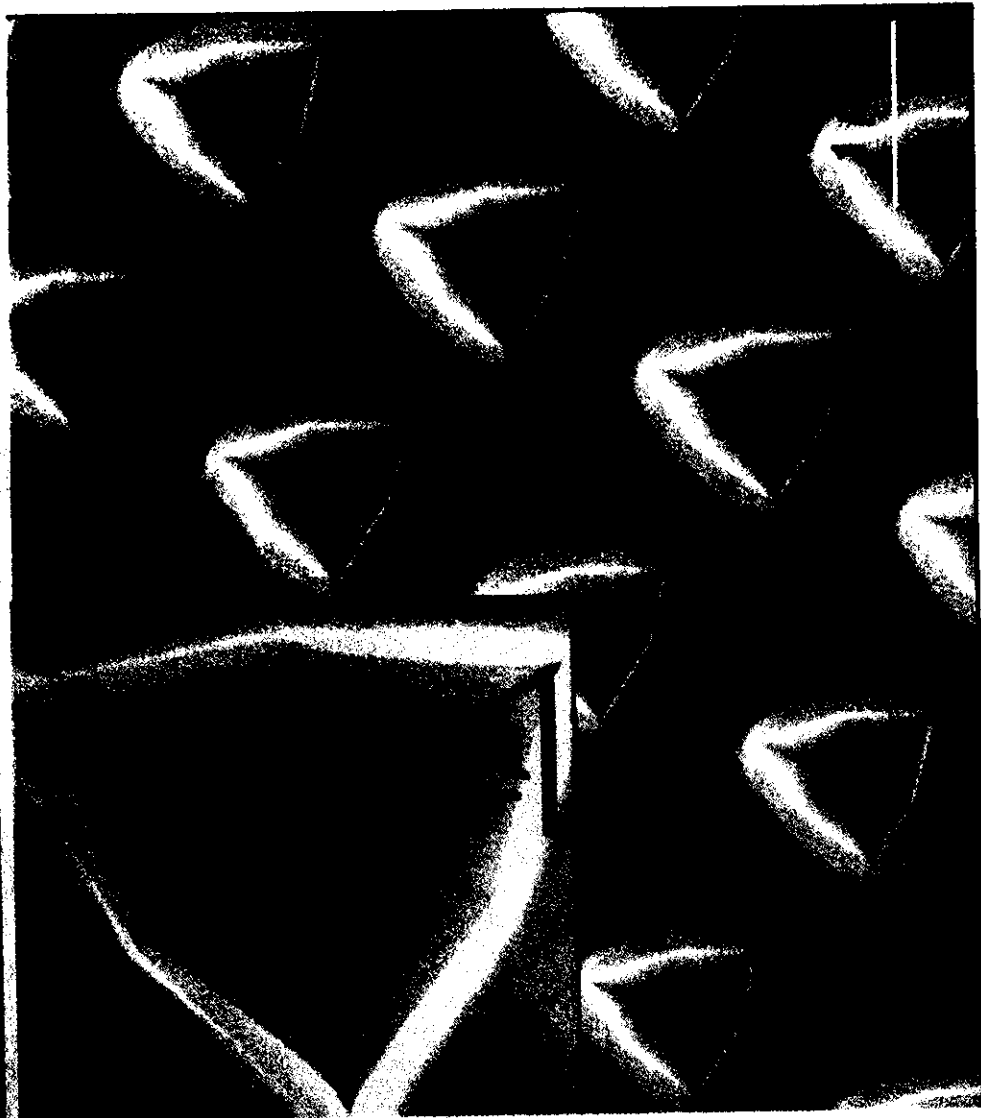
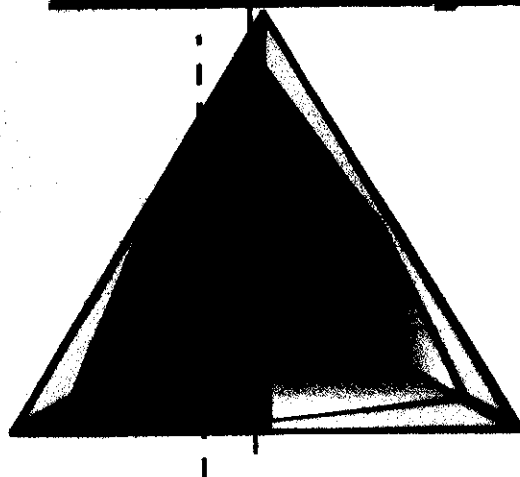
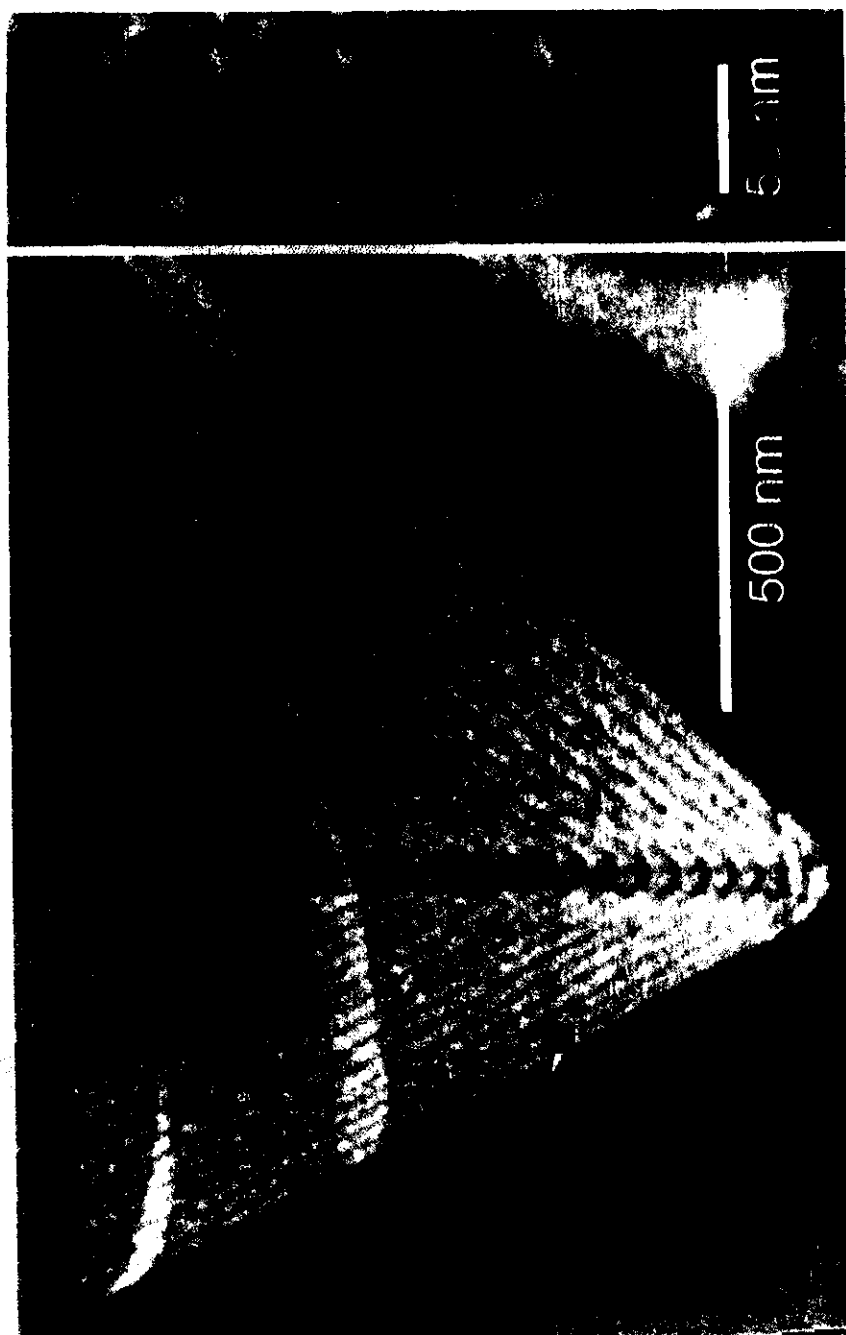


Figure 2. SEM image of inverted tetrahedral pyramids.

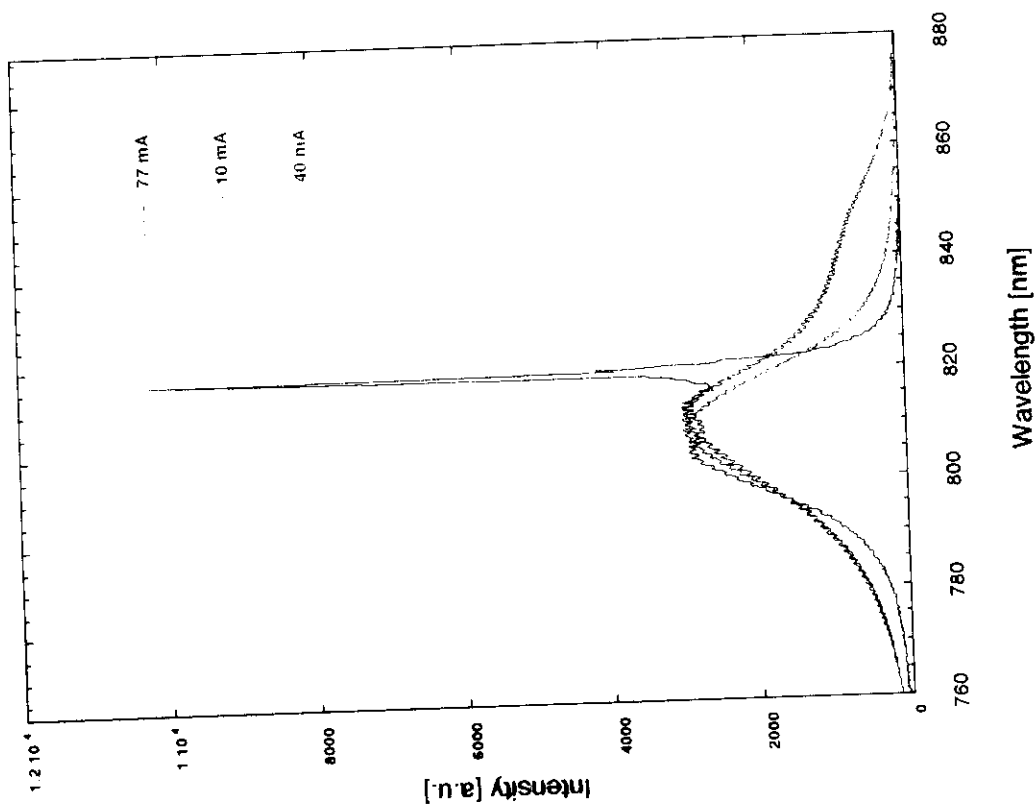
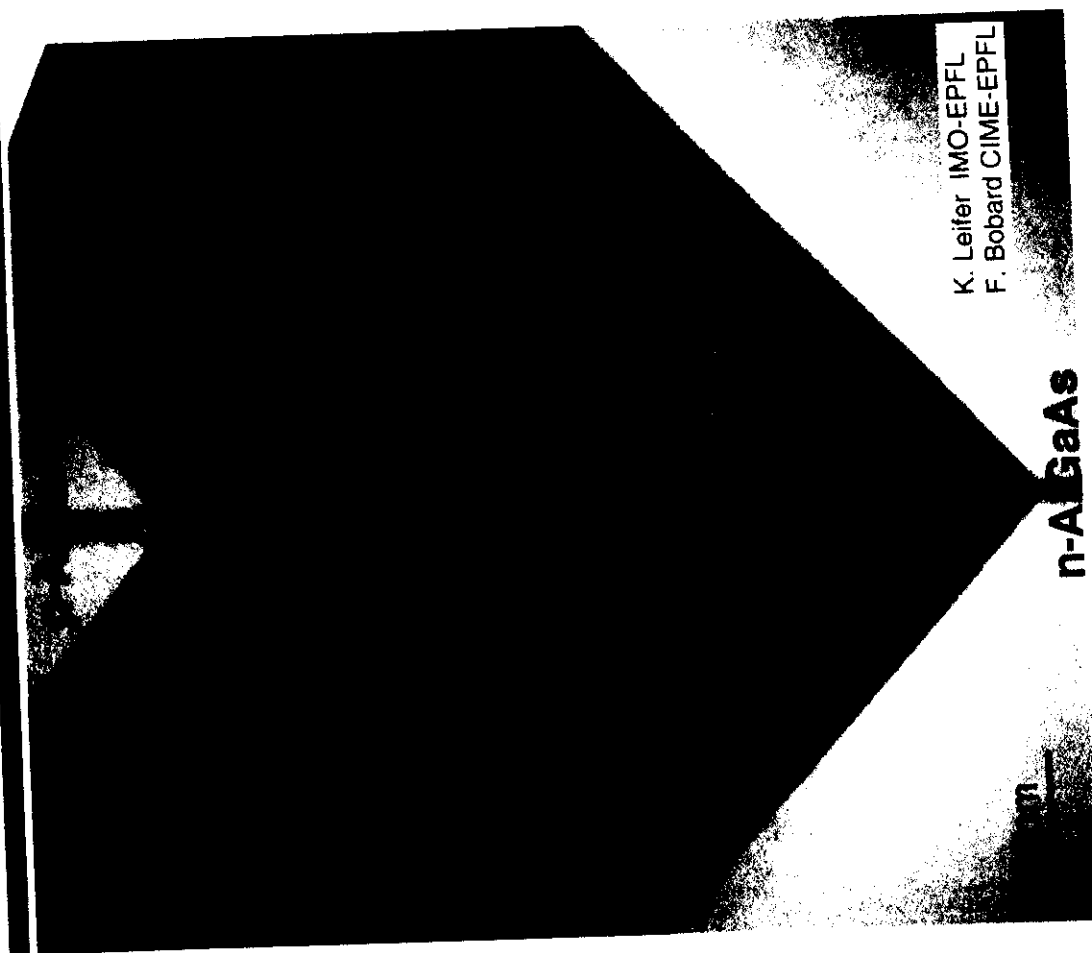
AFM Cross Section at Center of a QD Pyramid



- vertically-stacked QWRs and QDs
- vertical QWR



Multiple-QWR V-Groove Laser



Electronic Properties of Low Dimensional Nanostructures Grown on Nonplanar Substrates

outline:

- **Quantum confinement in vertical QWs**
- **Valence band mixing in QWRs**
- **Coupling and tunneling in double QWRs**
- **Localized and delocalized states in QWR superlattices**
- **Localized excitons in QWRs**
- **1D excitons at high densities**

**Electronic Properties of Low Dimensional Nanostructures
Grown on Nonplanar Substrates**

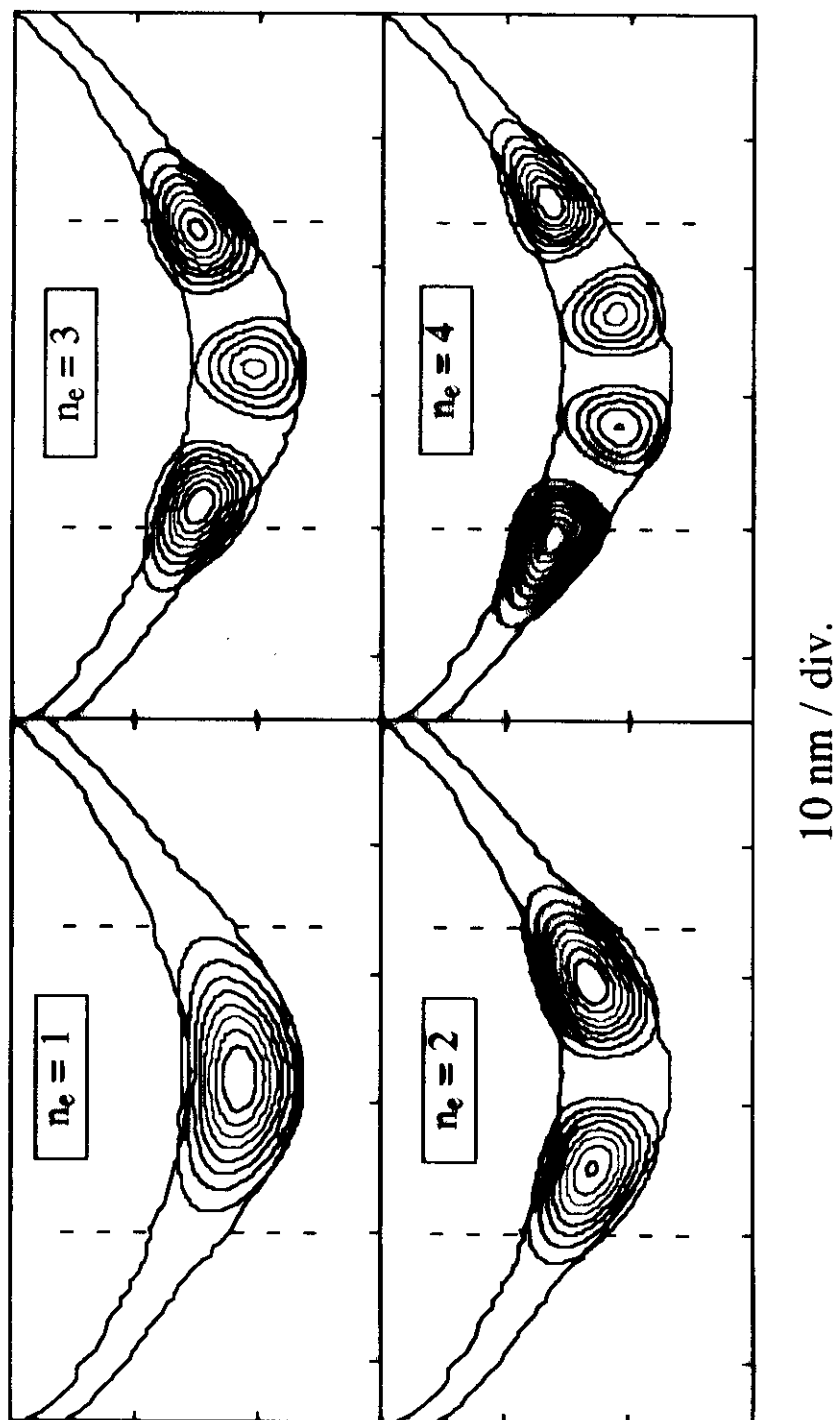
Collaborators:

D. Oberli, F. Veuille, M.-A. Duperetuis

E. Martinet, A. Gustafsson, H. Weman, Y. Dumeunier

Electron Subband in a V-Groove QWR

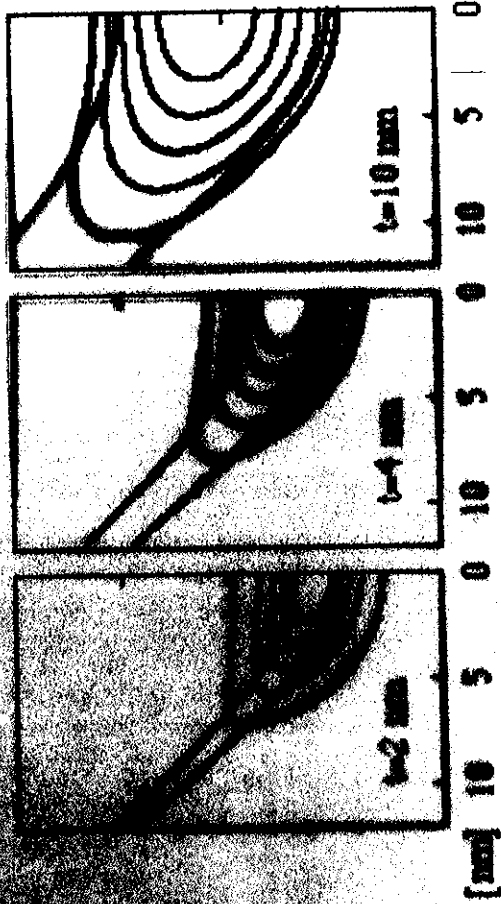
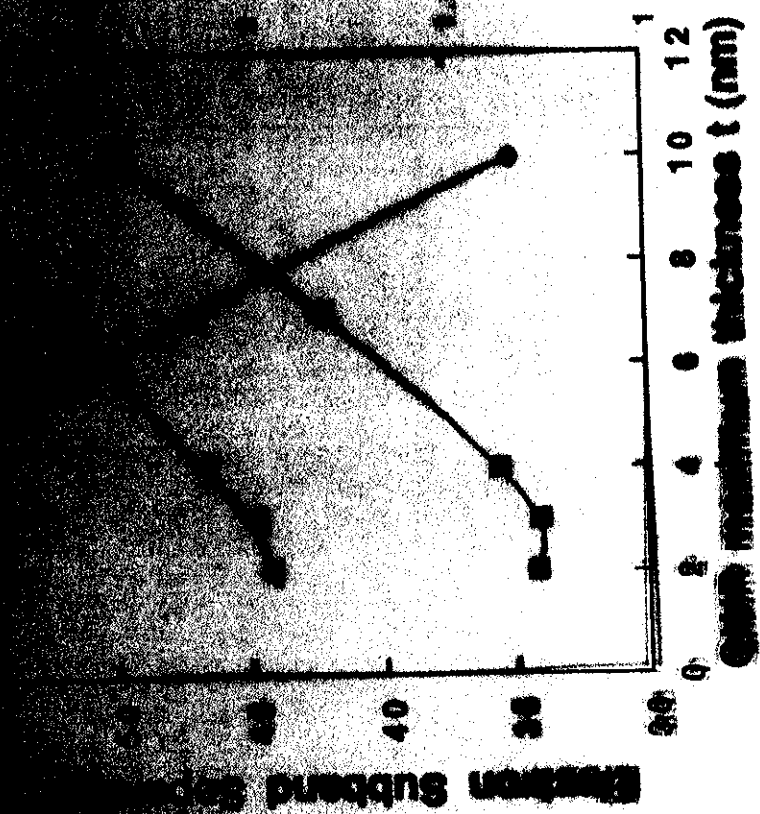
(Probability Density Distribution)



Ground State Separation

- lower radius of curvature $\rho = 5 \text{ nm}$
- Al mole fraction $x=0.5$

Ground State Standard Deviation (nm)



ground state wave functions

Valence Band Mixing in a 1D Semiconductor:

Lutinger Hamiltonian

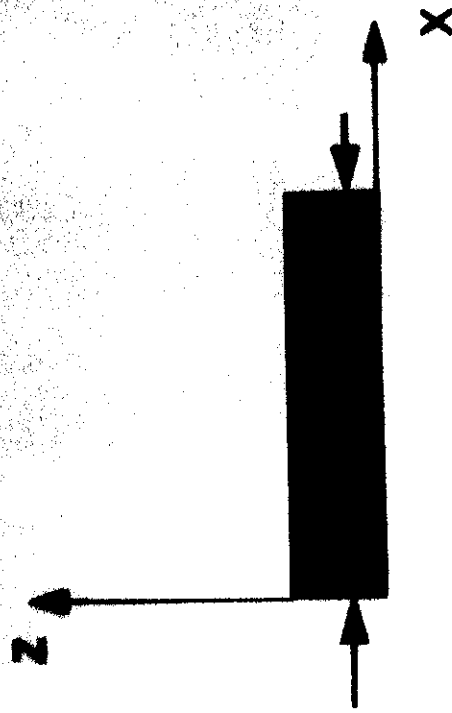


Diagram illustrating the structure of a light hole in a semiconductor. The diagram shows a series of energy levels (represented by horizontal lines) and their corresponding wave functions (represented by the symbols H_{hh} , c^* , b^* , 0 , c , H_{lh} , 0 , $-b^*$, c^* , H_{lh} , 0 , $-b$, c , H_{hh}). The energy levels are labeled H_{hh} , c^* , b^* , 0 , c , H_{lh} , 0 , $-b^*$, c^* , H_{lh} , 0 , $-b$, c , H_{hh} . The wave functions are labeled H_{hh} , c^* , b^* , 0 , c , H_{lh} , 0 , $-b^*$, c^* , H_{lh} , 0 , $-b$, c , H_{hh} . The diagram shows a band structure with a light hole at the top, indicated by an arrow pointing to the H_{hh} level.

lateral confinement

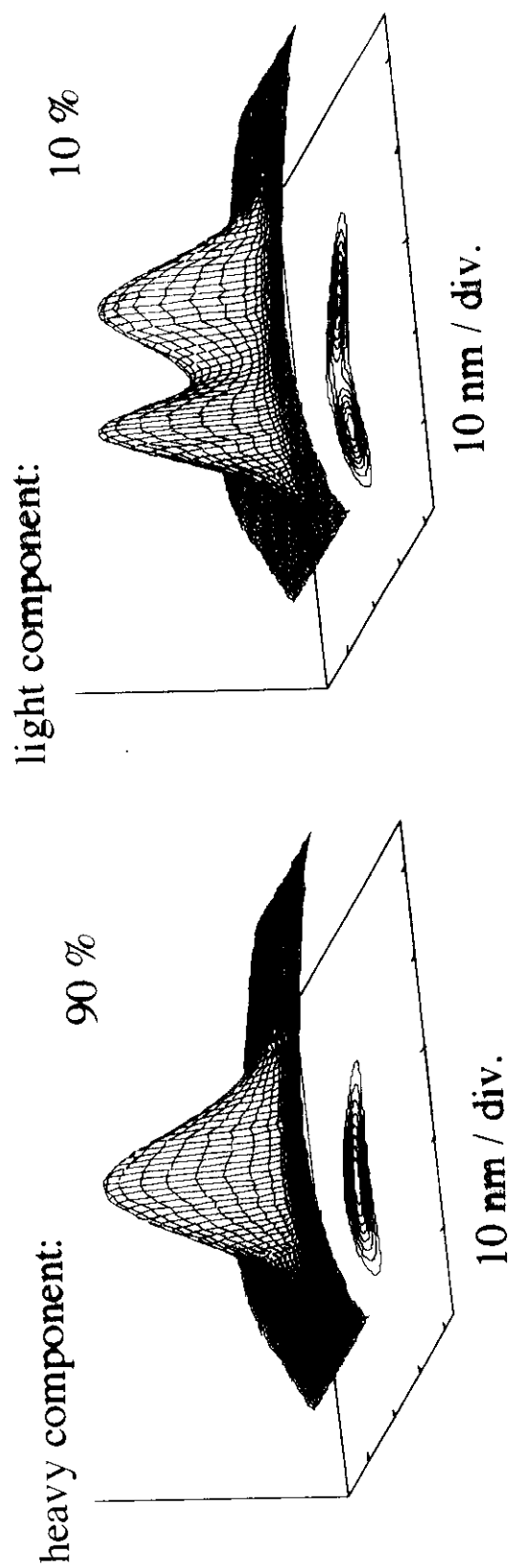
$$c=c(k_x, k_y), c(0,0)=0$$

$$b=b(k_x, k_y), \quad b(0,0)=0$$

heavy hole- light hole mixing

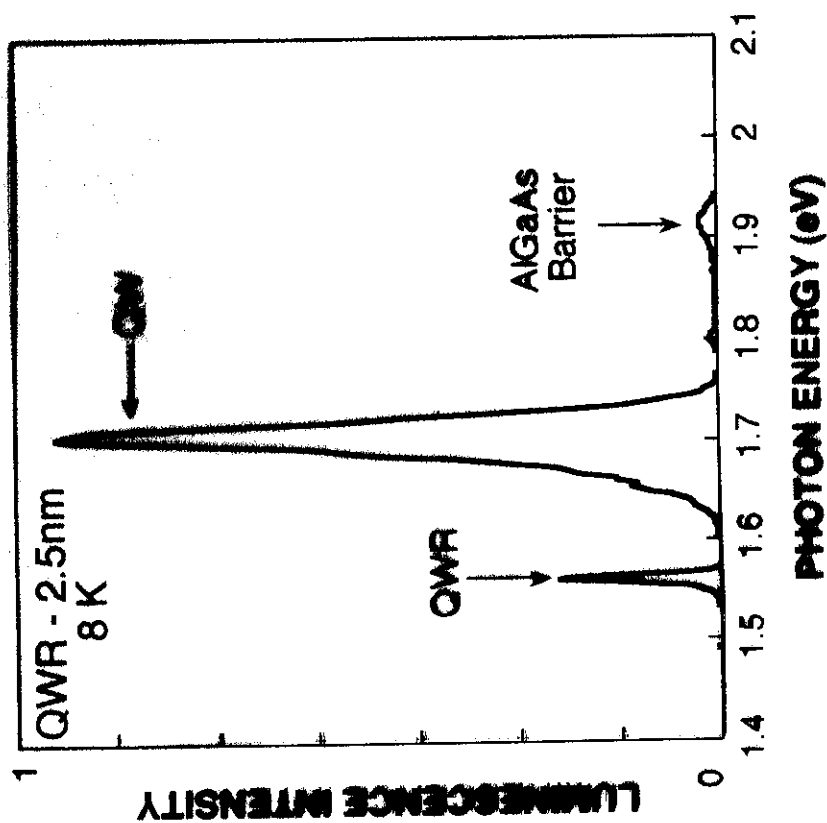
Valence Band Mixing in QWRs

(2.5 nm V-Groove QWR; $nh = 1$)



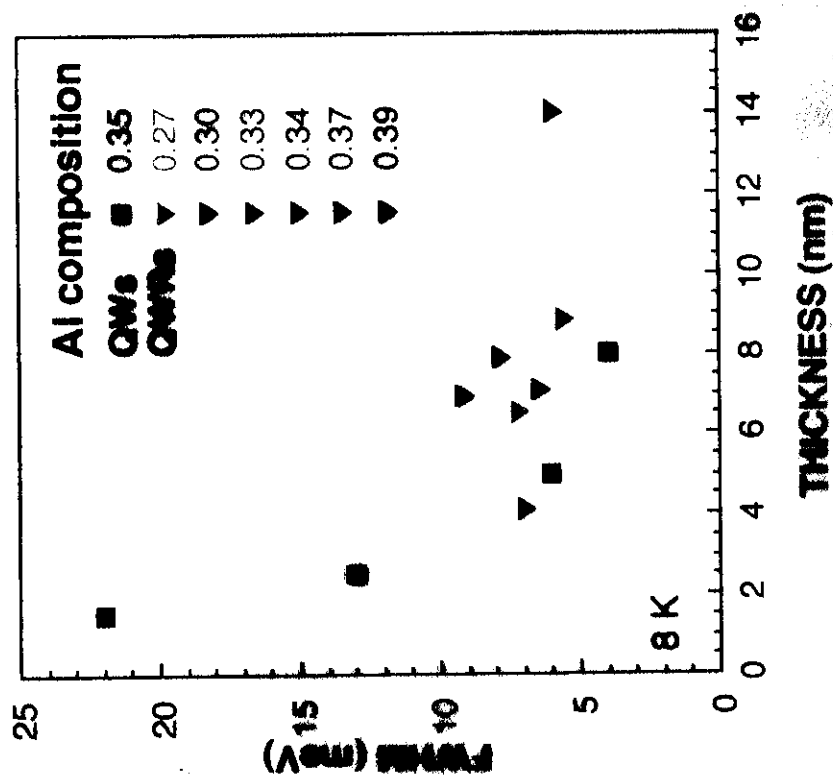
Low-Temperature PL Spectra of V-Groove QWRs

PL spectrum of a V-Groove QWR

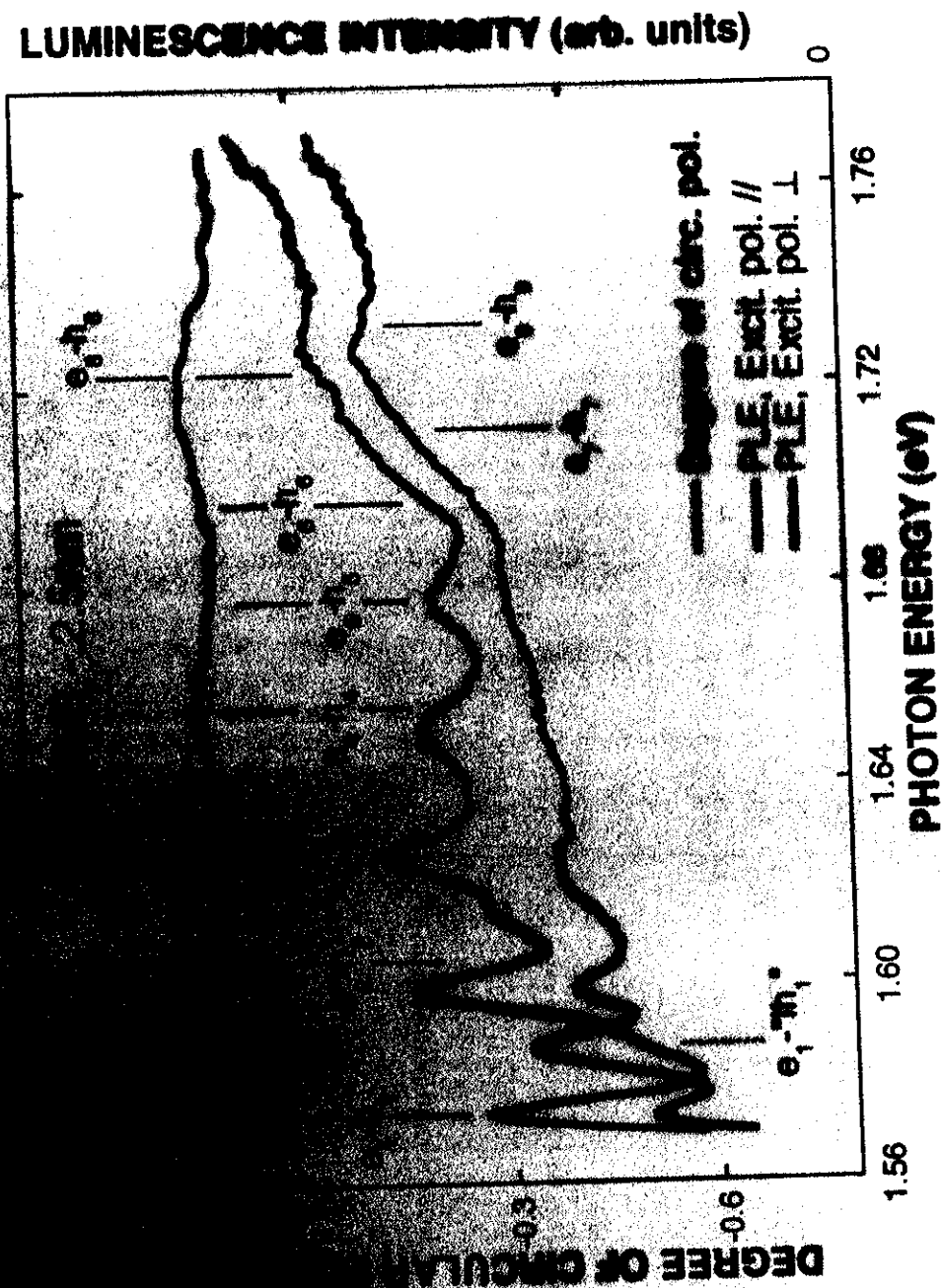


QWR vs QW Linewidths

Linewidth of QWs and QWRs

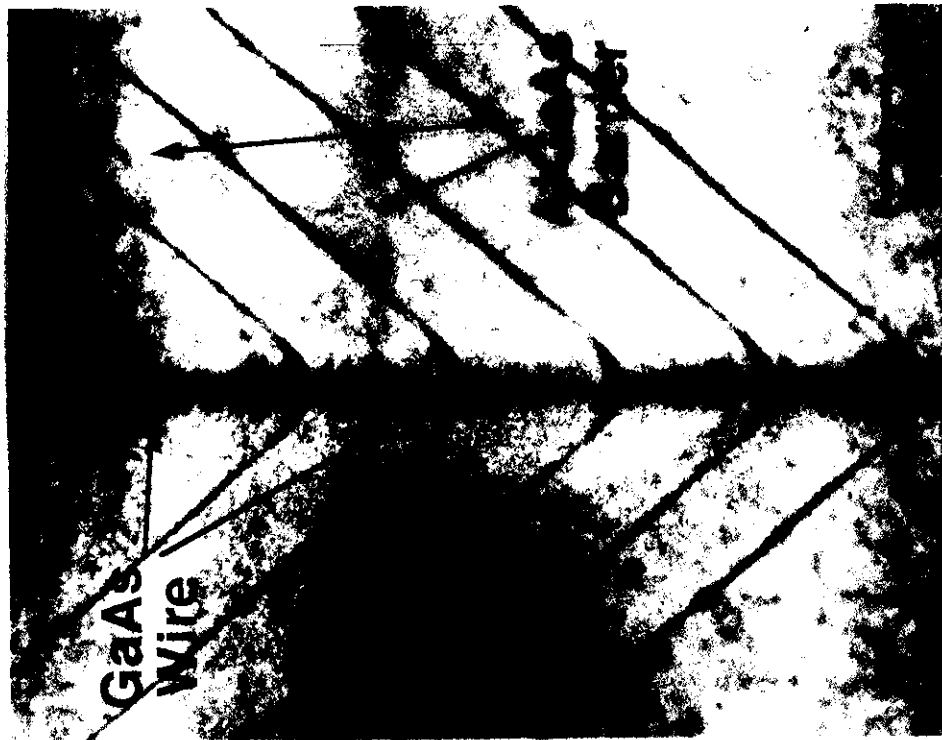
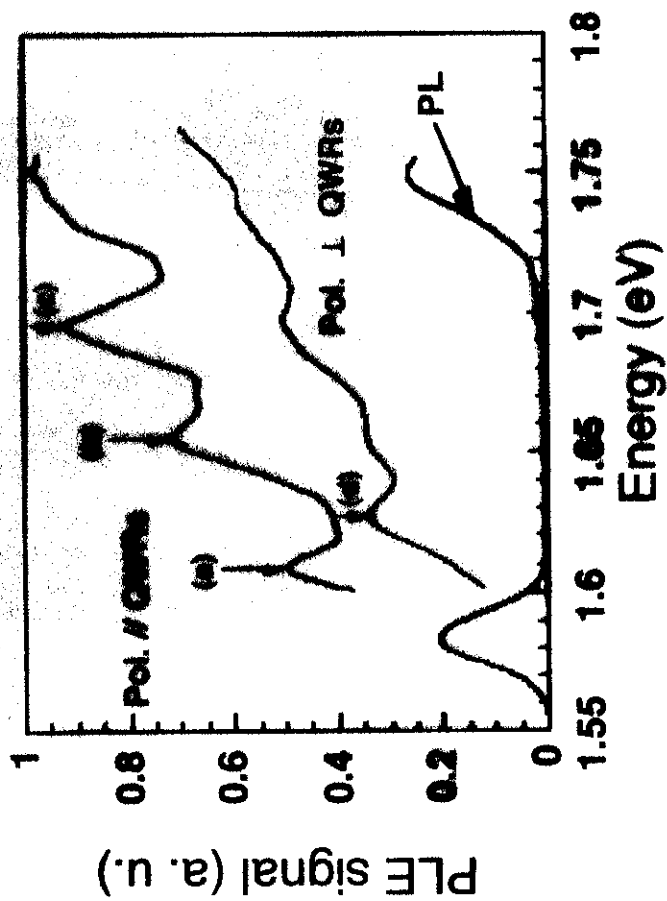


Excitation Anisotropy in V-Groove QWRs



- ☆ hh and lh related transitions observed
- ☆ polarization anisotropy in e-lh/e-hh ratio

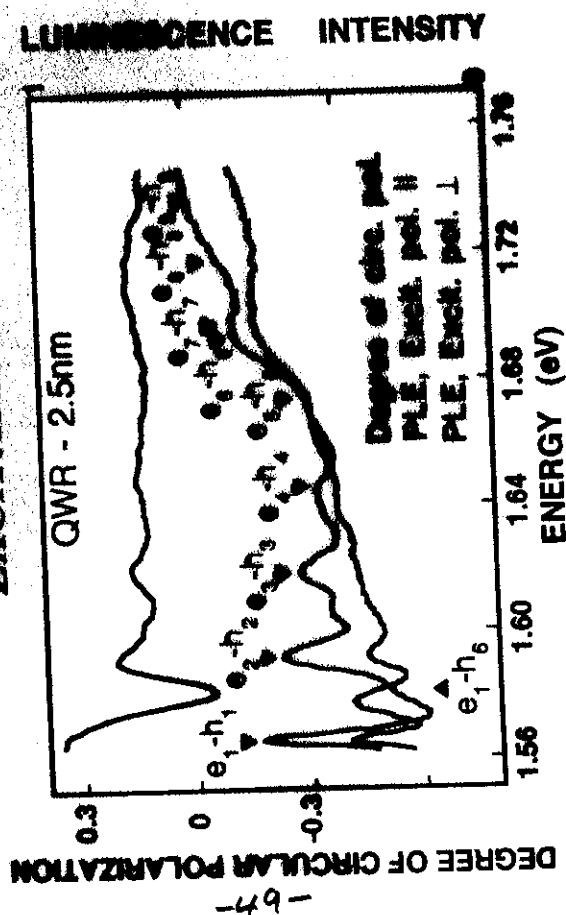
Large (45 meV) Subband Separation in V-Groove QWRs



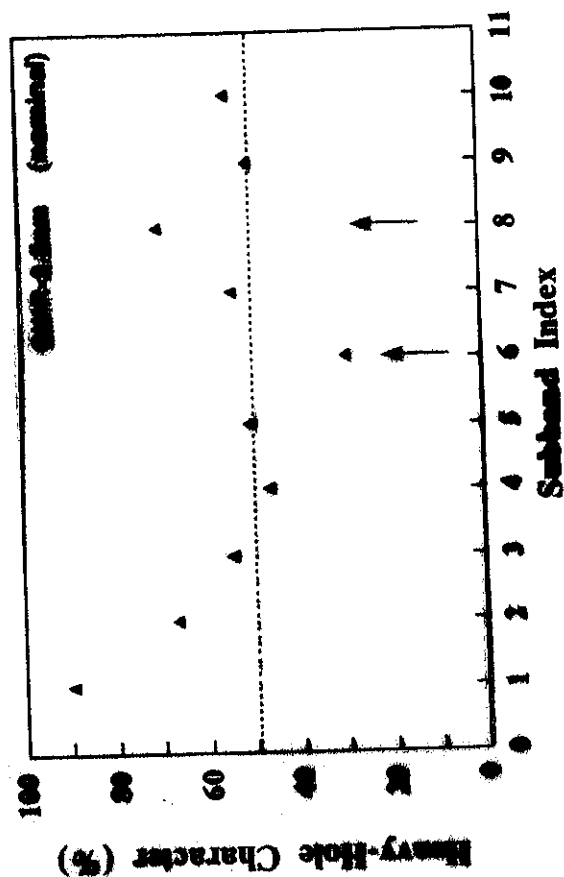
PLE Spectra:
 -45 meV e-hh" subband separation
 -large "hh"-hh" polarization anisotropy

Characterization of Valence Band Mixing in 1D Wires

PHOTOLUMINESCENCE EXCITATION



CALCULATED CHARACTER OF VALENCE SUBBAND STATES at $K=0$

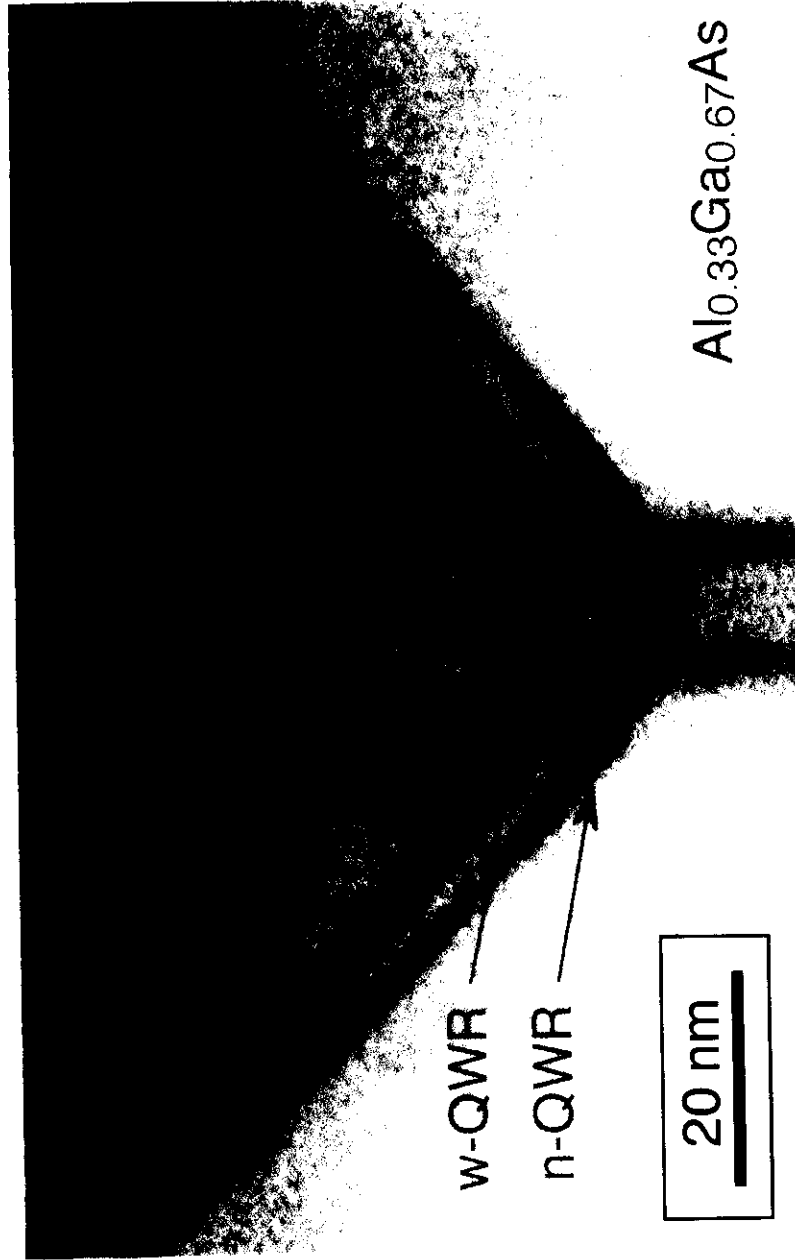


Heavy Hole Character =

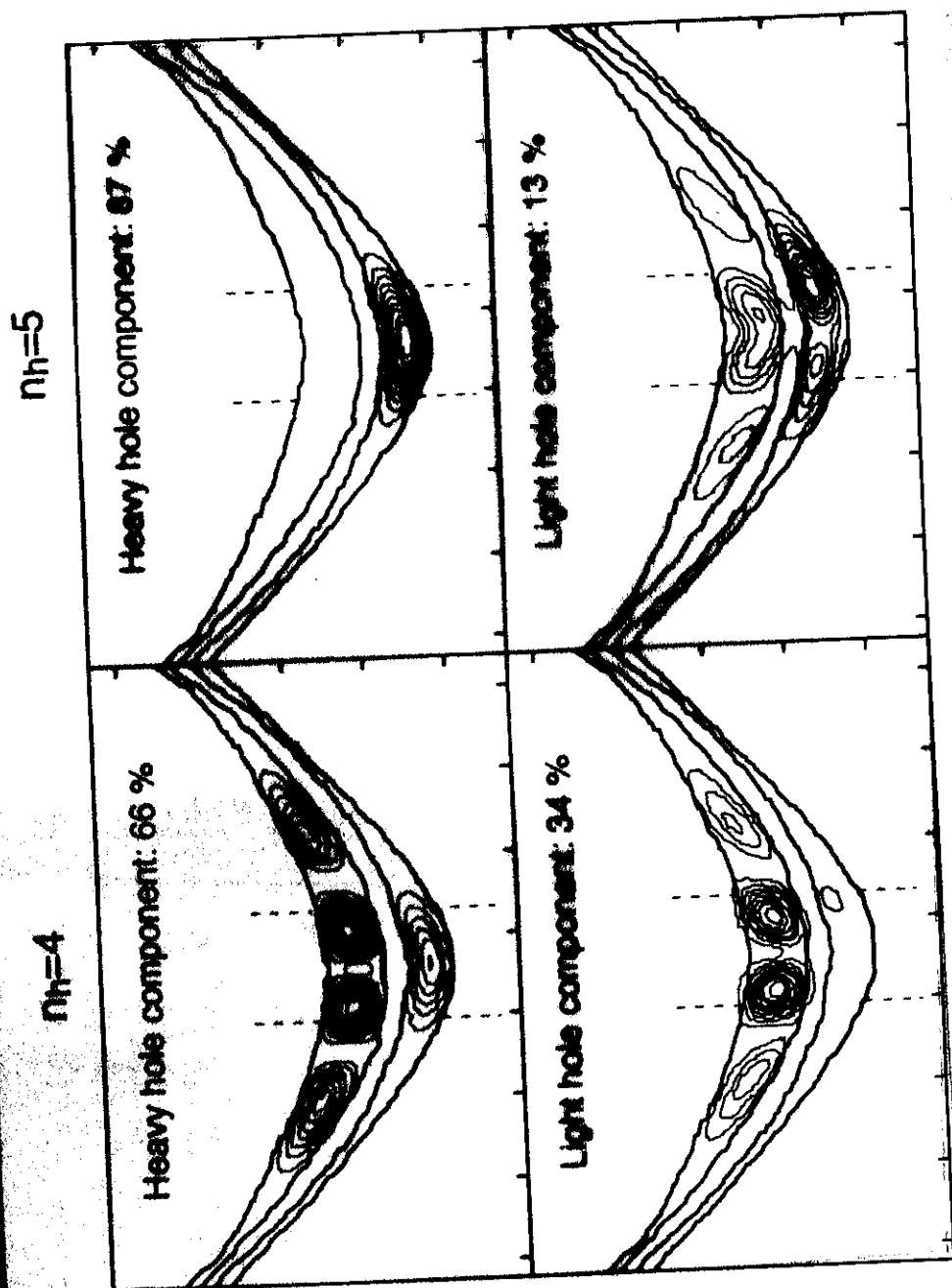
$$\langle F_{\frac{1}{2}}(r) | F_{\frac{3}{2}}(r) \rangle^2 + \langle F_{-\frac{1}{2}}(r) | F_{-\frac{3}{2}}(r) \rangle^2$$

- polarization anisotropy
- heavy/light hole mixing

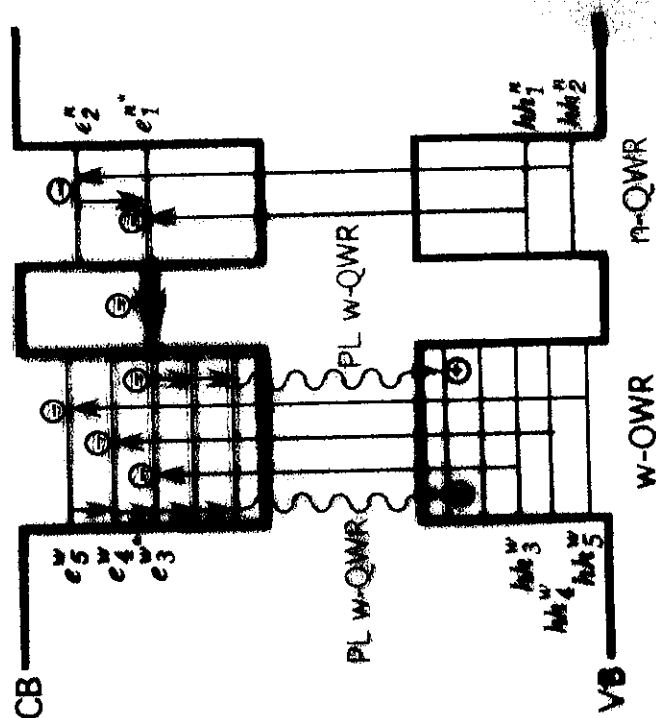
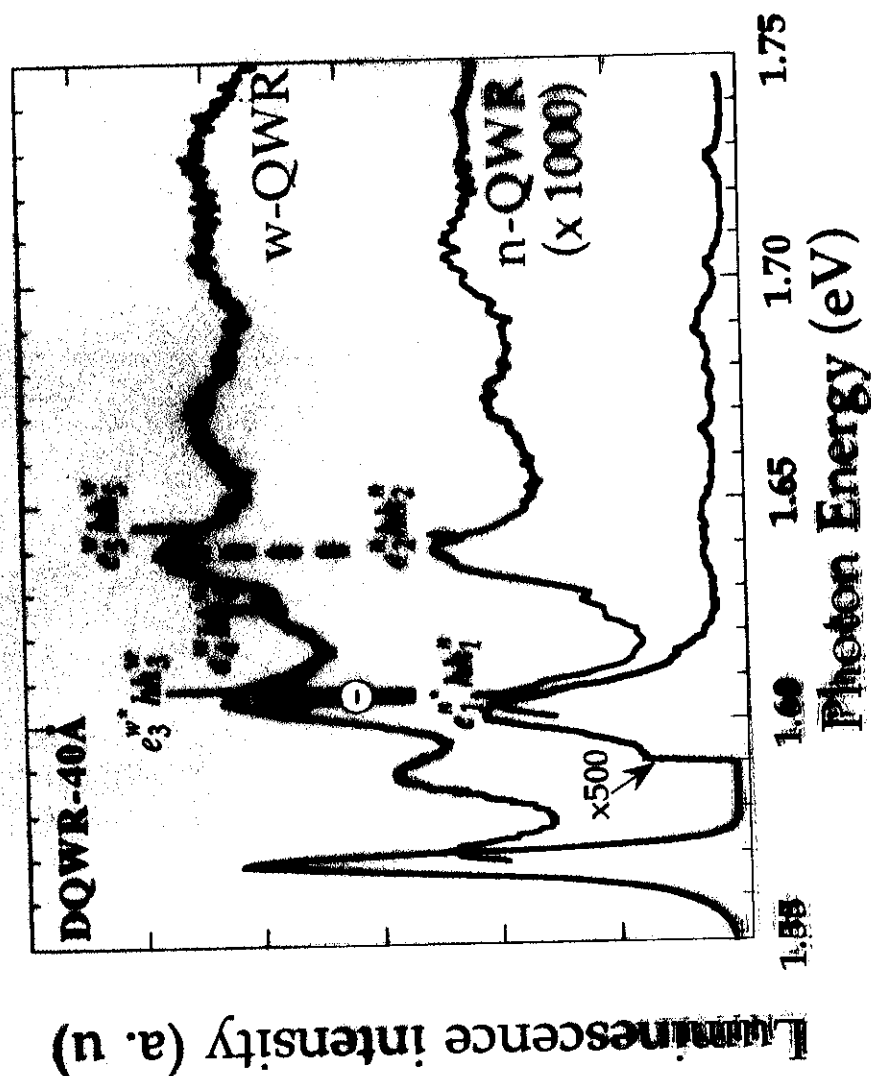
Coupled V-Groove Quantum Wires



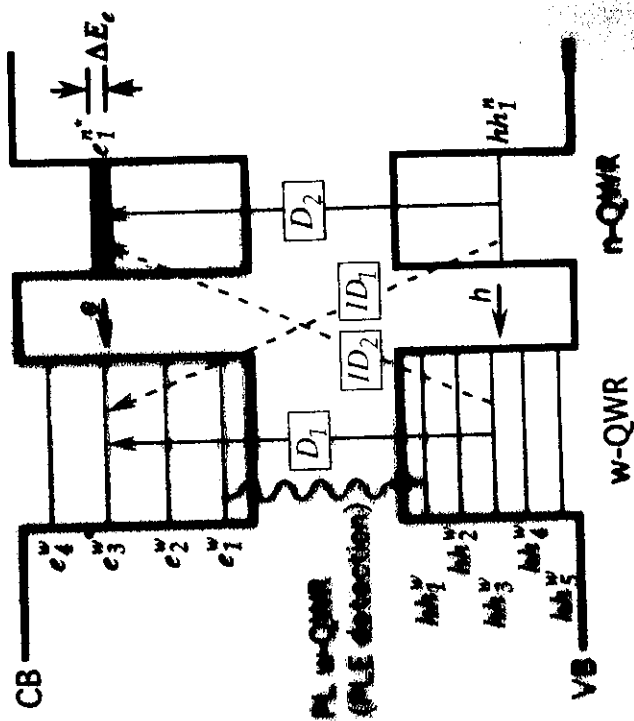
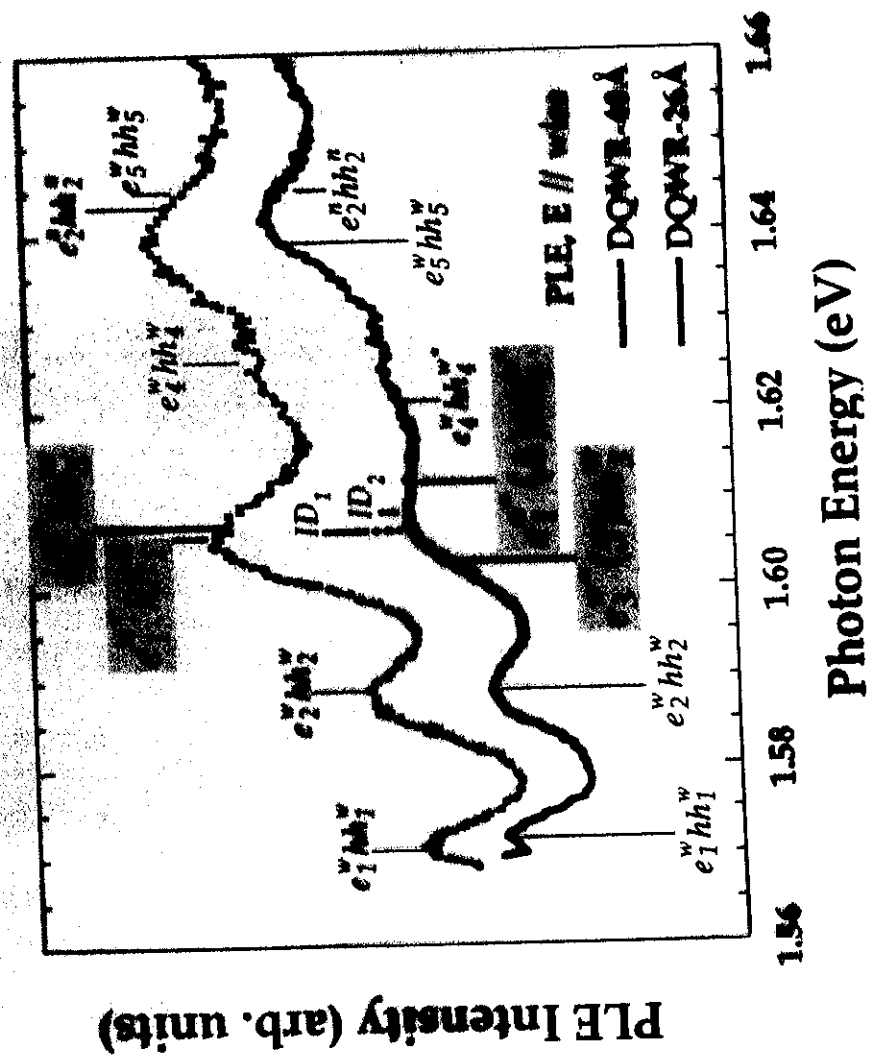
Coupled Hole States in Double V-Groove QWRs



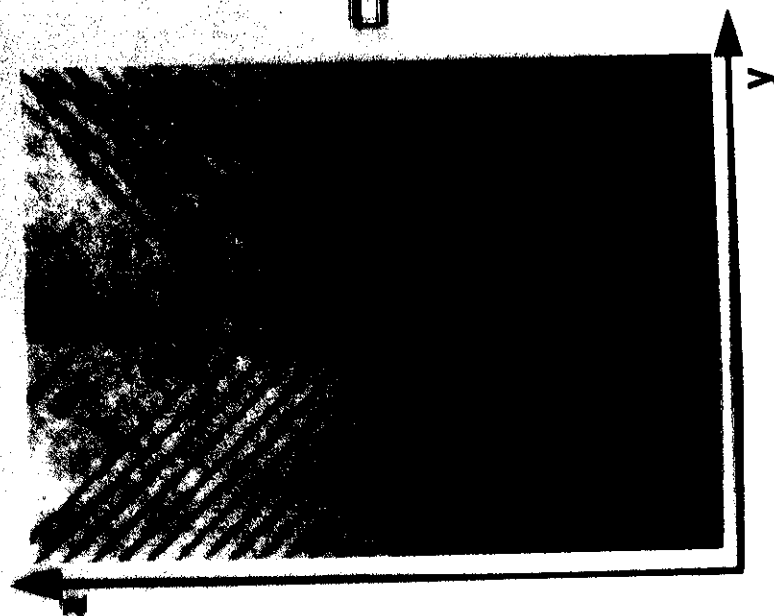
Evidence for Tunneling between 1D States



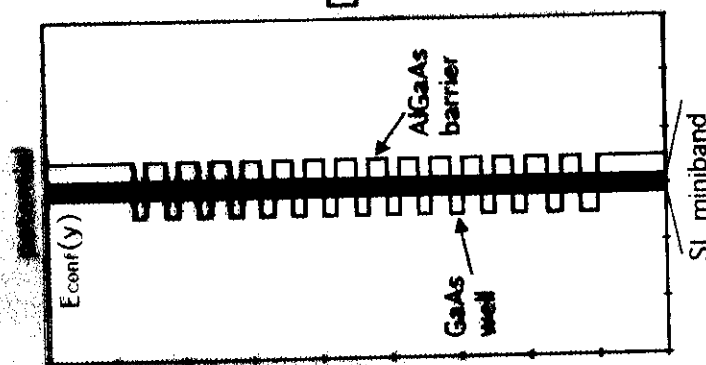
Evidence for Electronic Coupling in a Double QWR



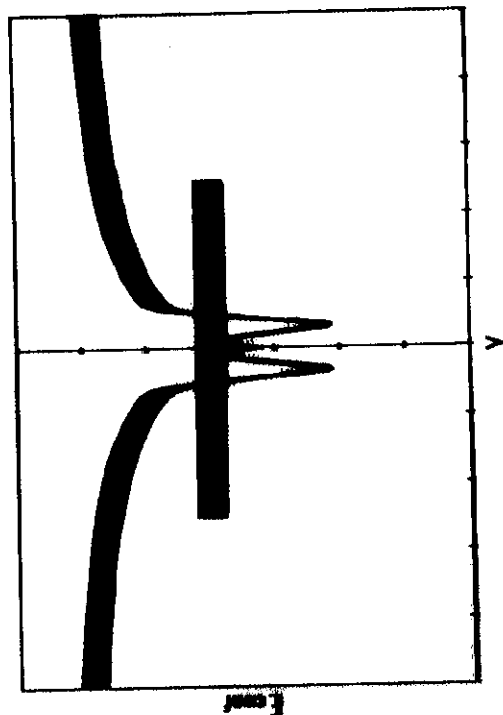
Adiabatic Model for QWR-SLs



TEM cross section

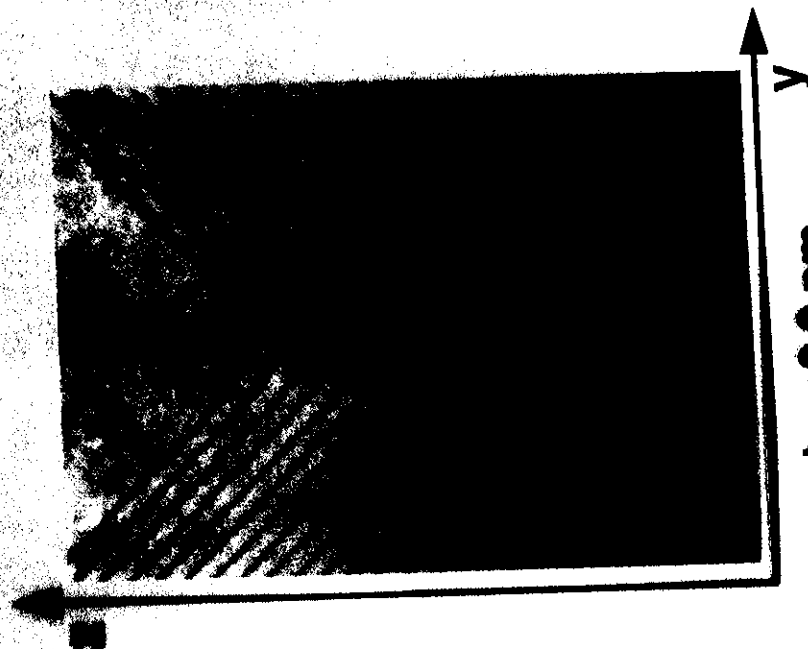


transverse wavefunctions



lateral wavefunctions

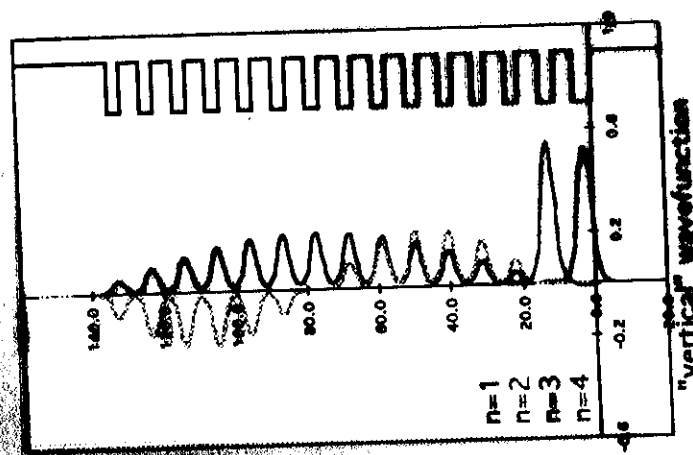
Localization of QWR-SL States: thick barriers



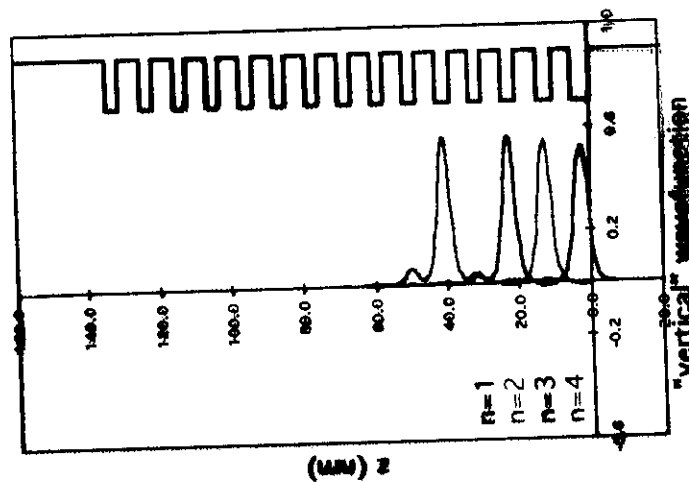
$t_b = 3.0 \text{ nm}$

$t_b = 5.2 \text{ nm}$

$T_s = 650^\circ\text{C}$

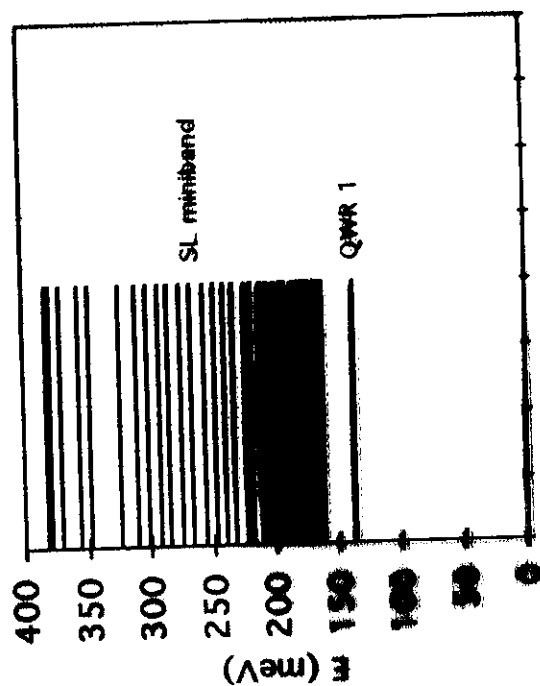


ideally uniform QWR-SL

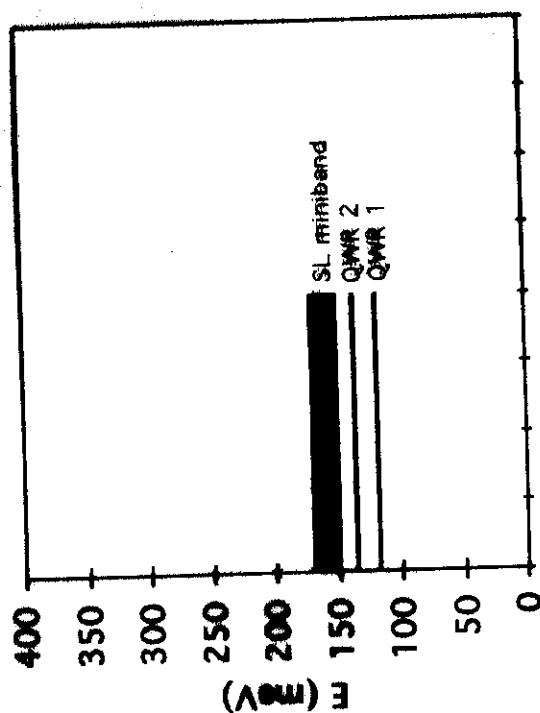


disordered QWR-SL

Calculated QWR-SL Minibands (electrons)

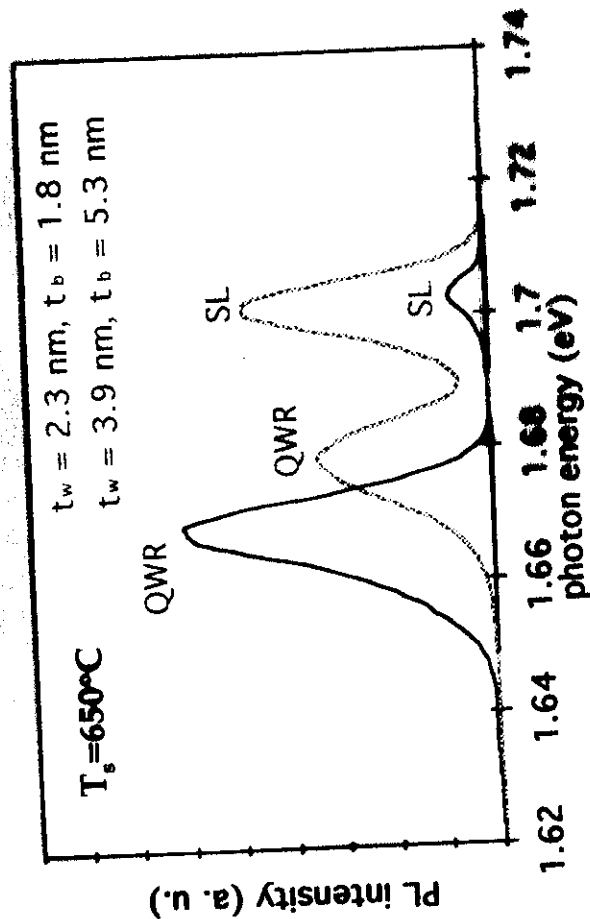


$L_w = 2.3 \text{ nm}$
 $L_p = 1.8 \text{ nm}$

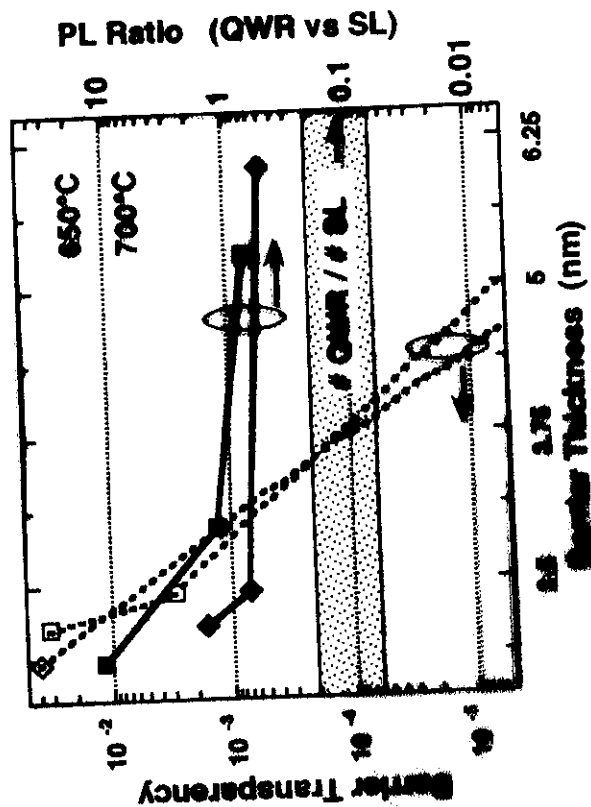


$L_w = 3.9 \text{ nm}$
 $L_p = 5.3 \text{ nm}$

Photoluminescence Spectra of QWR-SLs



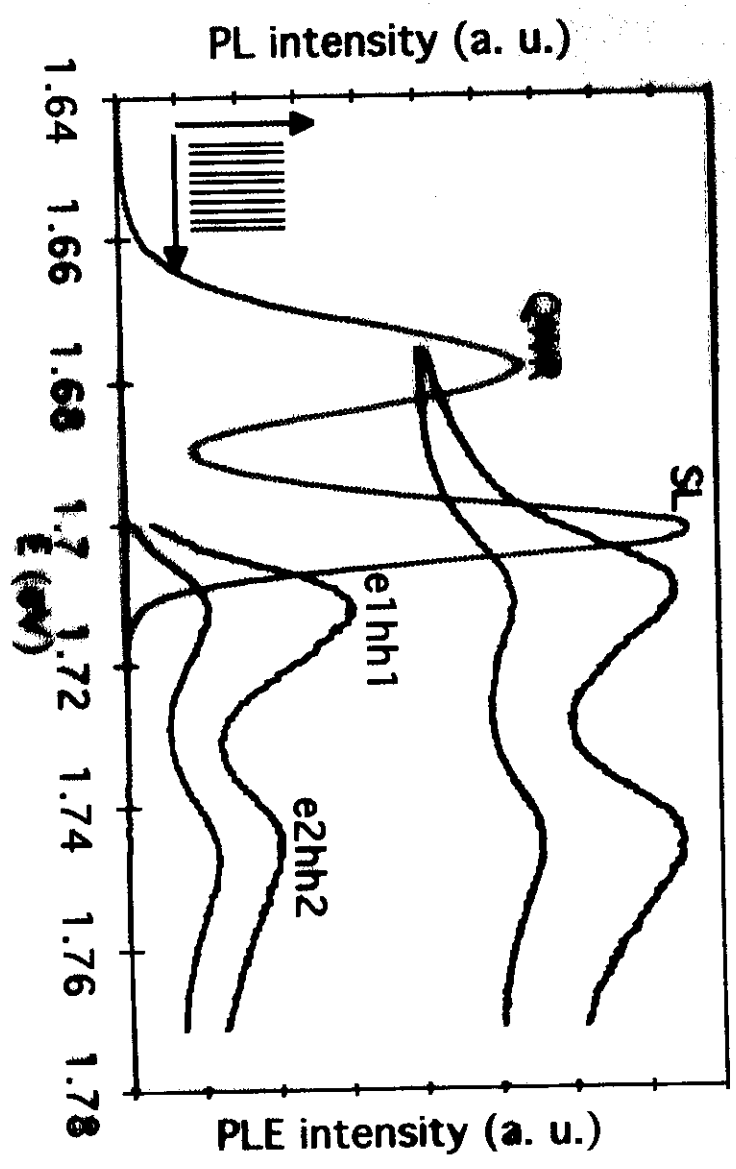
PL Spectra ($T=10\text{K}$)



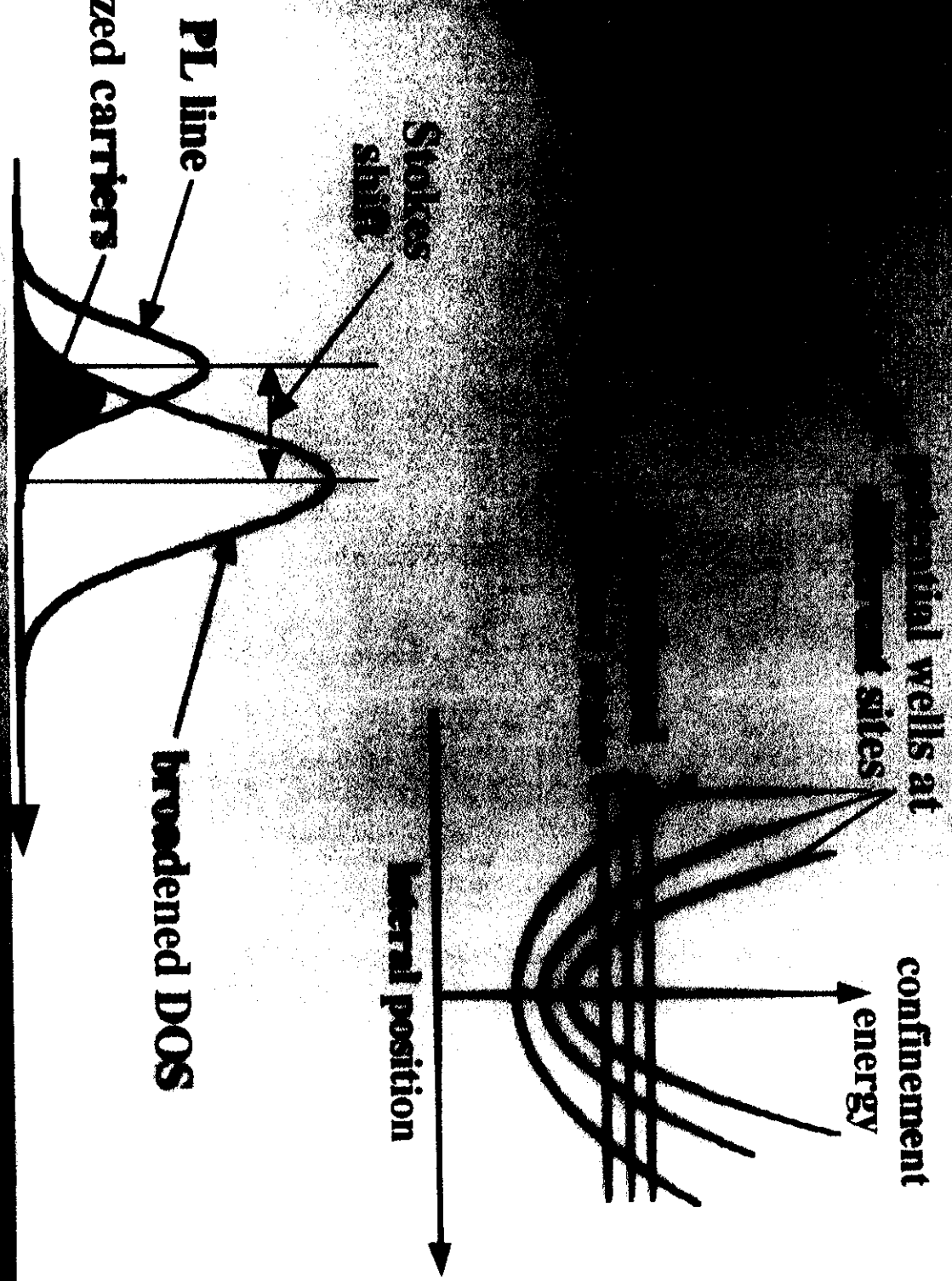
**Effect of barrier thickness
on QWR/SL intensity ratio**

PL-Excitation Spectra of QWR-SLs:

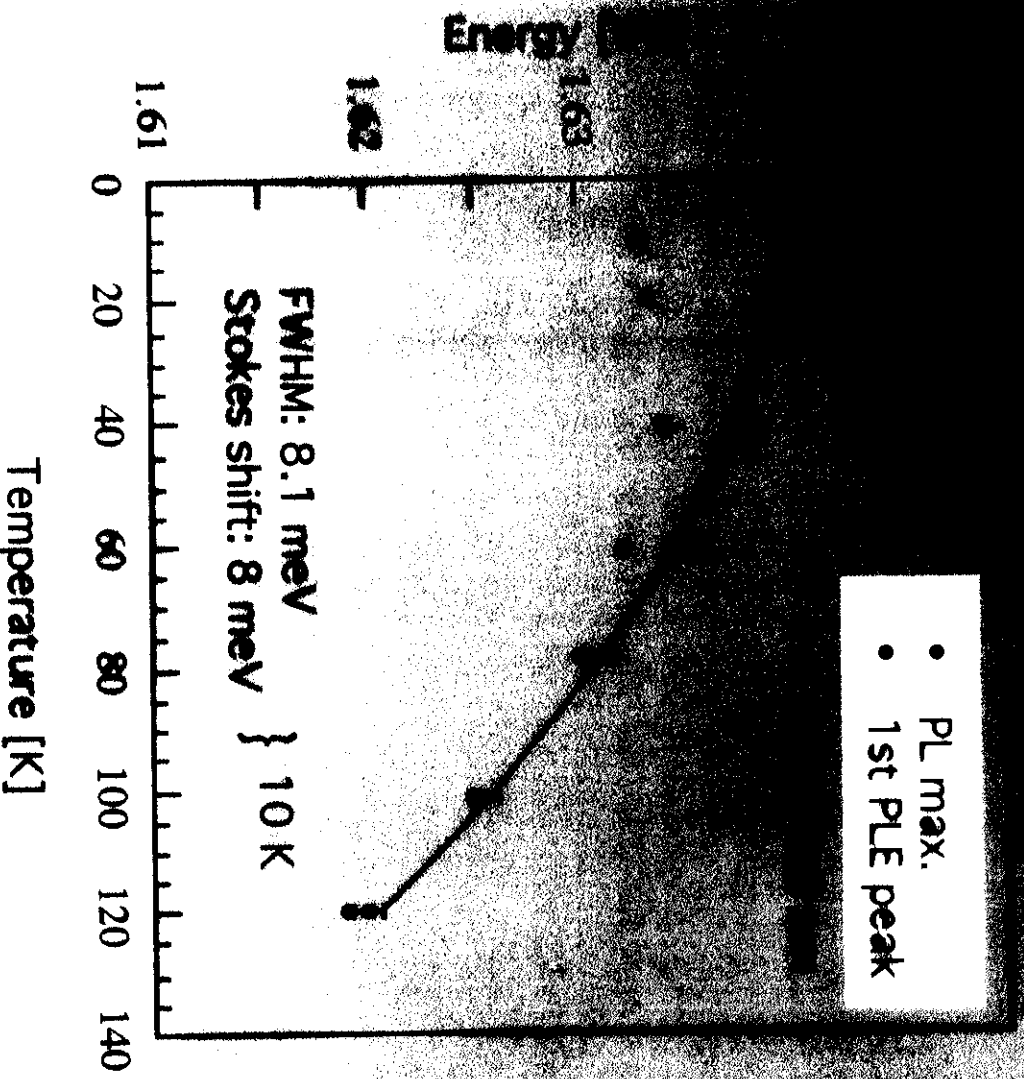
Quantum Wire Structures



$t_w = 3.9$ nm
 $t_b = 5.3$ nm
 $T_s = 650^\circ\text{C}$



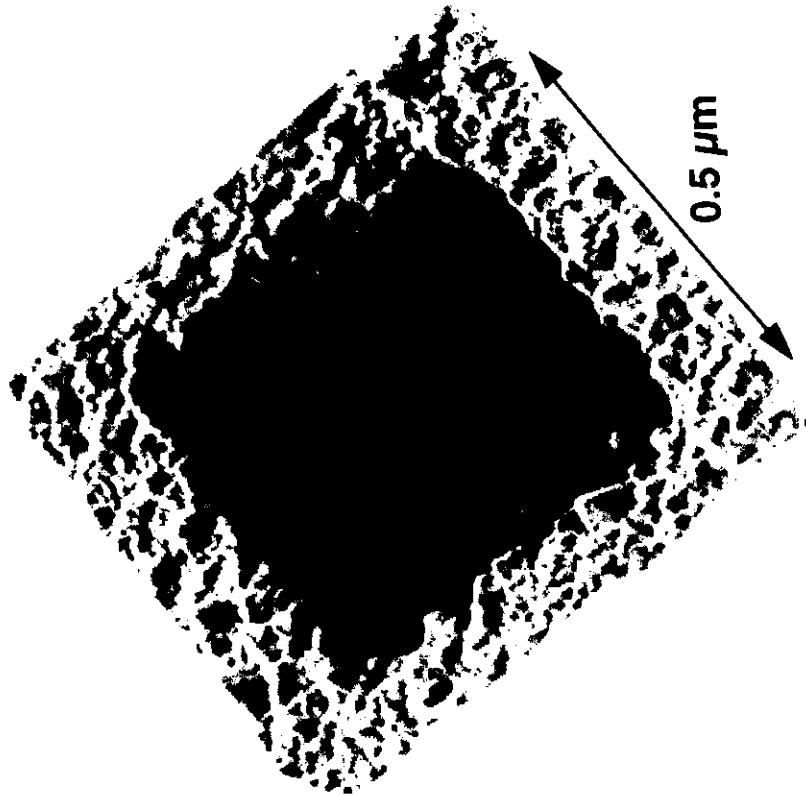
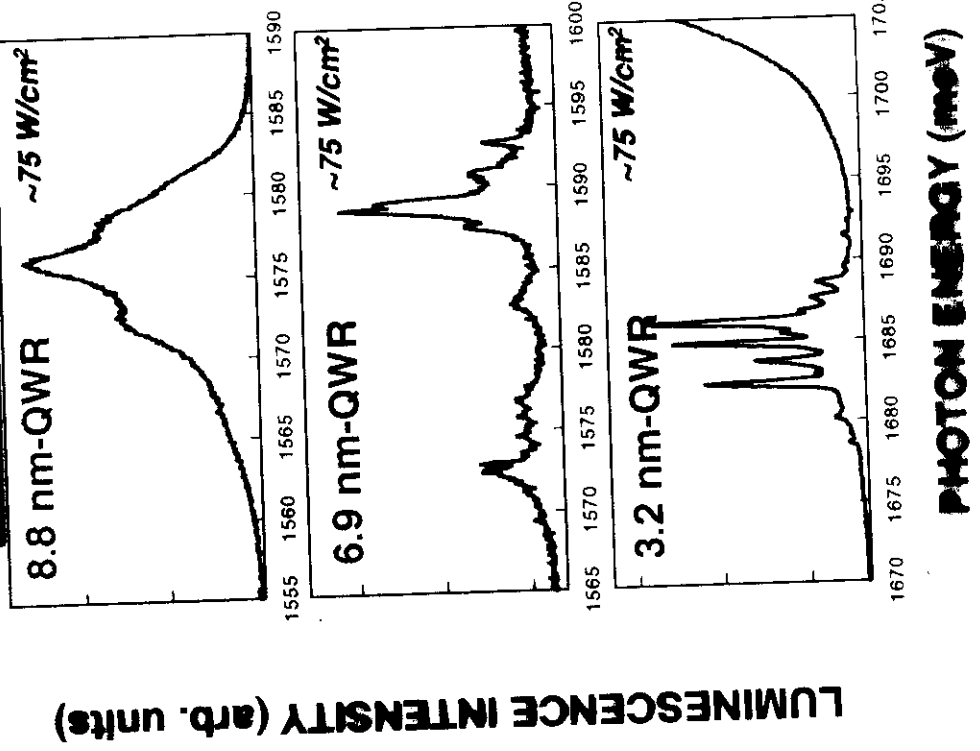
Temperature Dependence of PL and PLE



- Stokes shift increases with decreasing wire size at low temperatures
- Stokes shift vanishes at higher temperatures

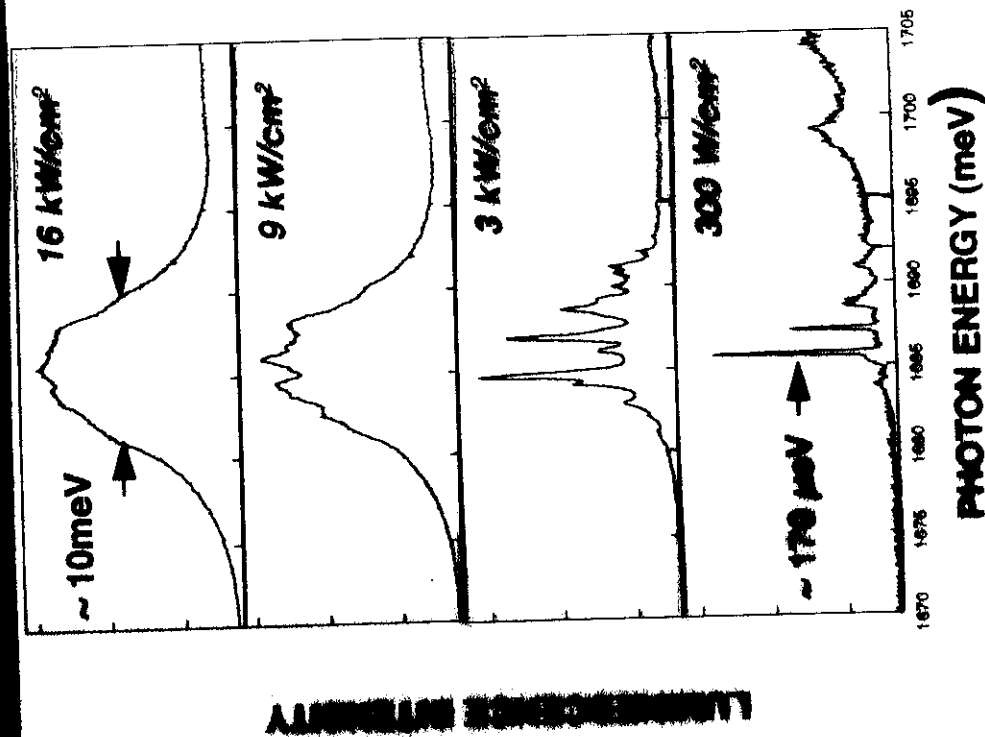
Apertured Micro-PL Spectra of V-Groove QWRs

0.5 μm hole; T=8K

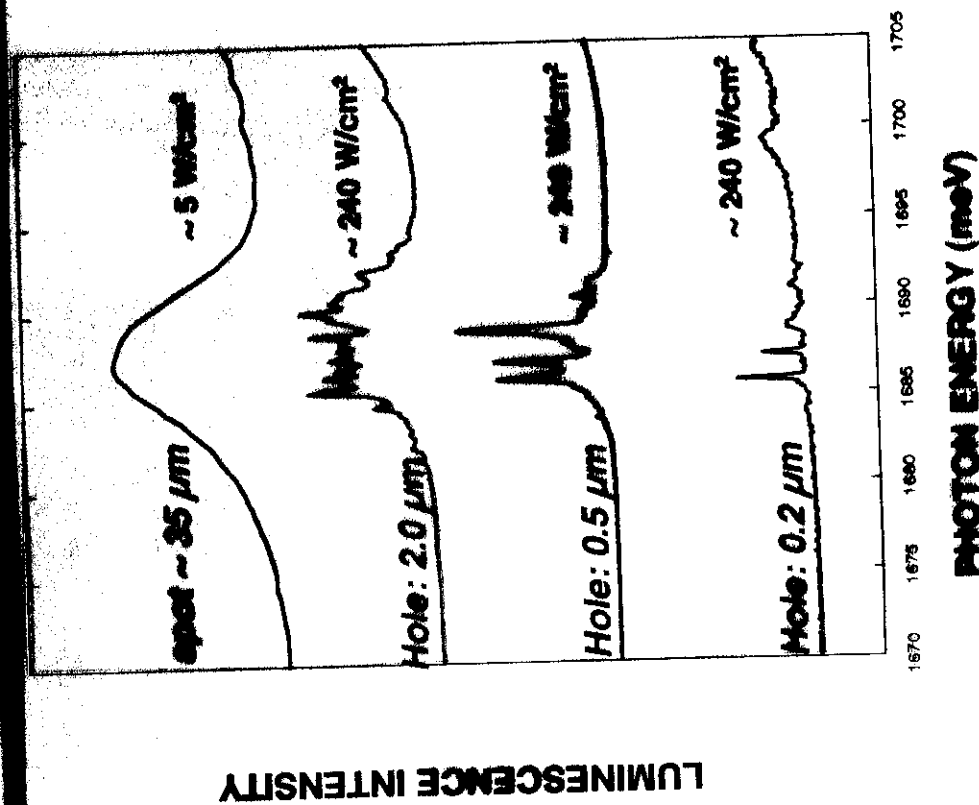


square holes in Al masks

Spatially-Resolved PL Spectra of V-Groove QWRs (32-nm QWR; 8K)



versus power (0.2 μm aperture)



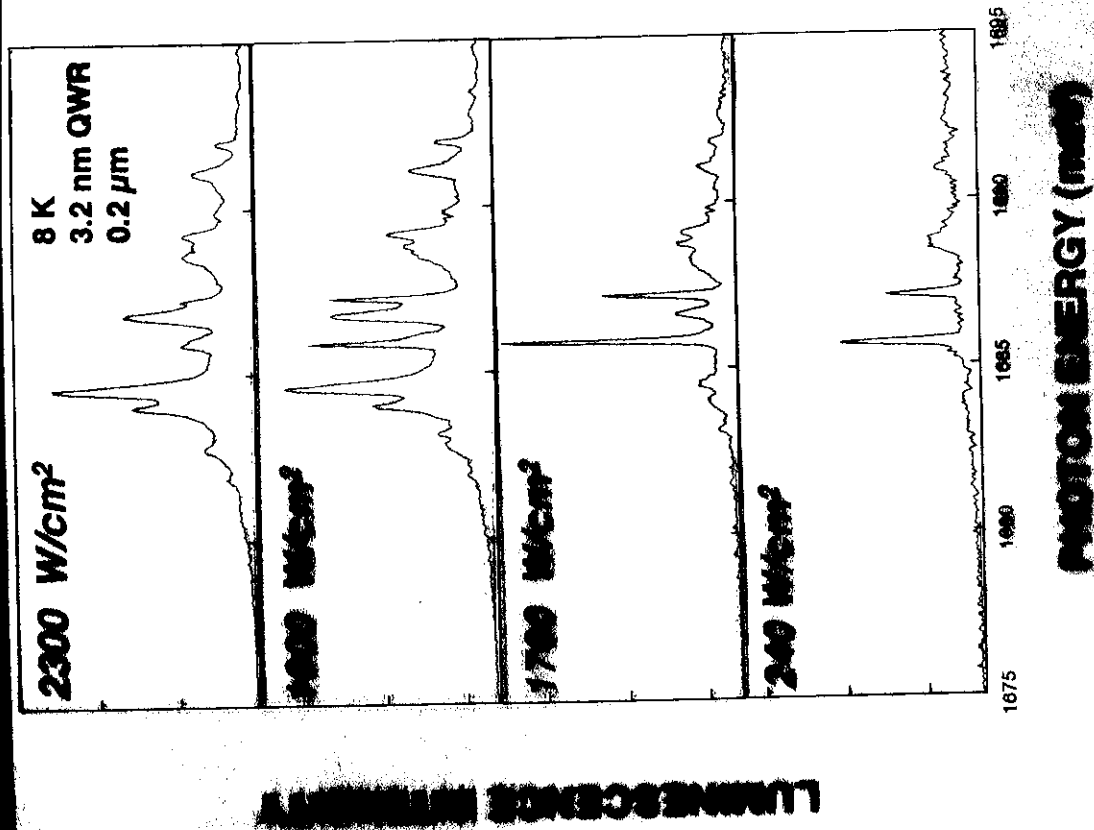
versus aperture size

1D Localized Exciton Spectra- Density Dependence

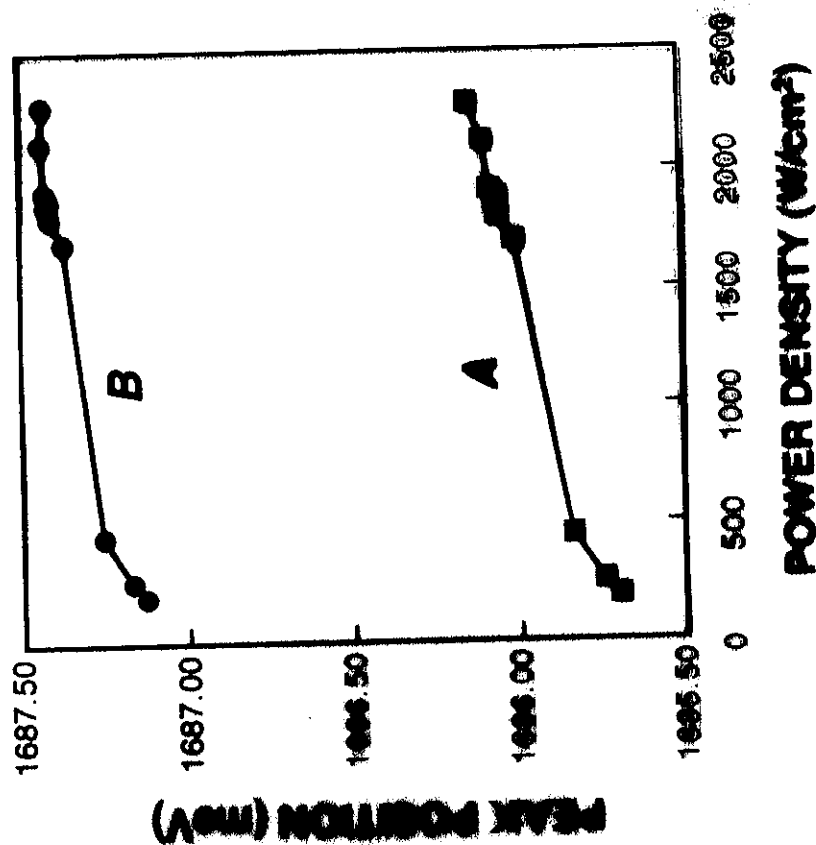
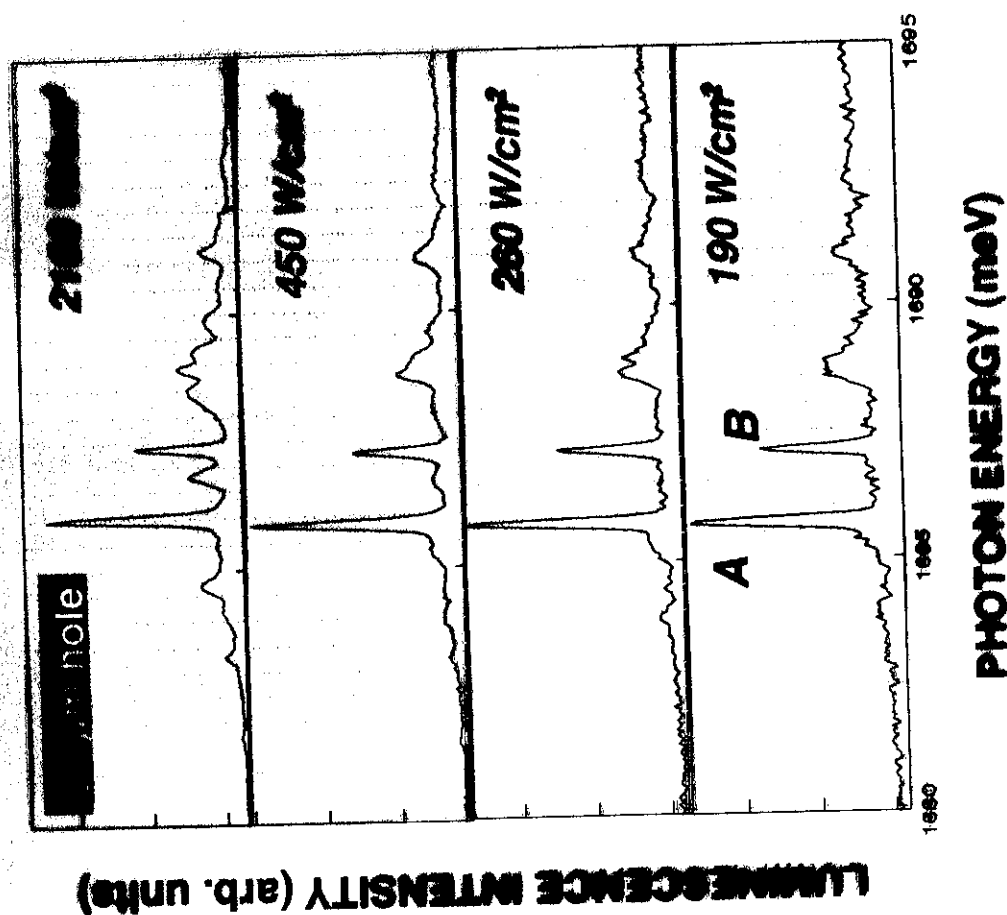
- low density lines saturate
- new lines appear on low energy side
- stronger exciton correlation in 1D



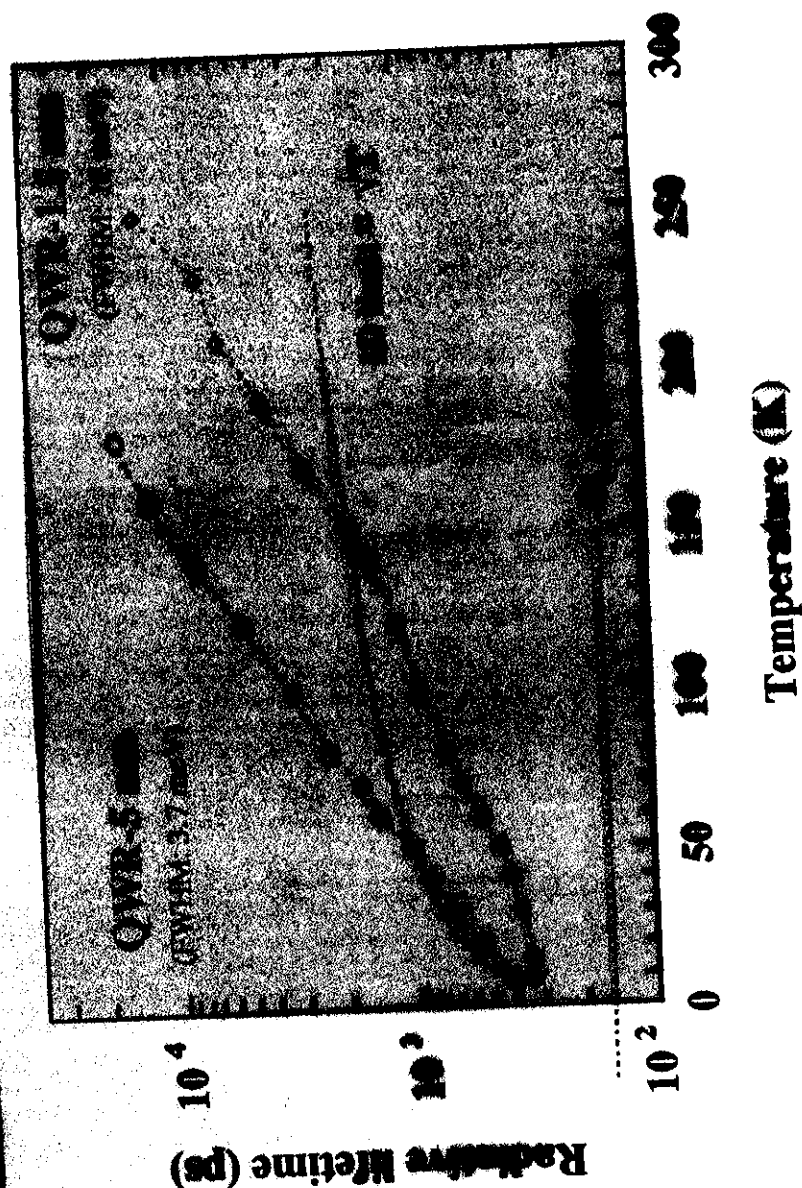
observation of 1D biexcitons



Blue Shift of 1D Excitons at Increasing Densities

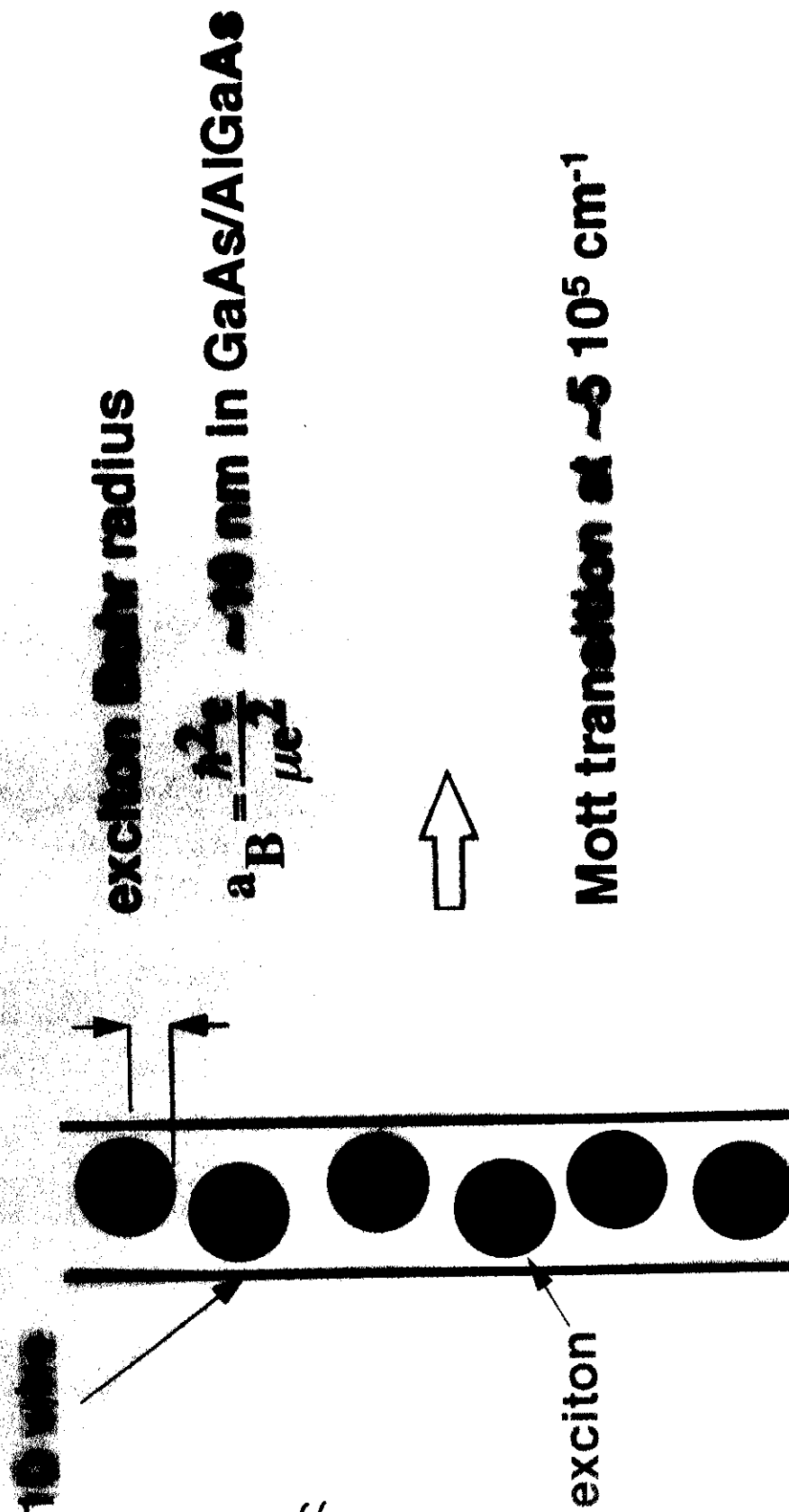


Radiative Lifetime of 1D Excitons- Effect of Localization

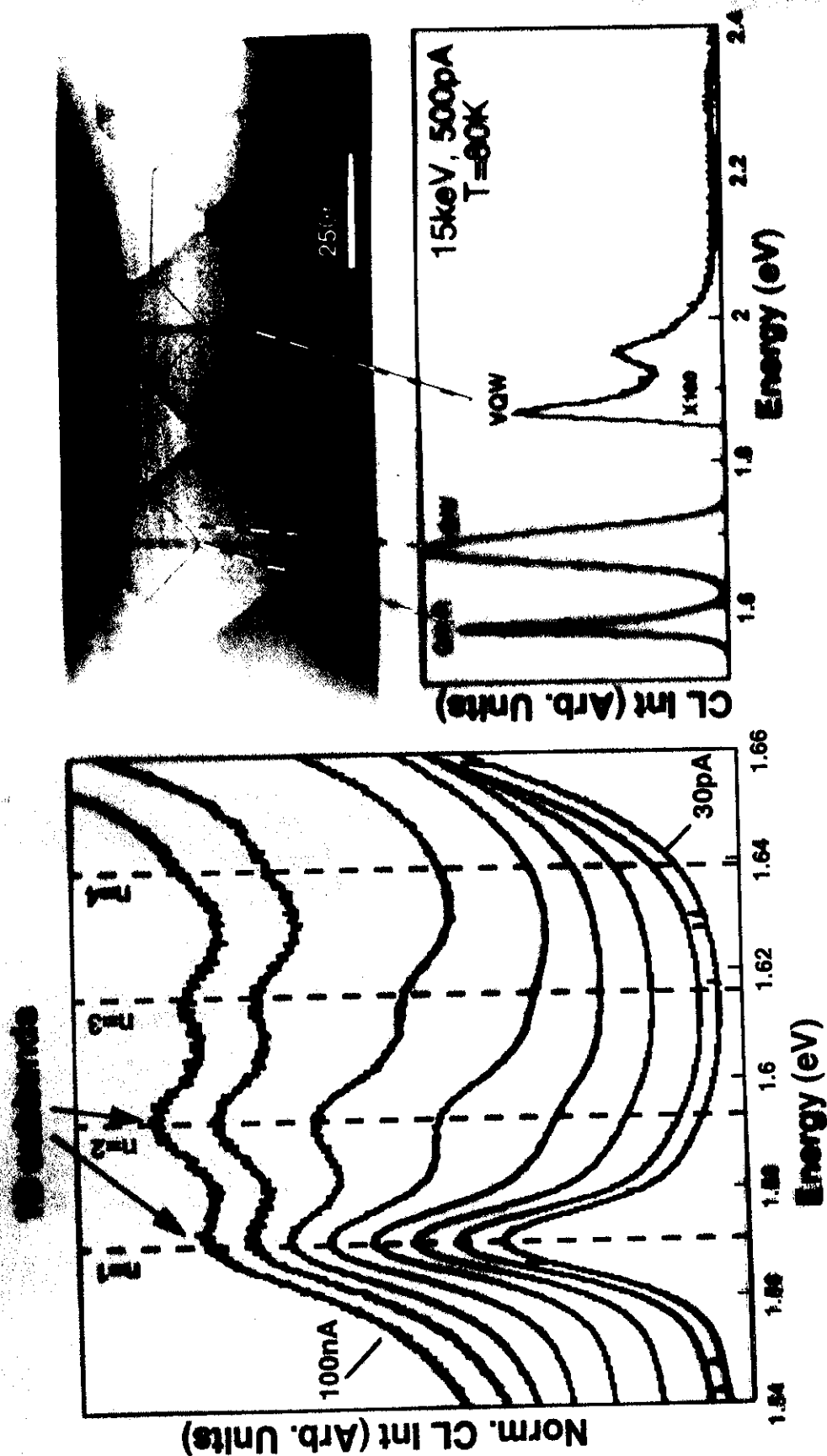


- Exponential T-dependence of radiative lifetime observed
- Variation with T increases with decreasing localization effects

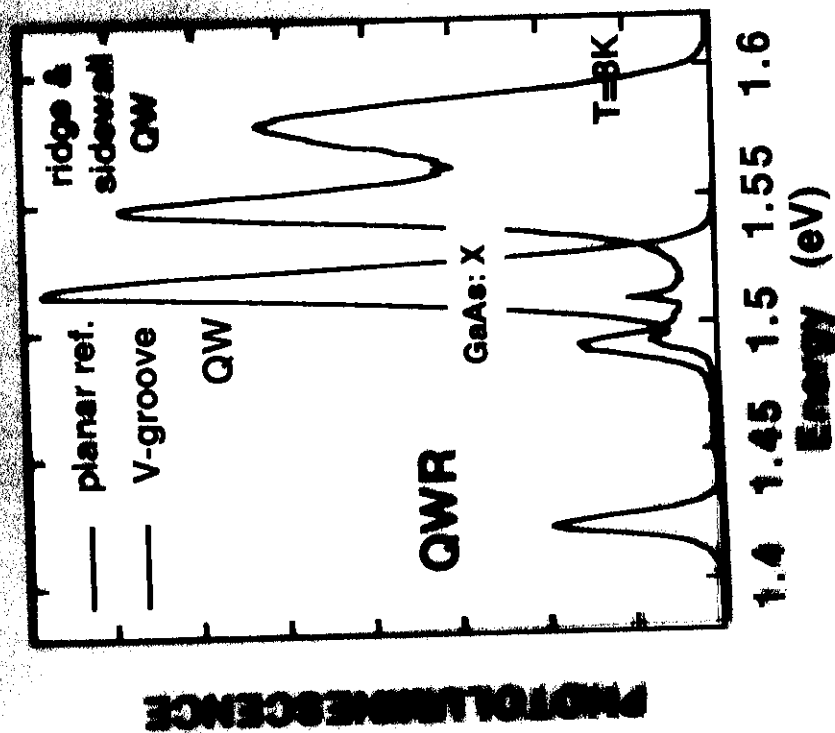
Mott Transition in a 1D Gas of Excitons



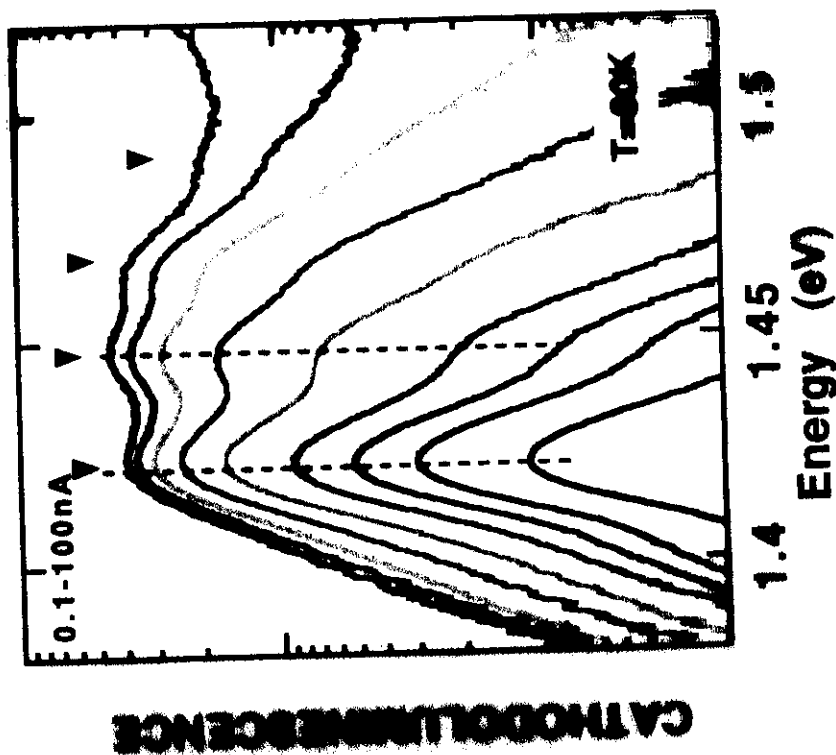
CL Spectra of a V-Groove QWR Array



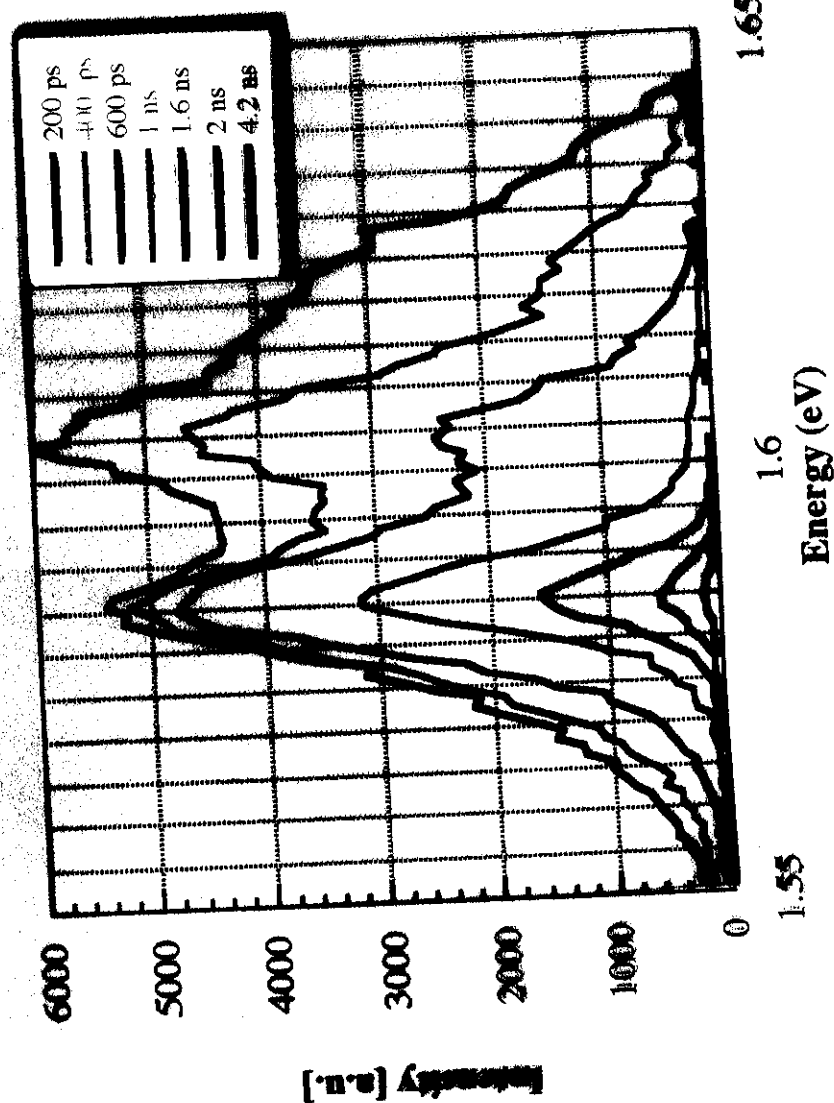
Photoluminescence of InGaAs/AlGaAs QWRs



- narrow linewidth (<10meV)
- efficient carrier capture



- 1D-subband filling ($\Delta E \approx 24\text{meV}$)
- No 1D subband energy shift



☆ no shift in 1D-subband
energies up to $\sim 3 \cdot 10^6 \text{ cm}^{-1}$

↑ -radiative recombination
dominated by excitons

-Mott transition not observed

-bandgap renormalization
<10-15 meV